

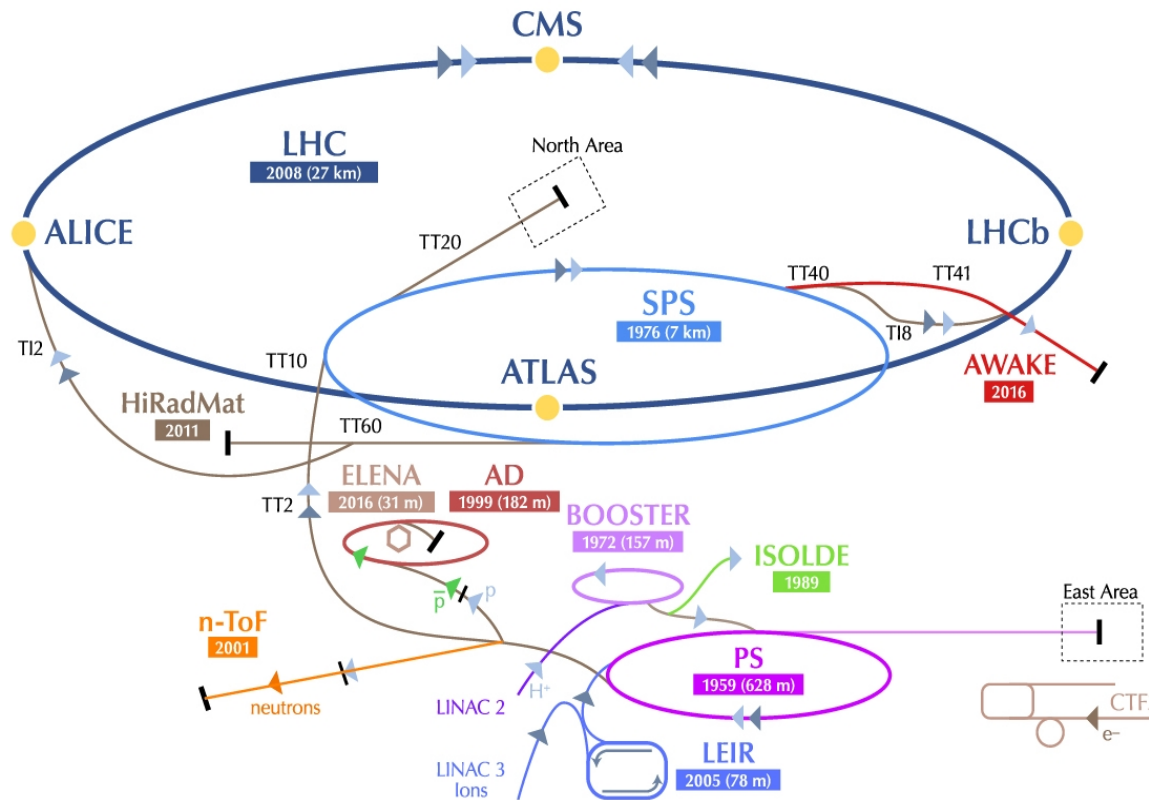
Longitudinal Mitigations of Transverse Space Charge Effects

Simon Albright

Acknowledgements: M. E. Angoletta, H. Bartosik, G. P. Di Giovanni, A. Findlay, S. Hancock, A. Huschauer, B. Mikulec, A. Oeftiger, M. Paoluzzi, E. Shaposhnikova, et al

Contents

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- Established longitudinal space charge mitigation
- LEIR – Maximum intensity ion beams
- PSB – Maximum brightness proton beams
- Future work
- Conclusion

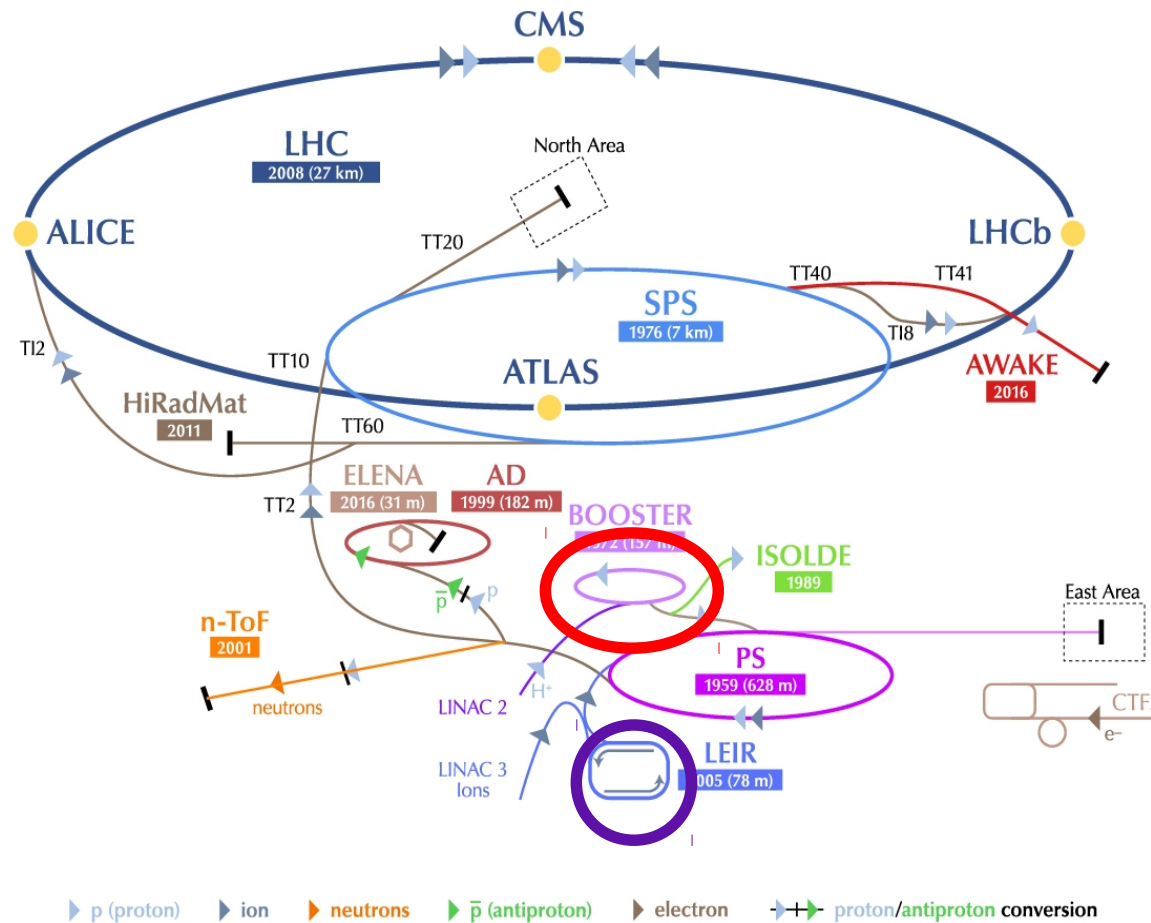


▶ p (proton) ▶ ion ▶ neutrons ▶ \bar{p} (antiproton) ▶ electron ▶ \leftrightarrow proton/antiproton conversion

LHC Large Hadron Collider SPS Super Proton Synchrotron PS Proton Synchrotron

AD Antiproton Decelerator CTF3 Clic Test Facility AWAKE Advanced WAKEfield Experiment ISOLDE Isotope Separator OnLine DEvice

LEIR Low Energy Ion Ring LINAC LINEar ACcelerator n-ToF Neutrons Time Of Flight HiRadMat High-Radiation to Materials



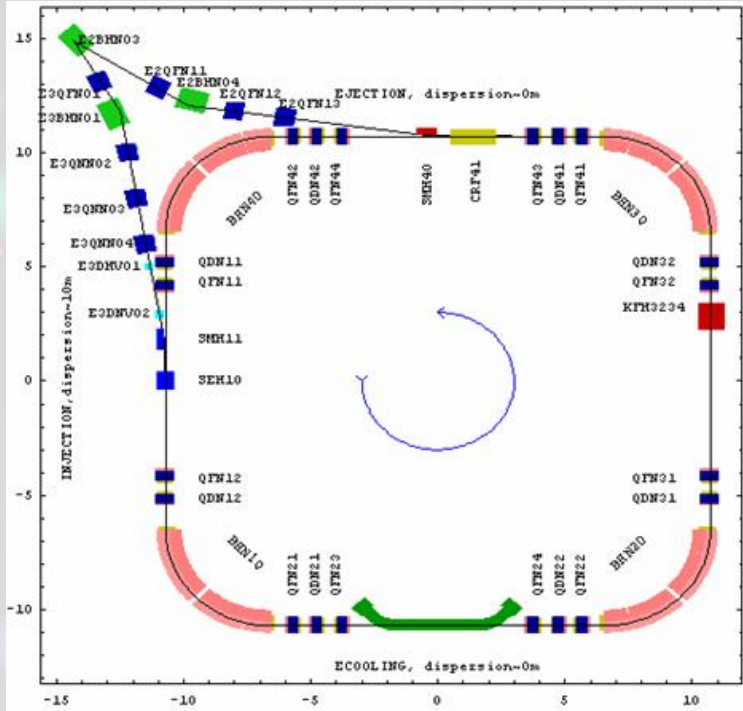
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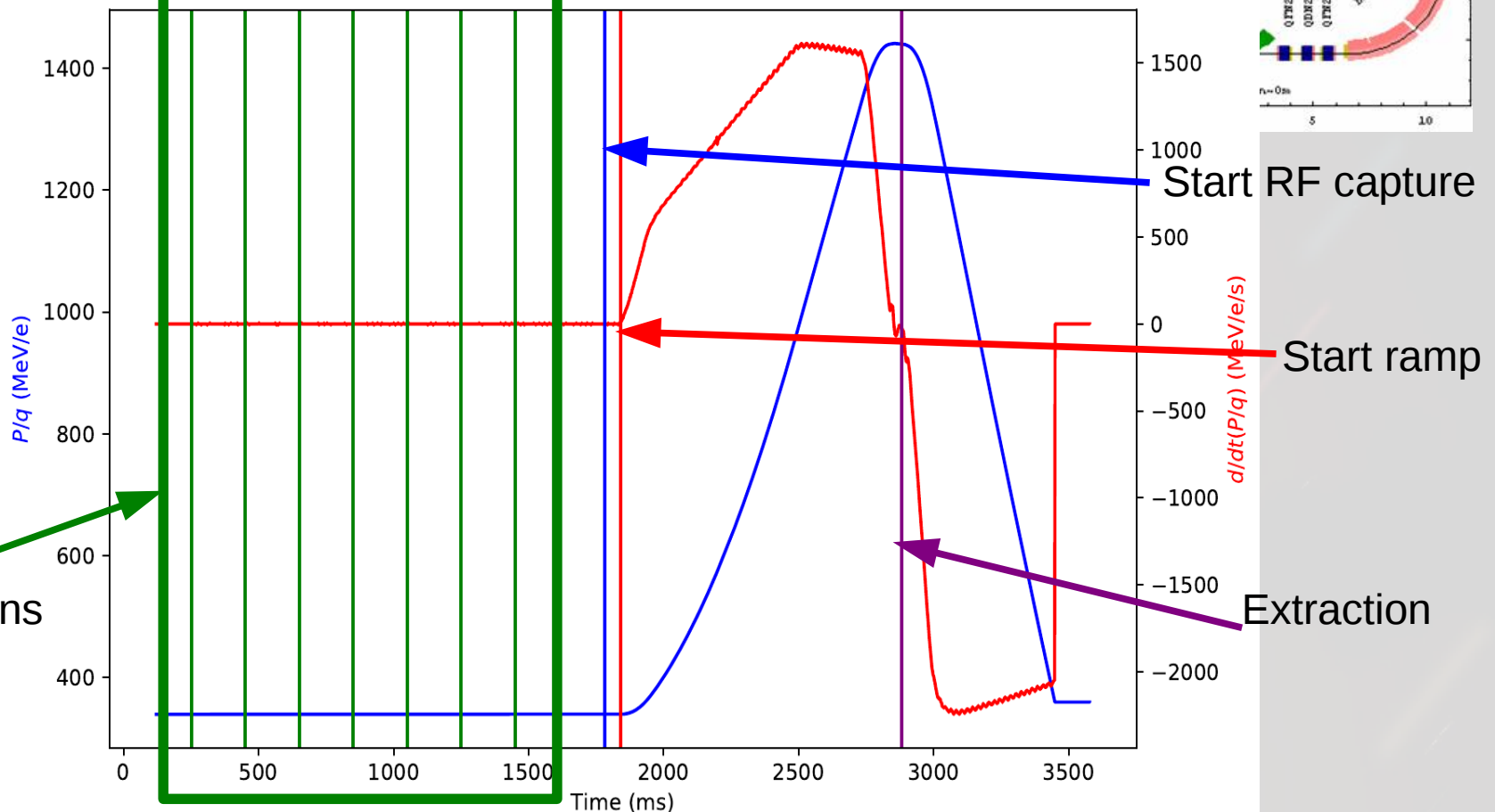
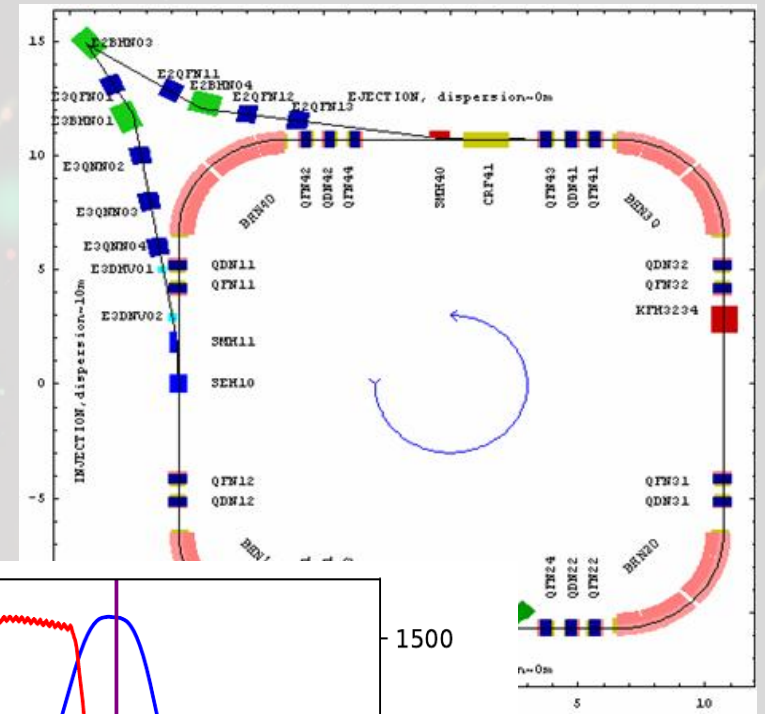
LEIR – Low Energy Ion Ring

- Small machine – average radius = 12.5 m
- 7 multi-turn injections space by 200 ms
- e-cooling during long flat bottom
- Iso-adiabatic RF capture prior to ramp
- RF operated with $h=2$ + $h=4$ for high intensity beams
- Broadband Finemet™ RF operated with $h=2$ + $h=4$ for high intensity beams



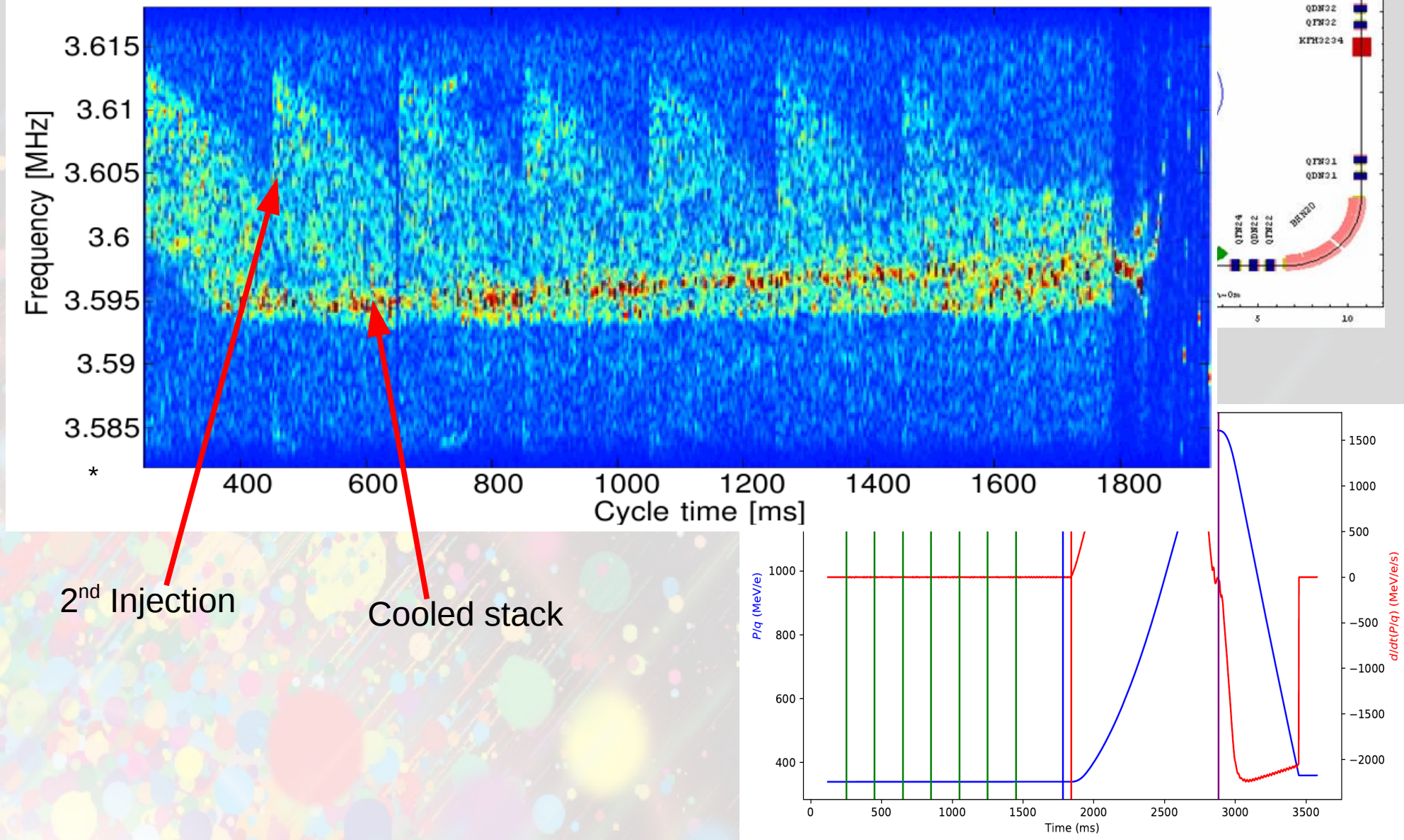
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- Broadband + $h=4$ for h



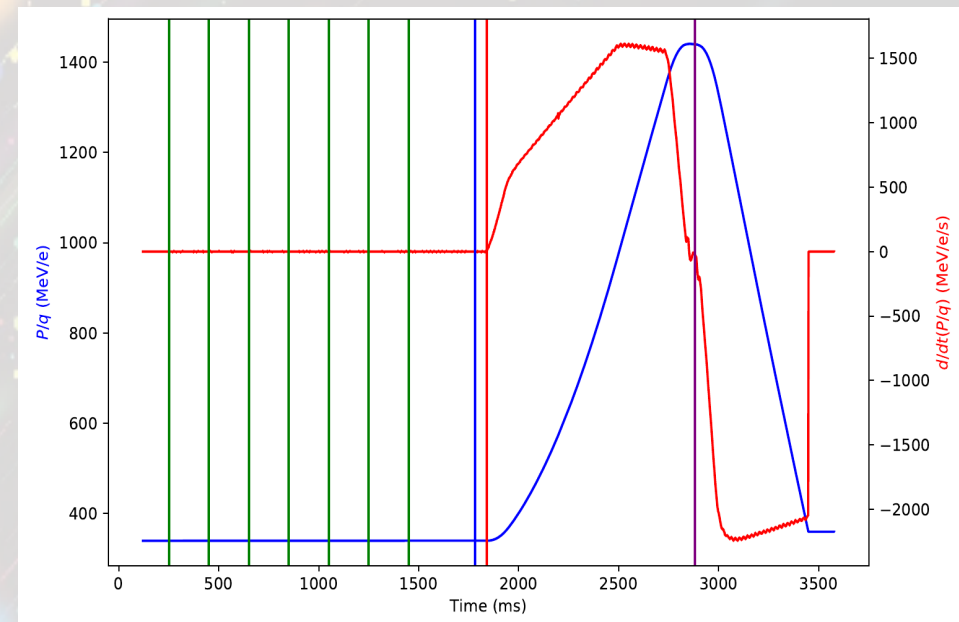
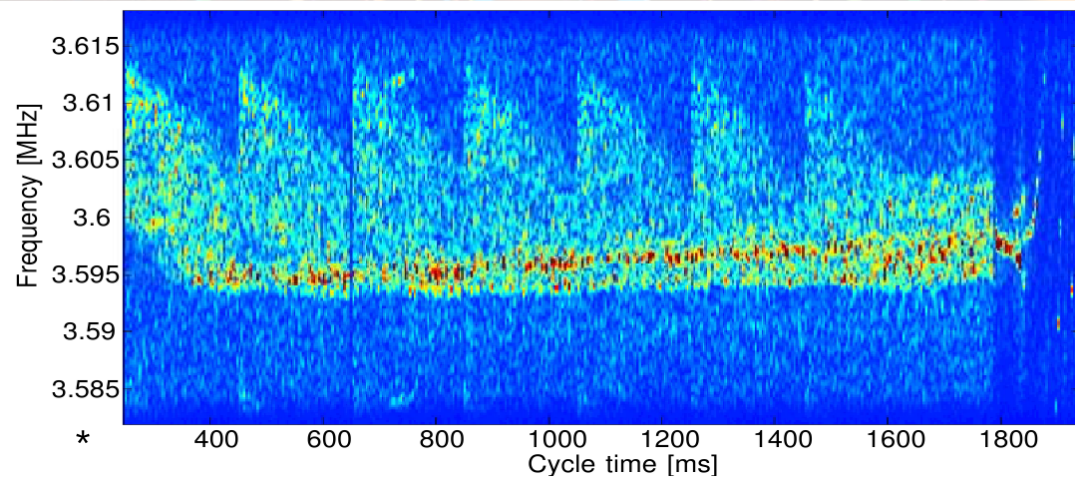
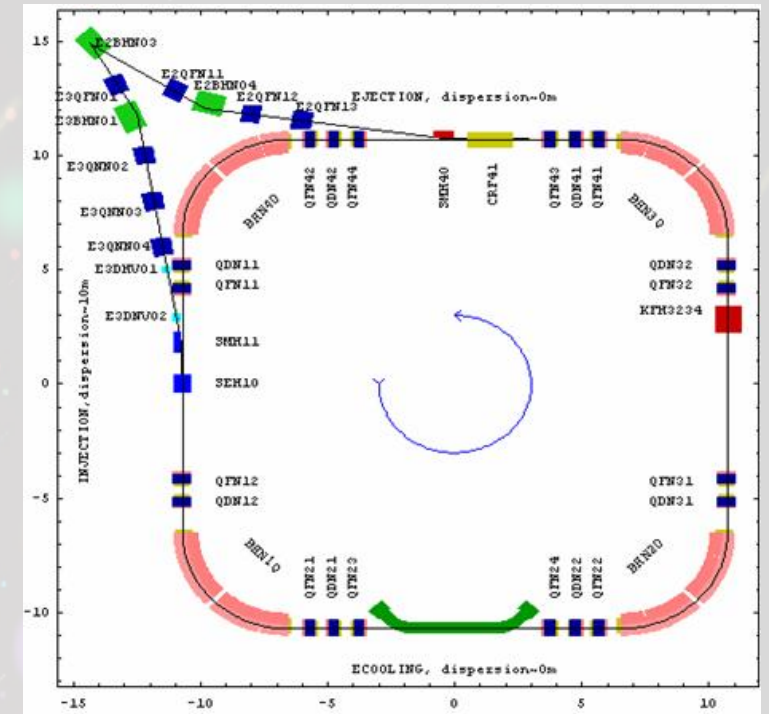
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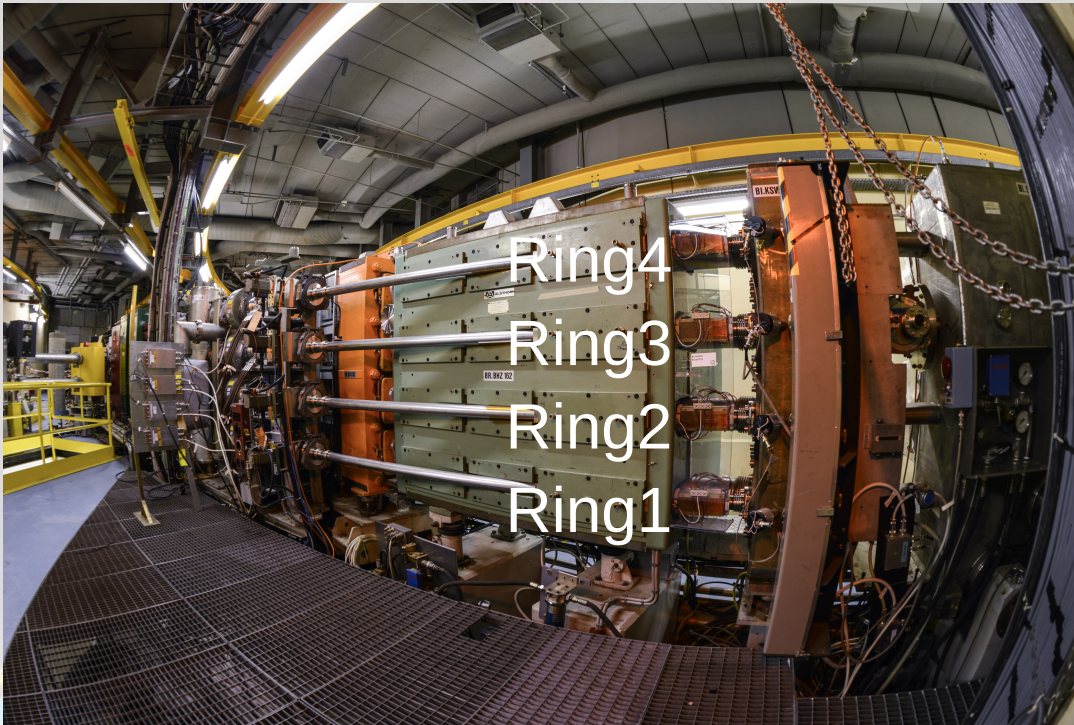


LEIR – Low Energy Ion Ring

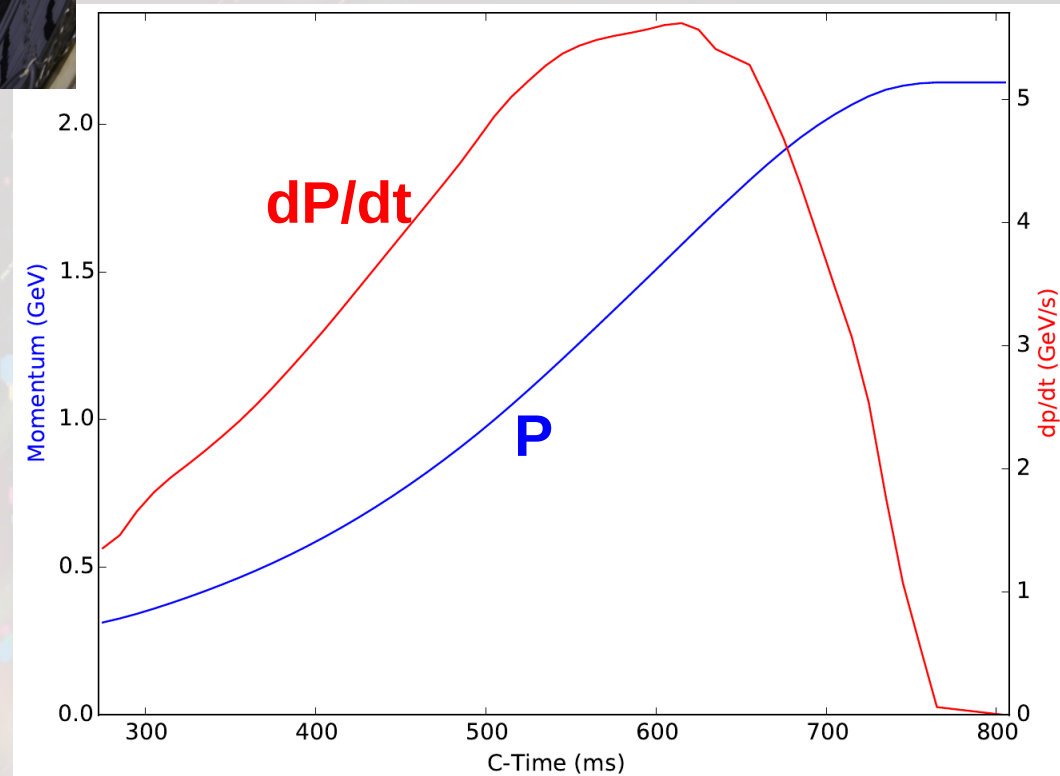
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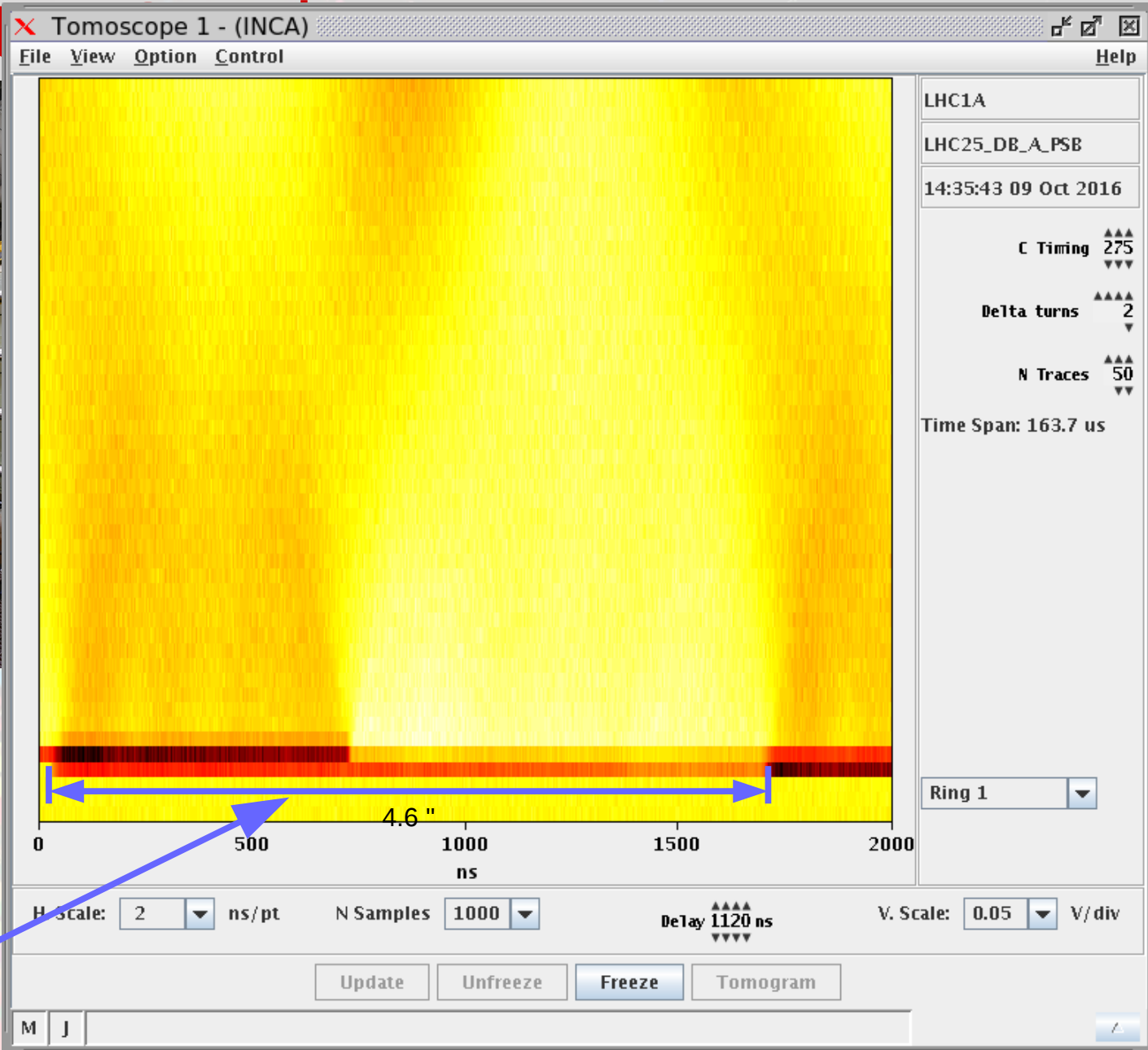
PSB – Proton Synchrotron Booster



- 4 **almost** identical rings
- Common magnetic cycle
- Independent RF systems
- Tunable ferrite RF systems at $h=1$, $h=2$, $h \leq 16$
- Multi-turn injection at non-zero dB/dt
- Broadband Finemet™ test cavity in Ring 4



PSB – Prot



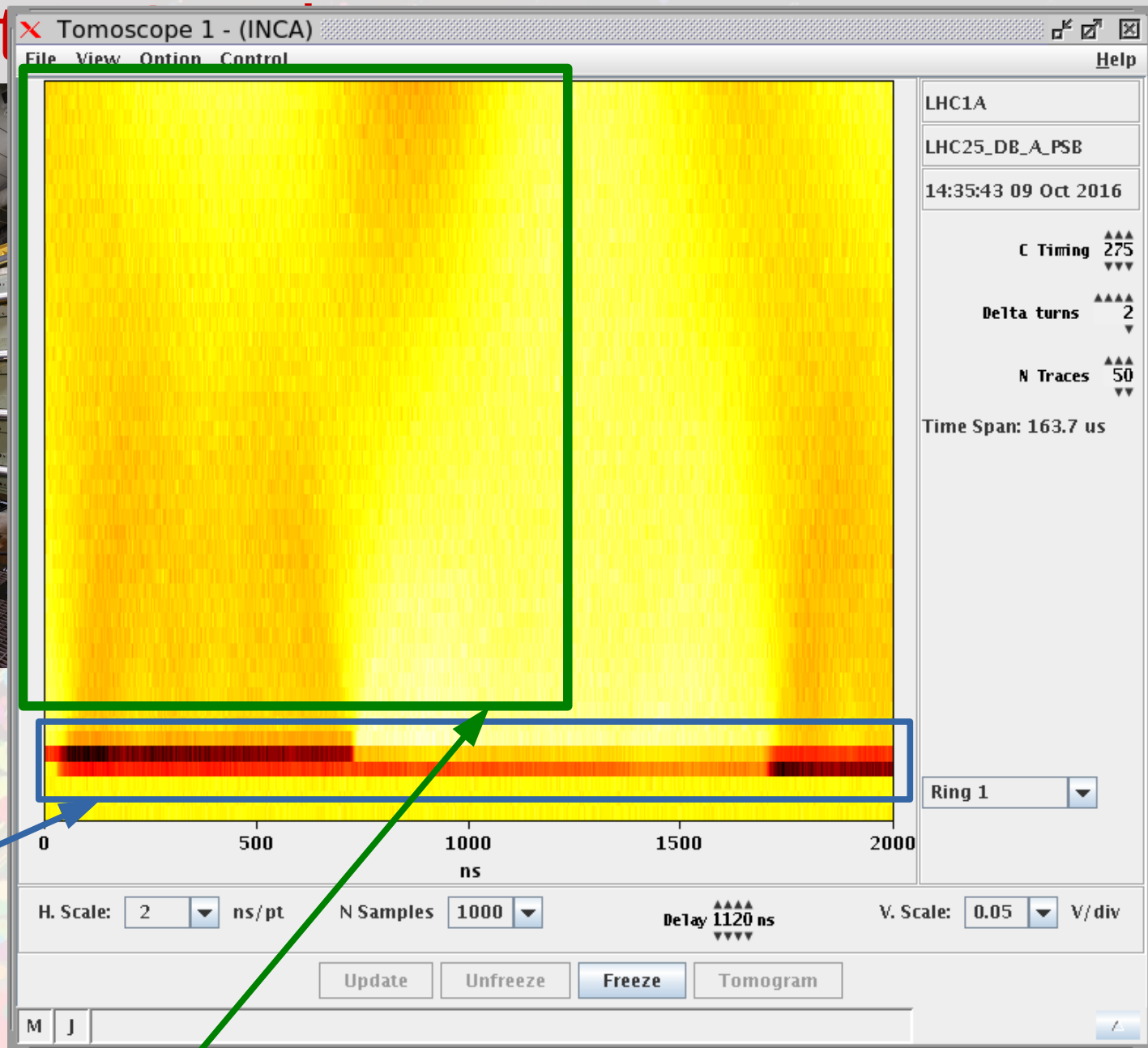
1 injected turn

, h=2,

/dt

n Ring 4

PSB – Prot



Multi-turn injection

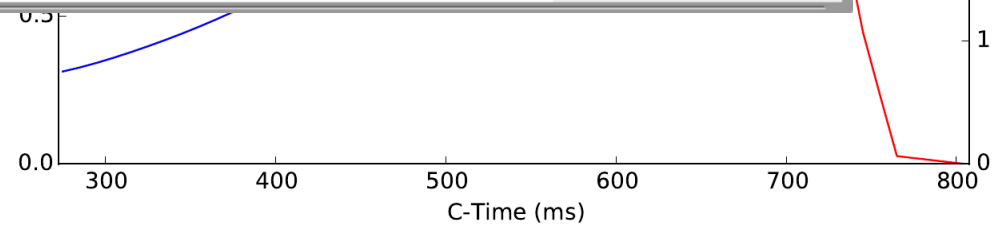
Capture into h1+h2 bucket

, $h=2$,

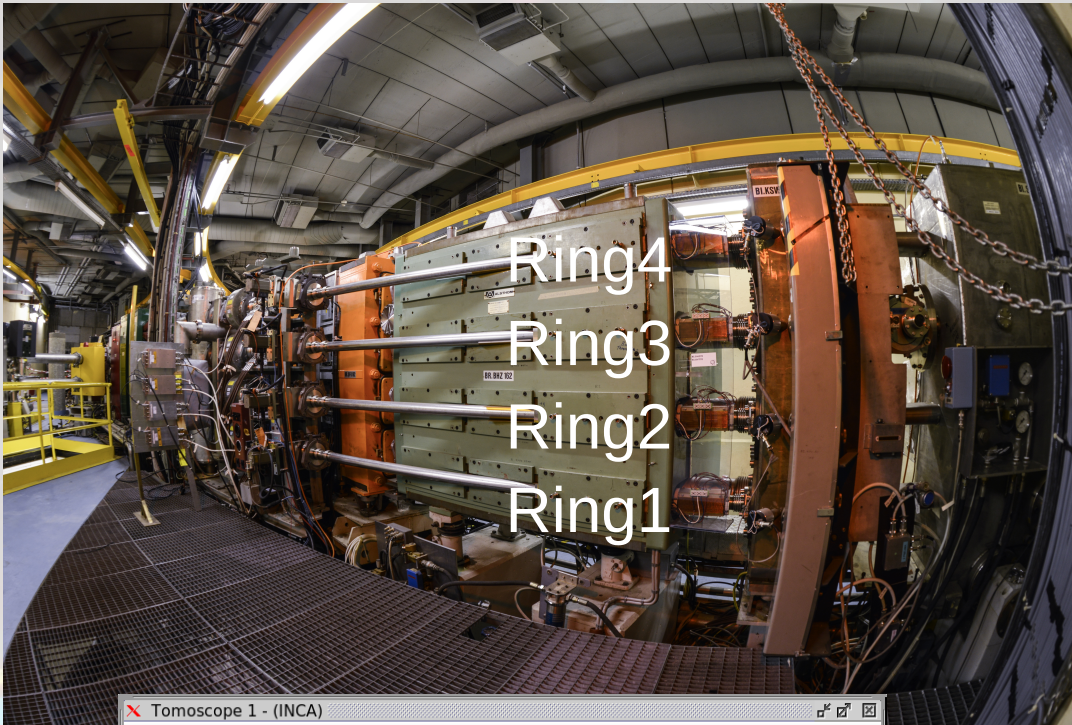
$\frac{dp}{dt}$

in Ring 4

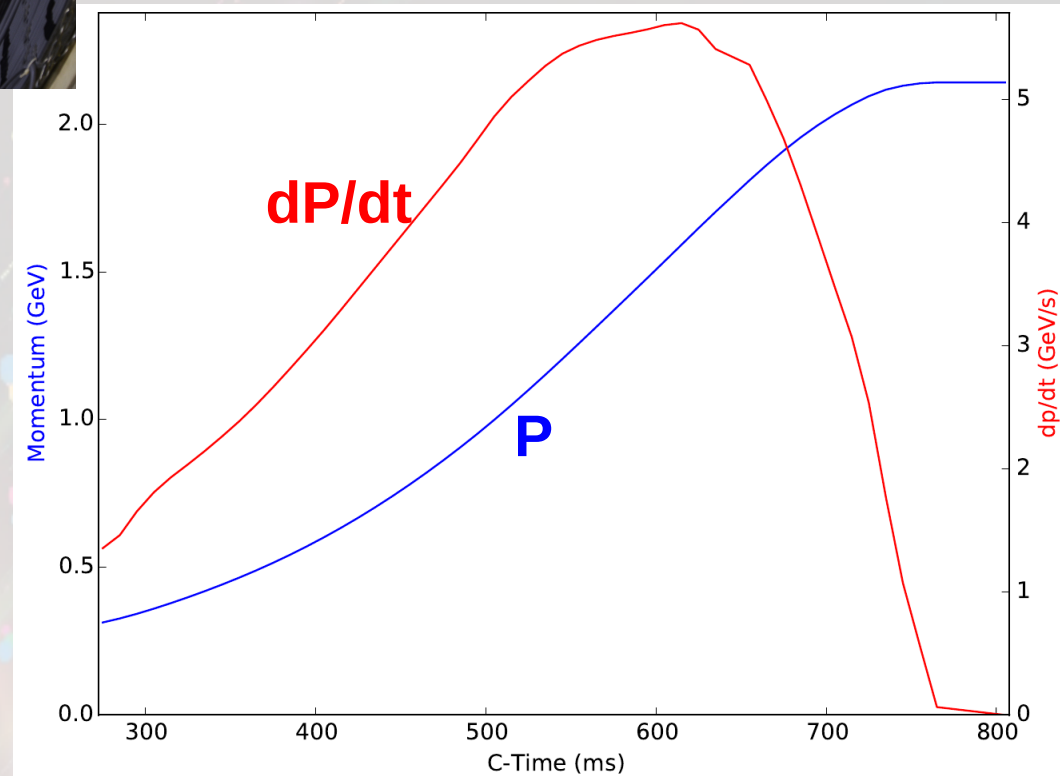
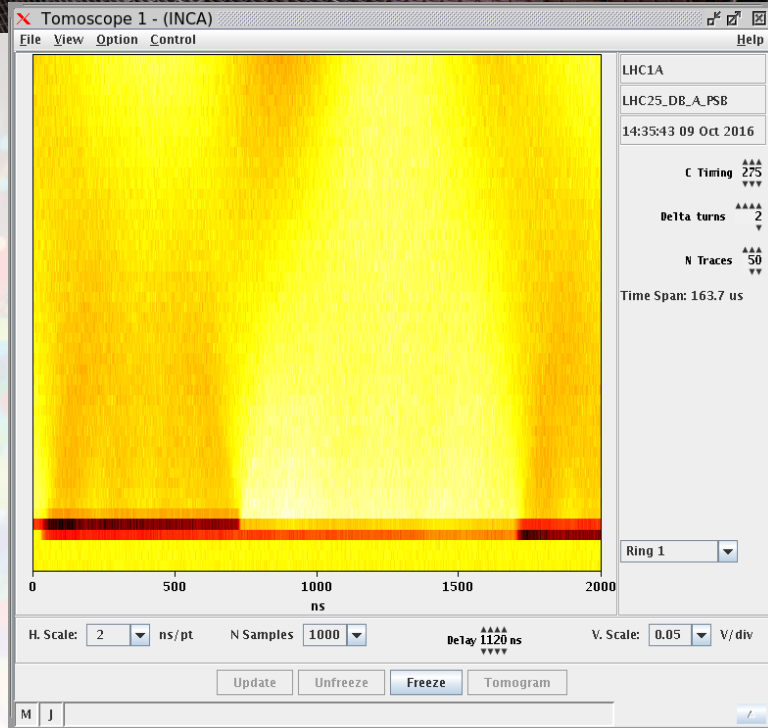
$\frac{dp}{dt}$ (GeV/s)



PSB – Proton Synchrotron Booster



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Space Charge Mitigation

$$\Delta Q_{x,y} = -\frac{q\lambda}{8\pi^2\epsilon_0 m_p c^2 \beta^2 \gamma^3} \oint \frac{\beta_{x,y}(s)}{\sigma_{x,y}(s) (\sigma_x(s) + \sigma_y(s))}$$

$$\sigma_x(s) = \sqrt{\frac{\beta_x(s)\epsilon_x}{\beta\gamma} + D_x^2(s)\delta_{rms}^2}$$

$$\sigma_y(s) = \sqrt{\frac{\beta_y(s)\epsilon_y}{\beta\gamma}}$$

Space Charge Mitigation

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Space Charge Mitigation

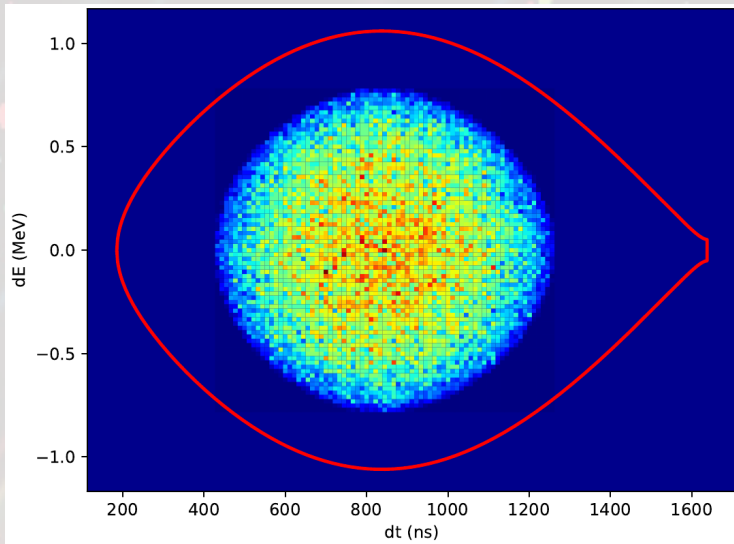
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$$\sigma_x(s) = \sqrt{\frac{\beta_x(s)\epsilon_x}{\beta\gamma} + D_x^2(s)\delta_{rms}^2} \quad \sigma_y(s) = \sqrt{\frac{\beta_y(s)\epsilon_y}{\beta\gamma}}$$

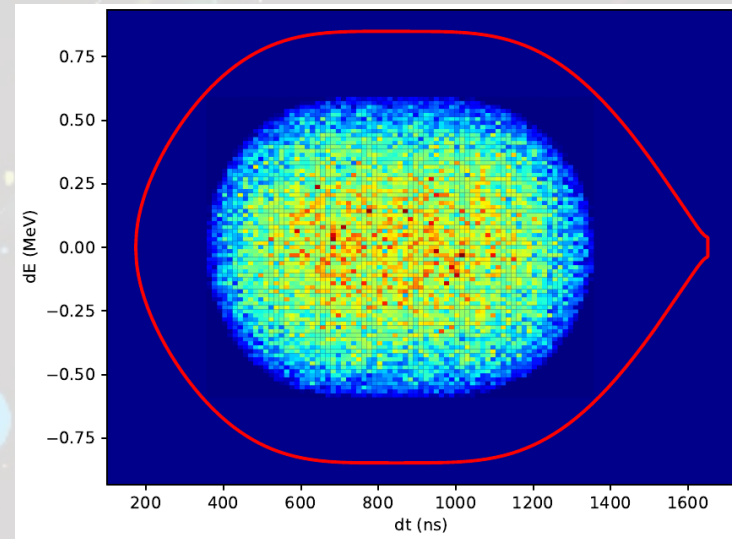
$$\Delta Q_{x,y} = f(\lambda, \delta_{RMS})$$

Space Charge Mitigation

Single harmonic

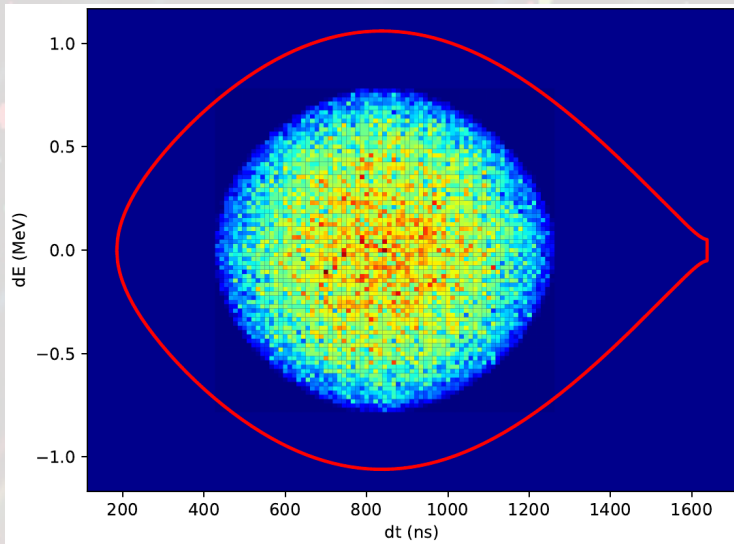


Double harmonic (Bunch Lengthening Mode)

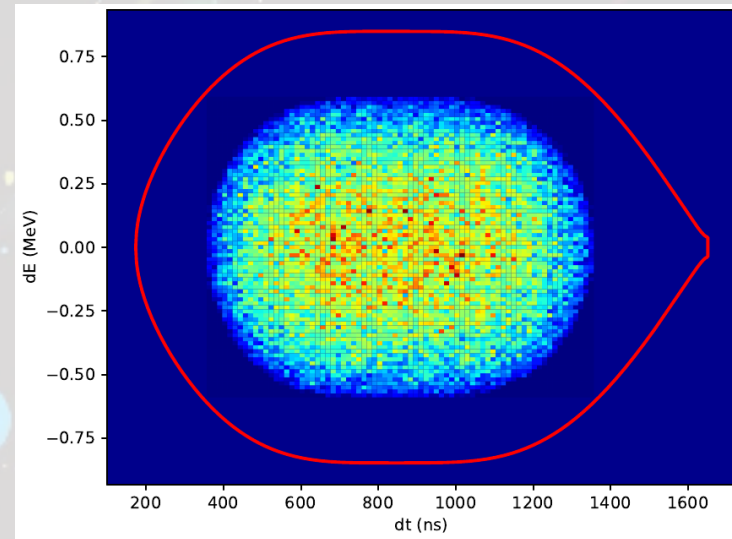


Space Charge Mitigation

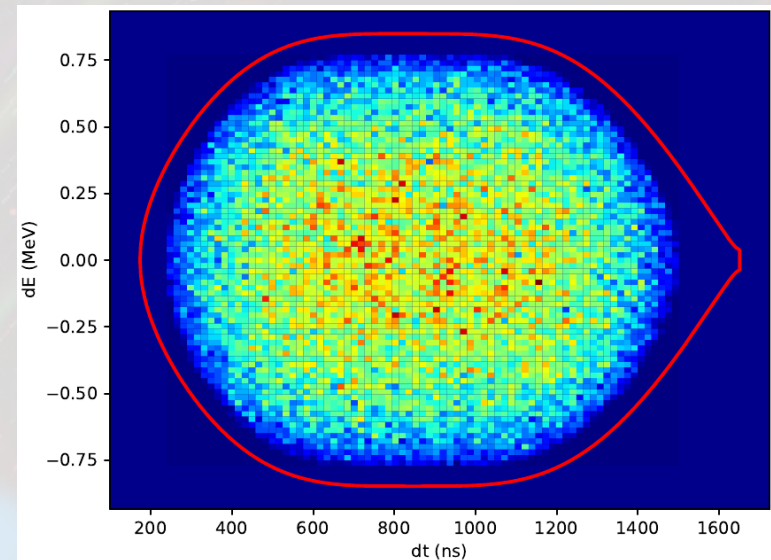
Single harmonic



Double harmonic (Bunch Lengthening Mode)

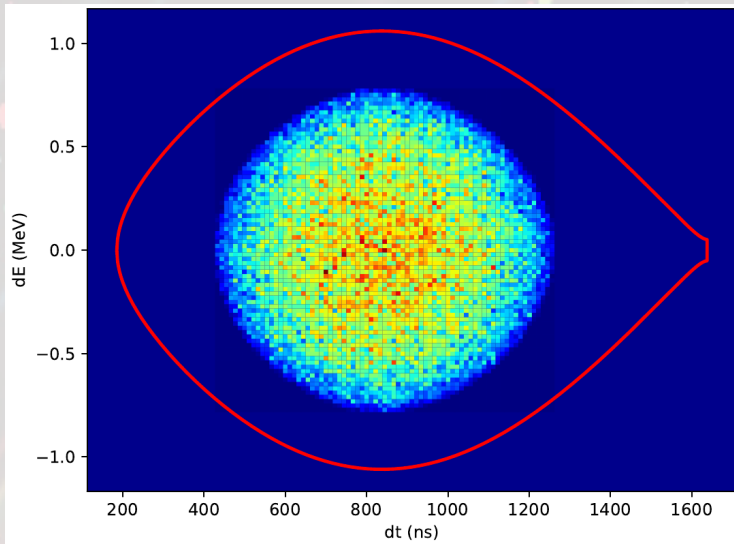


Double harmonic (BLM) + long. emittance blow-up

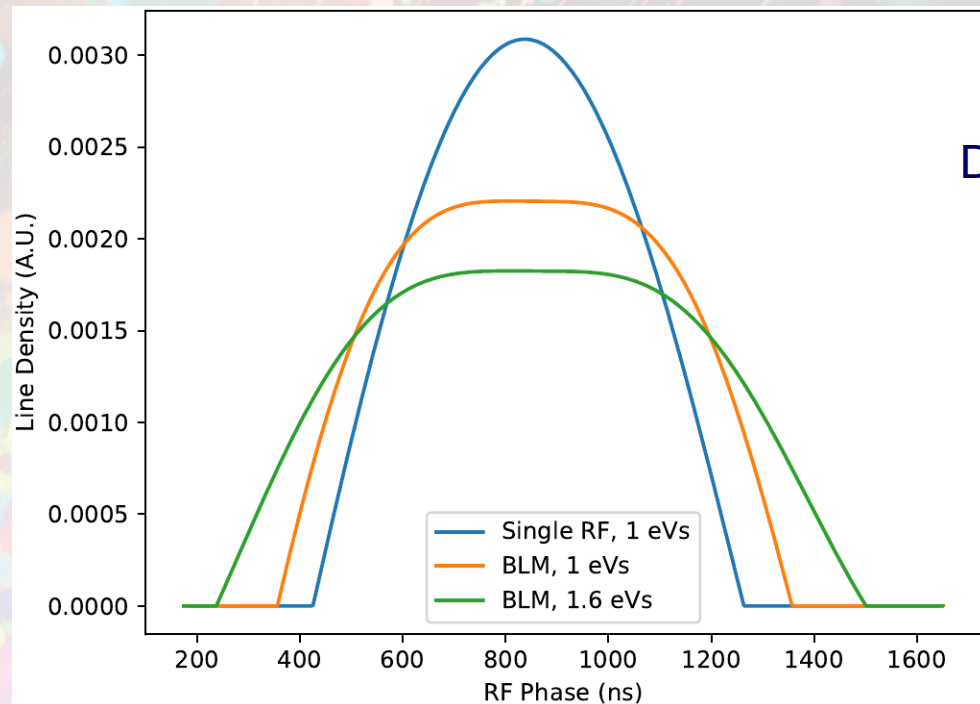
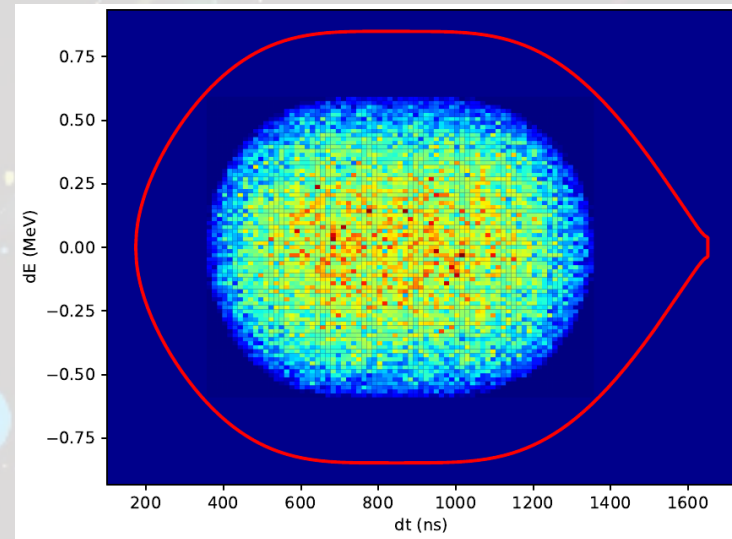


Space Charge Mitigation

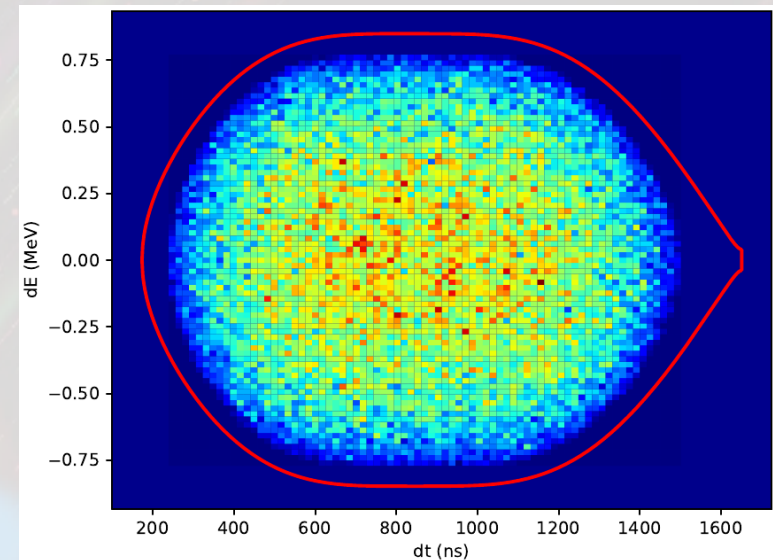
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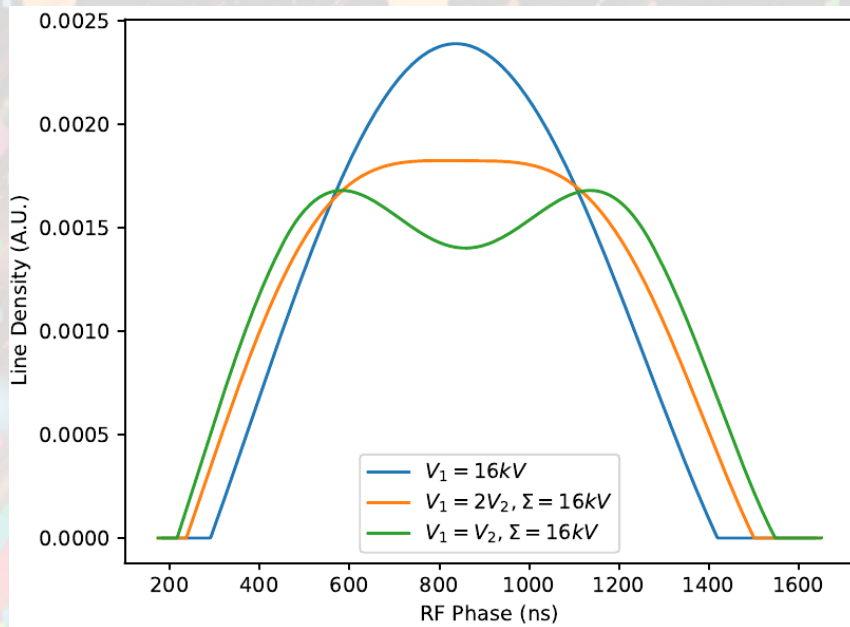
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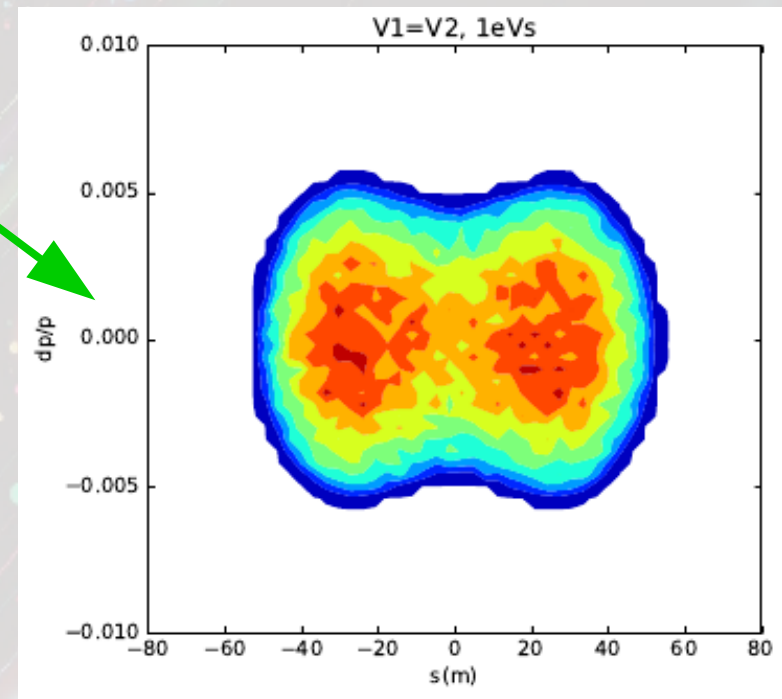
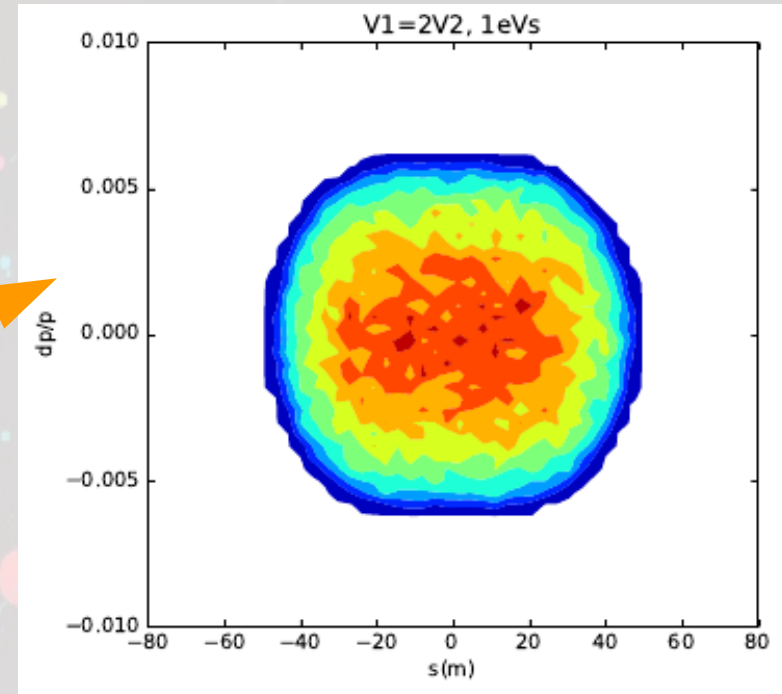
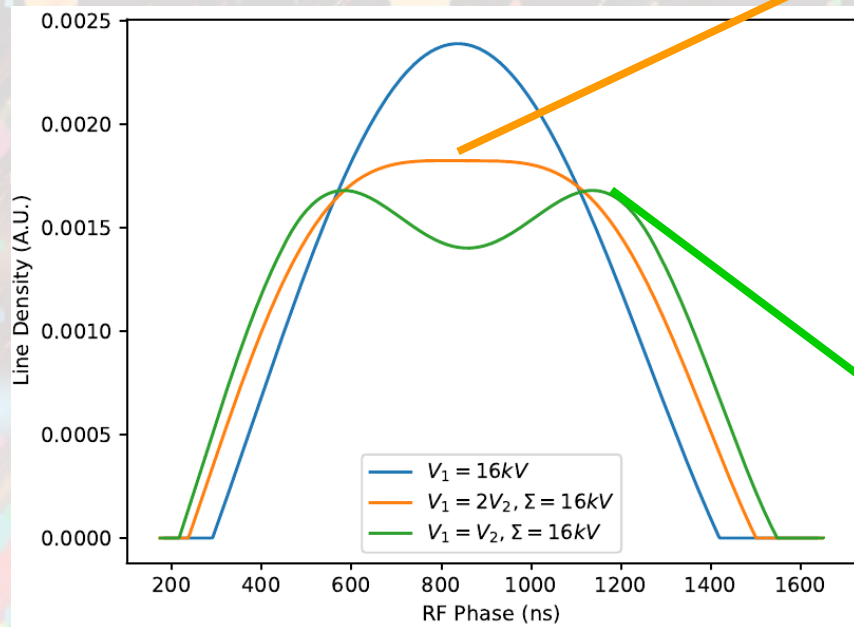
Space Charge Mitigation

Example: PS Booster

- 2 RF narrow band tunable ferrite cavities
- $h=1$ for acceleration (max. 8 kV)
- $h=2$ for bunch shaping (max. 8 kV)
- During LS2 ferrites will be replaced with broadband Finemet™ cavities
- Finemet™ will enable arbitrary voltage distribution increasing flexibility



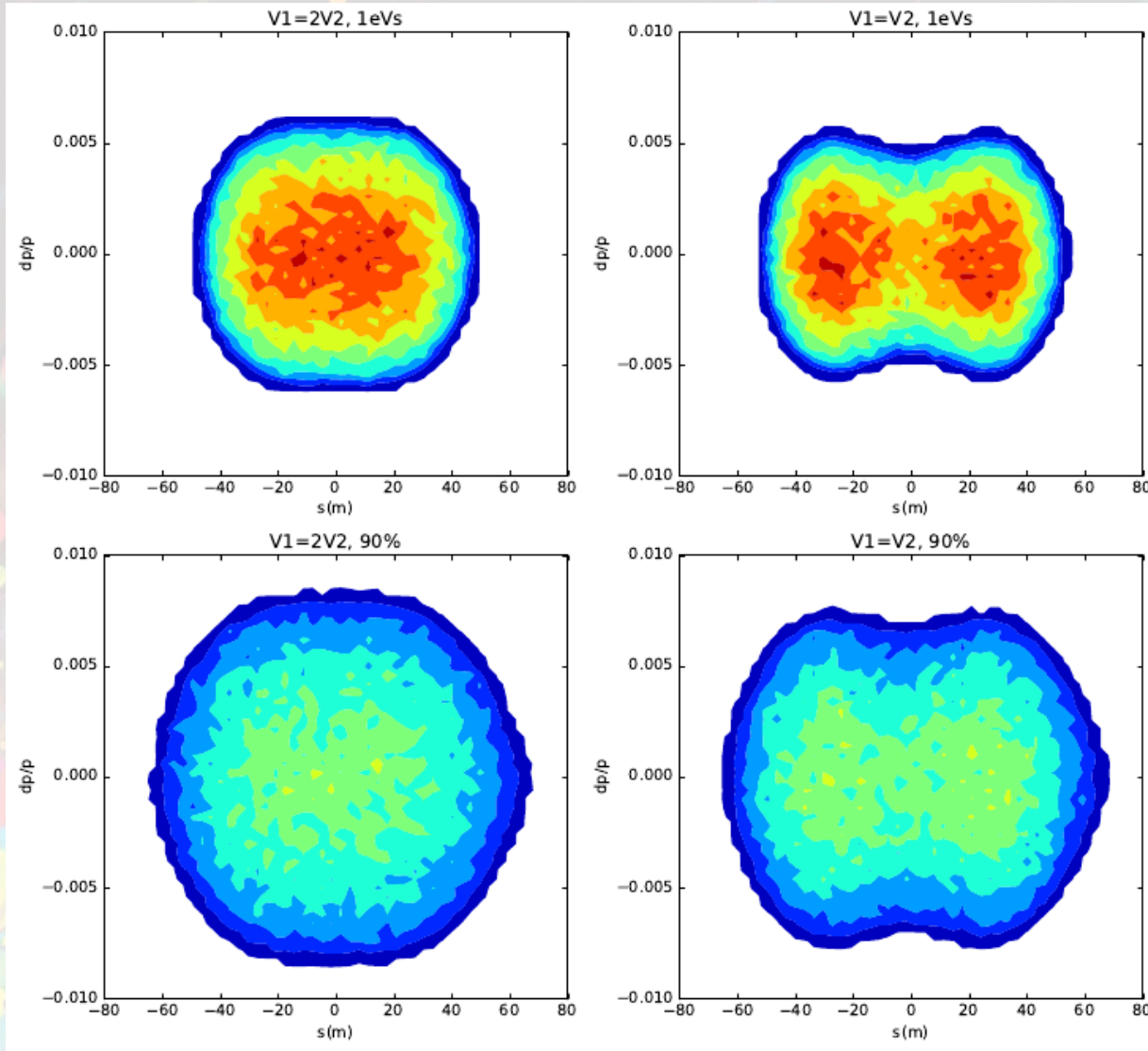
Space Charge Mitigation



Space Charge Mitigation

$$V_1 = 2V_2$$

$$V_1 = V_2$$



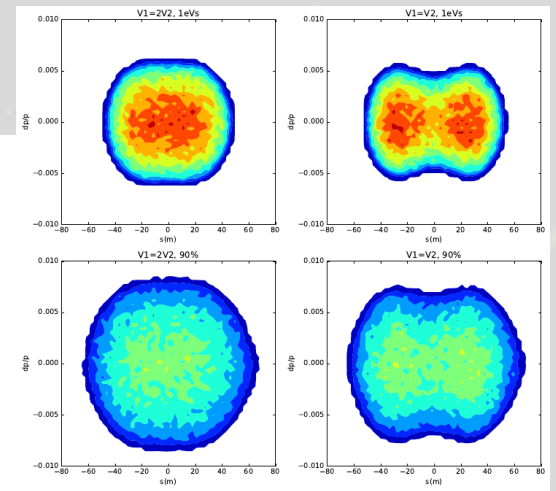
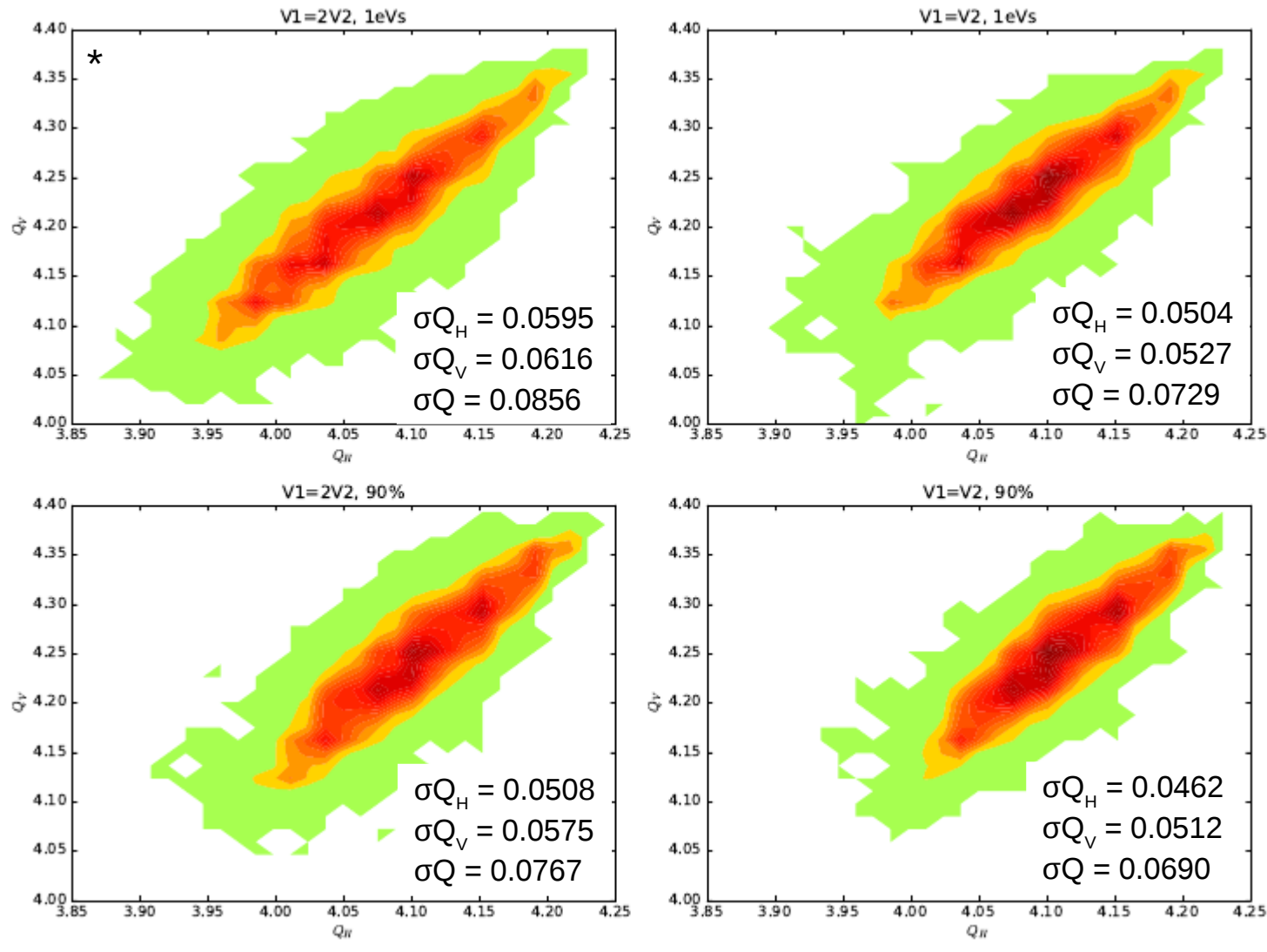
1 eVs long. emittance

long. emittance = 90%
bucket area

$$V_1=2V_2 \quad A_B \sim 1.9 \text{ eVs}$$

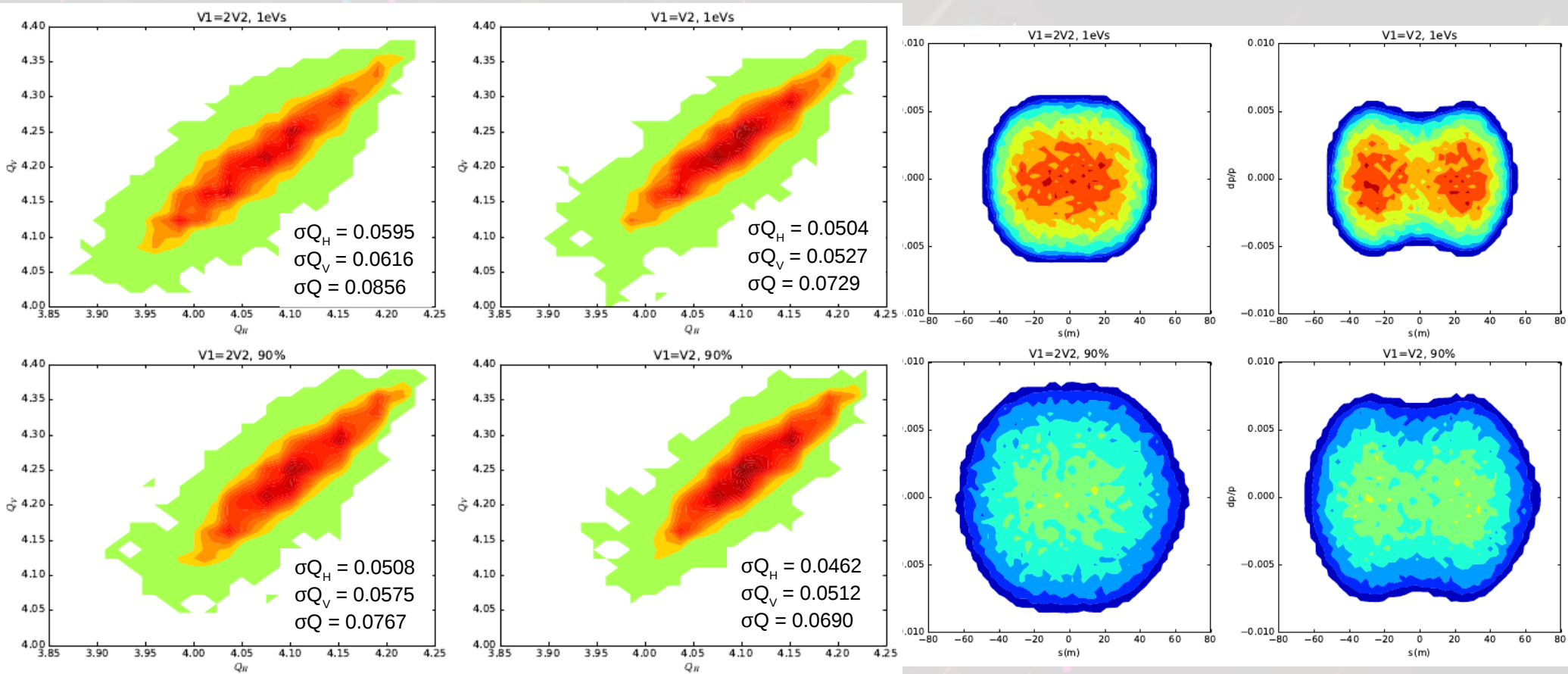
$$V_1=V_2 \quad A_B \sim 1.8 \text{ eVs}$$

Space Charge Mitigation



* Thanks to A. Oeftiger for tune spread simulations

Space Charge Mitigation



- Simulation confirms what we already know, big long bunches reduce space charge
- Changing voltage ratios can be as effective as longitudinal emittance blow-up from 1 \rightarrow 1.7 eVs

Application

LEIR:

- High 6D density coasting beams
- Adiabatic RF capture on flat bottom
- Consider maximum extracted intensity
- Transmission limited by transverse space charge effects*

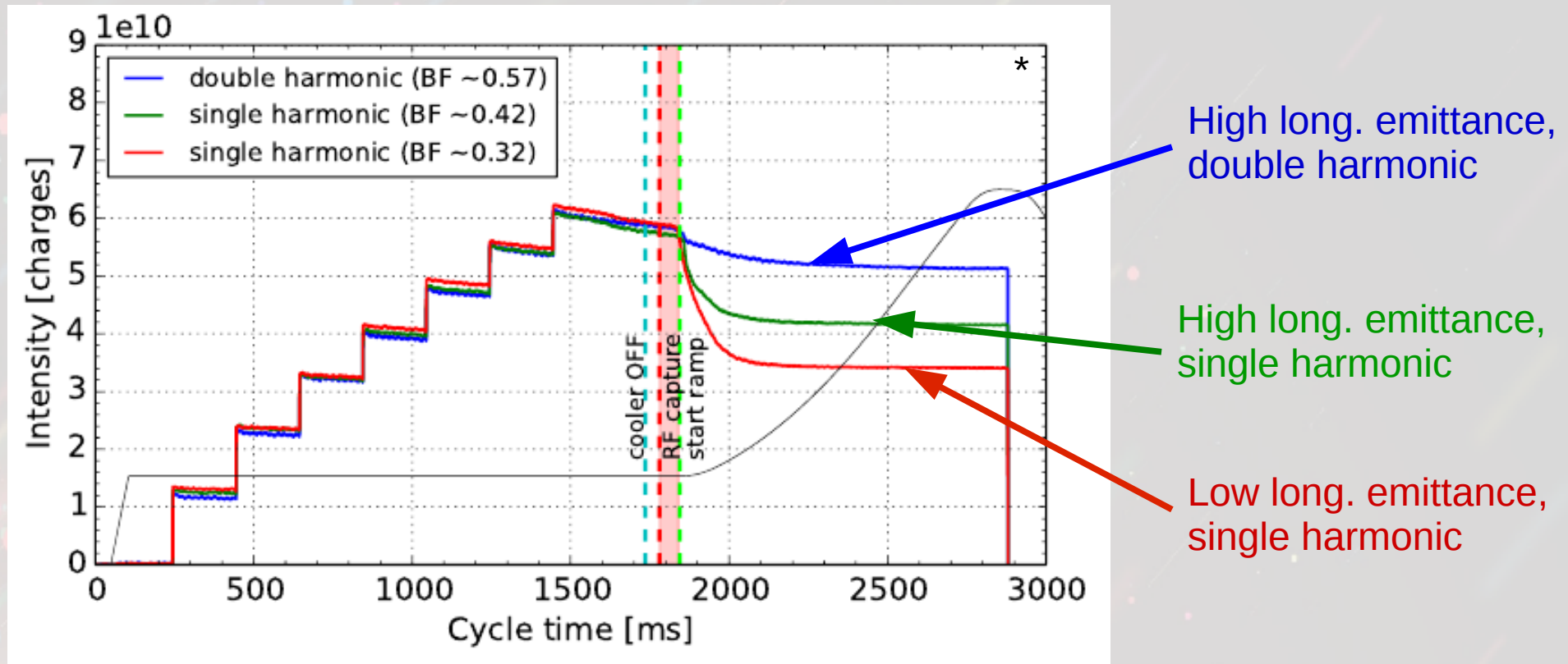
PSB:

- Multi-turn injection on ramp
- RF capture during injection
- Consider maximum brightness
- Transmission and brightness both affected by space charge⁺

*HB2016 – TUAM5X01, H.Bartosik et al
IPAC2017 – THPAB049, A. Huschauer et al

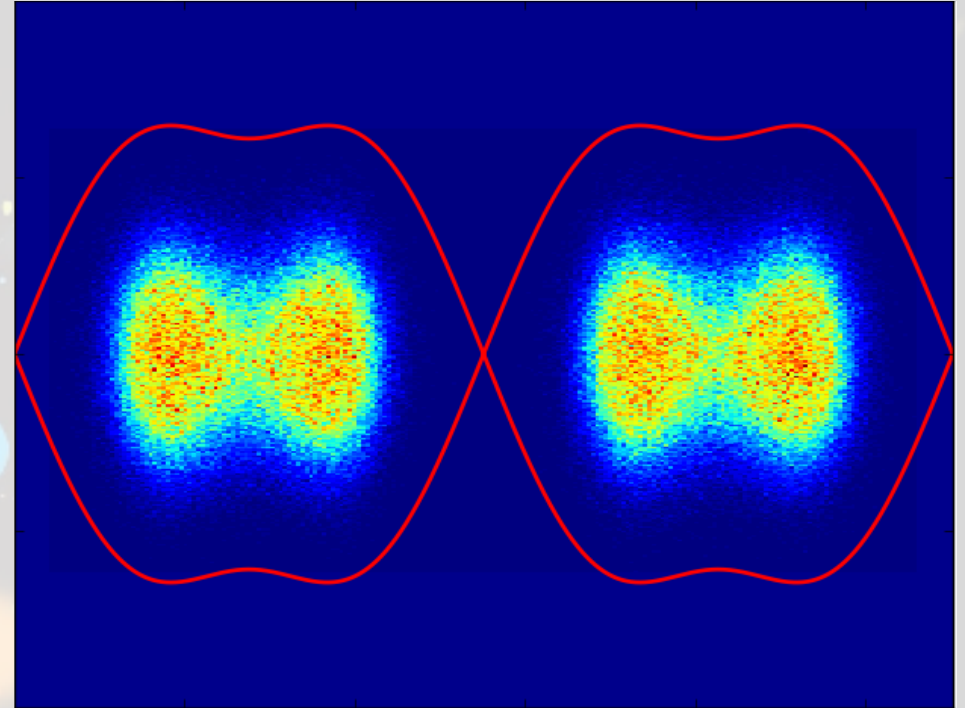
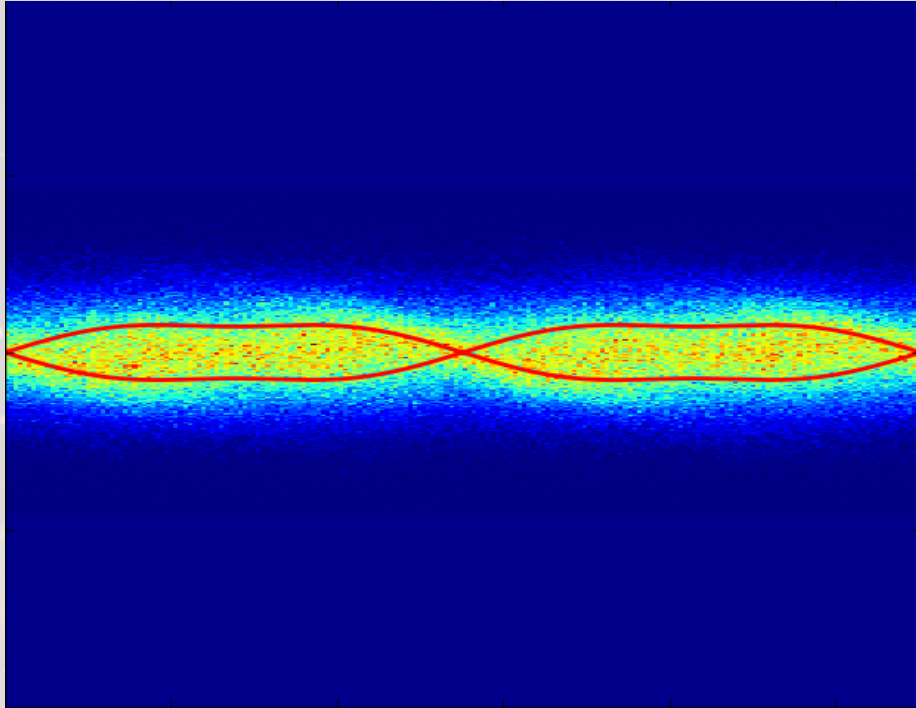
⁺LHC Injectors Upgrade TDR – Vol. 1: Protons

Application - LEIR



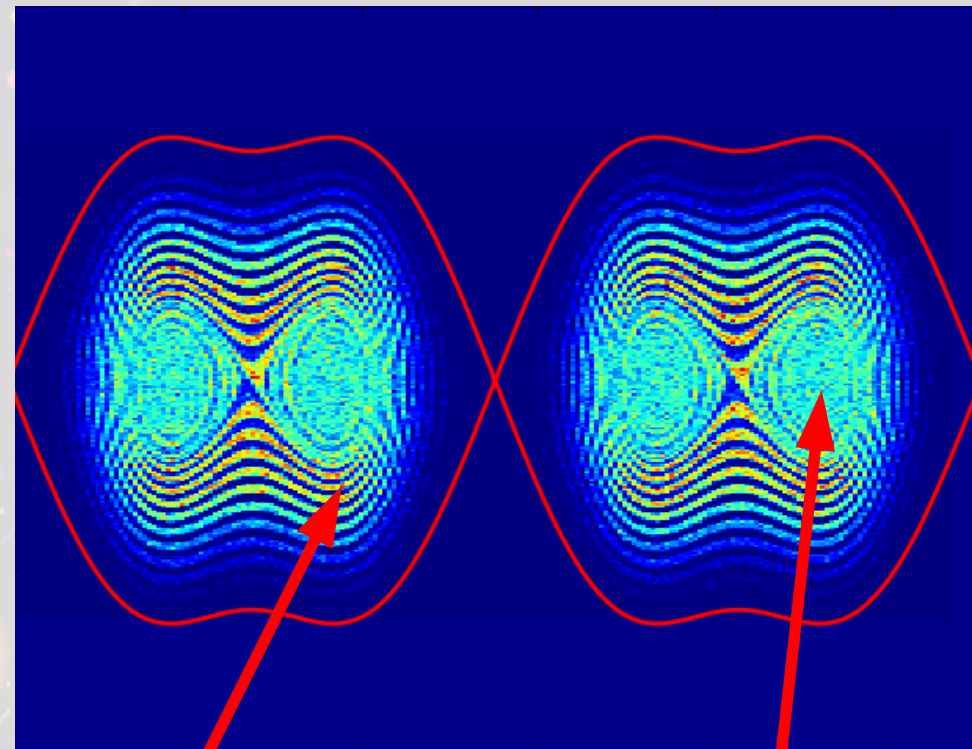
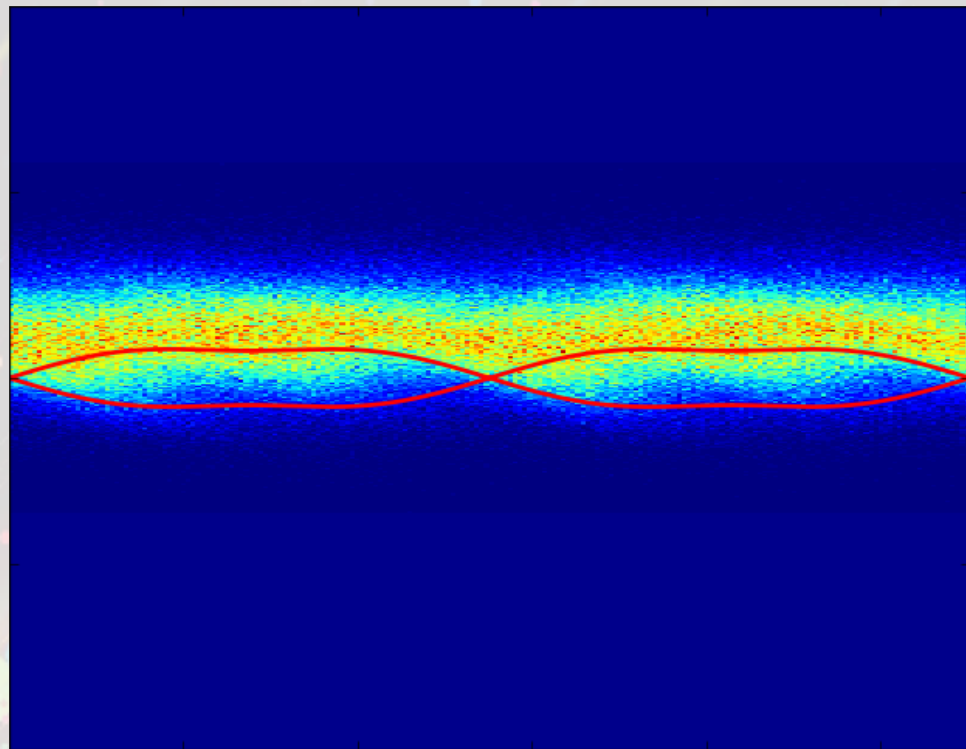
- Losses start during or immediately after RF capture
- No time for dedicated blow-up, 10s of ms required
- Maximise bunching factor during capture process to reduce losses

Application - LEIR



- Adiabatic capture on flat bottom
- $F_{\text{RF}} = F_{\text{beam}}$, bucket forms on bunch leading to smallest possible longitudinal emittance

Application - LEIR

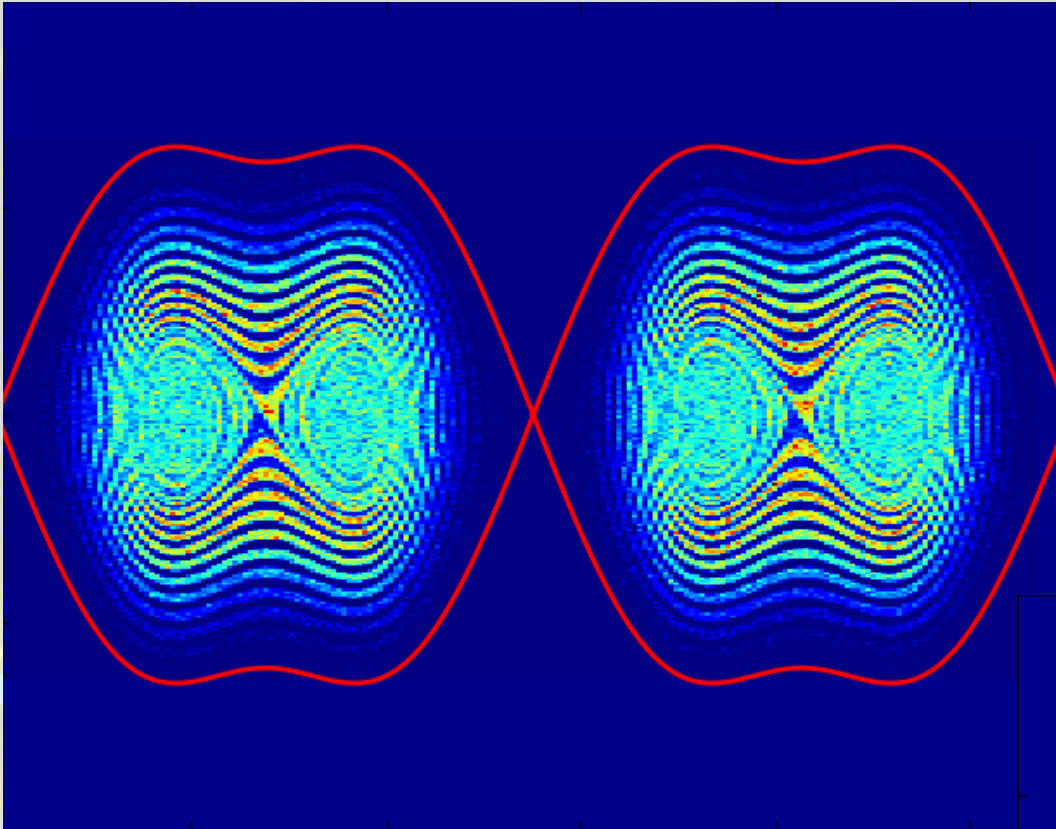


high density outside

low density core

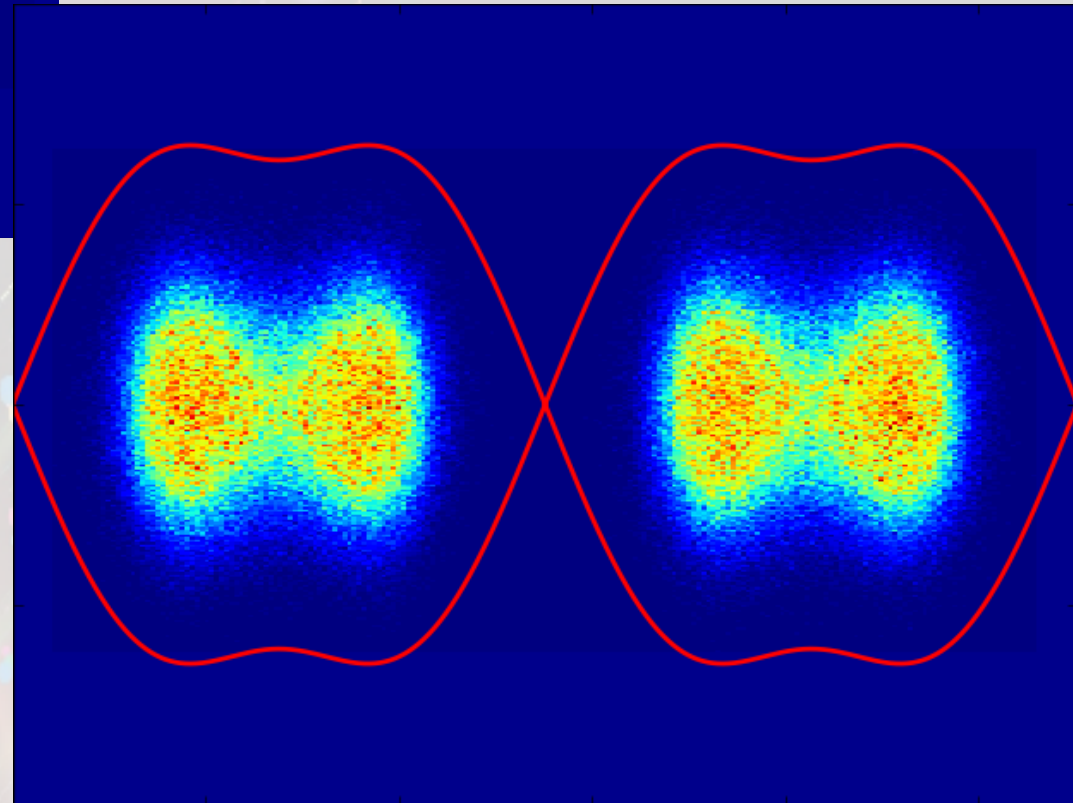
- $F_{\text{RF}} \neq F_{\text{beam}}$, captured emittance increased and core density decreased
- Increased bunching factor \rightarrow reduced space charge effect

Application - LEIR

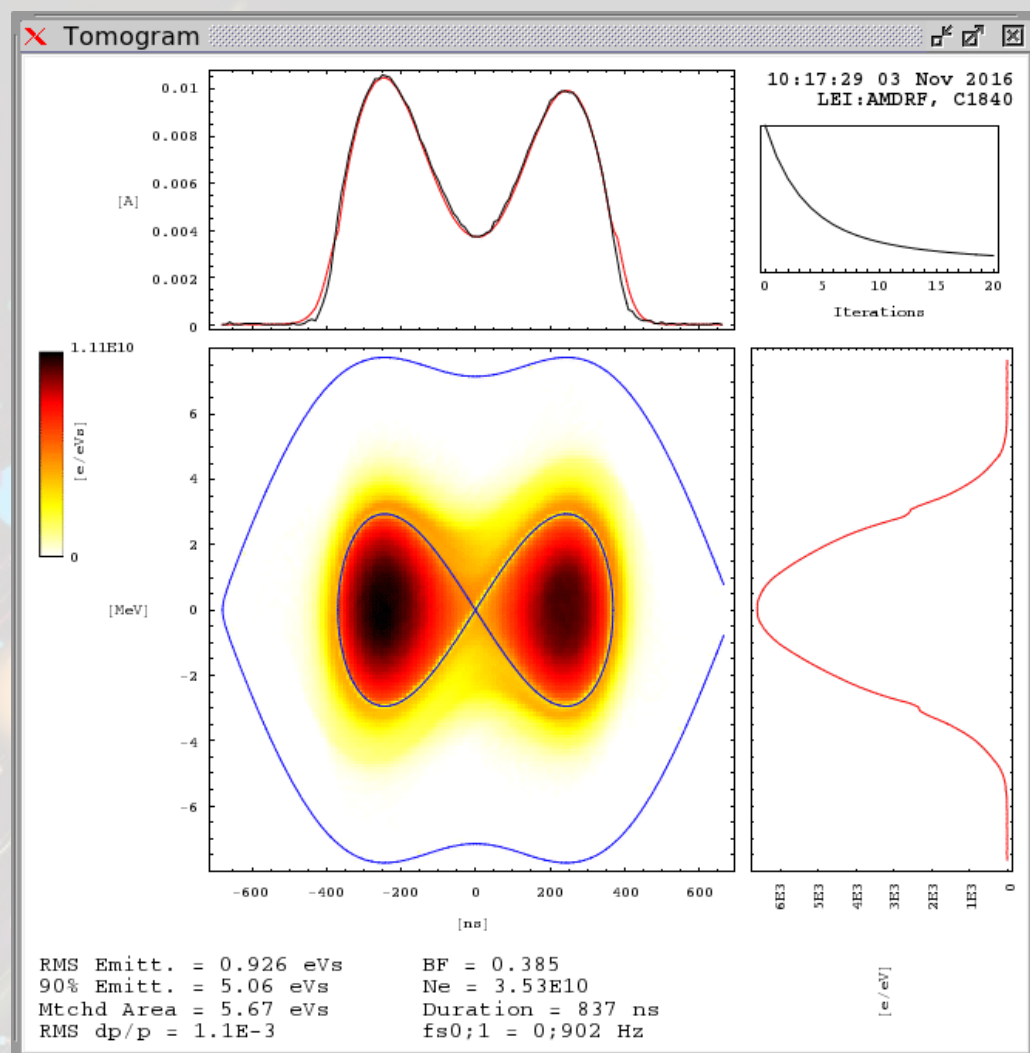
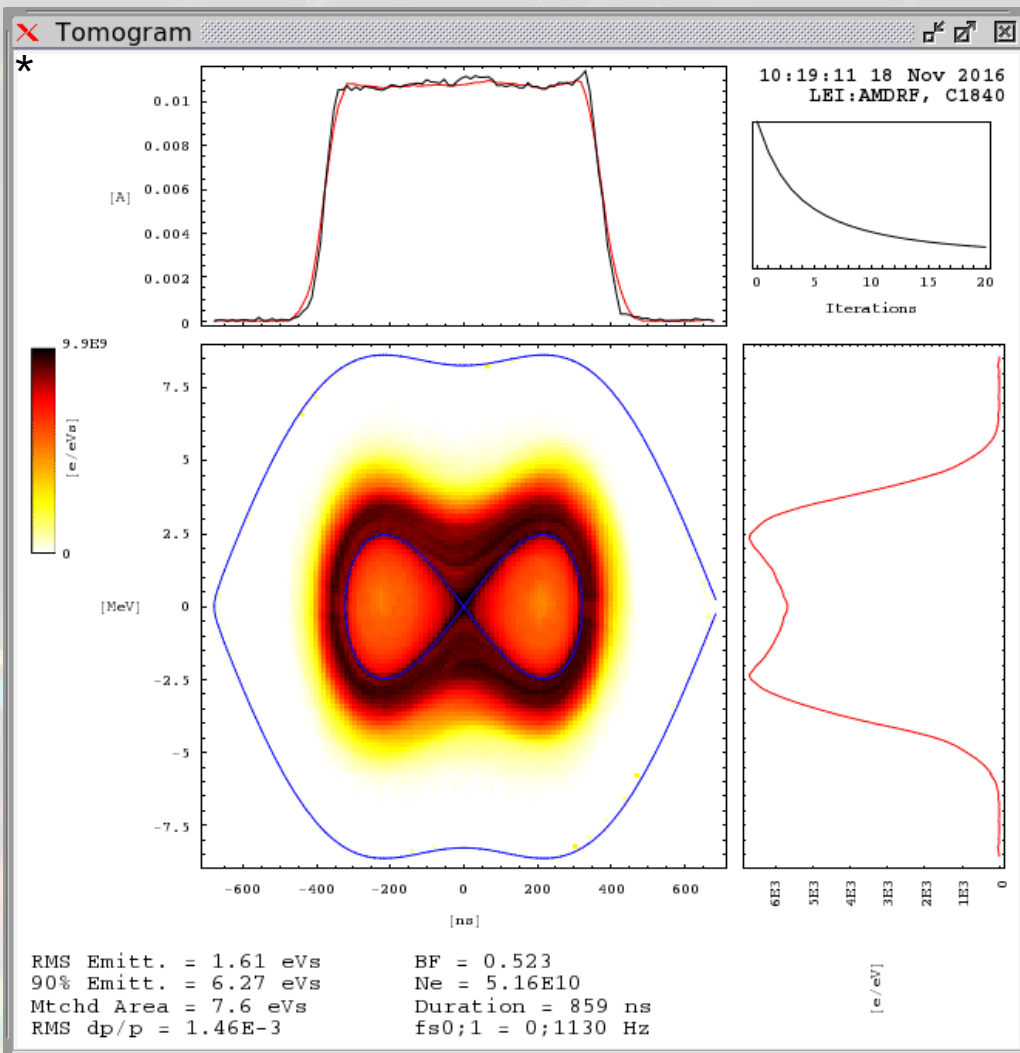


High density, low bunching factor,
high losses

Low density, high bunching factor,
low losses



Application - LEIR

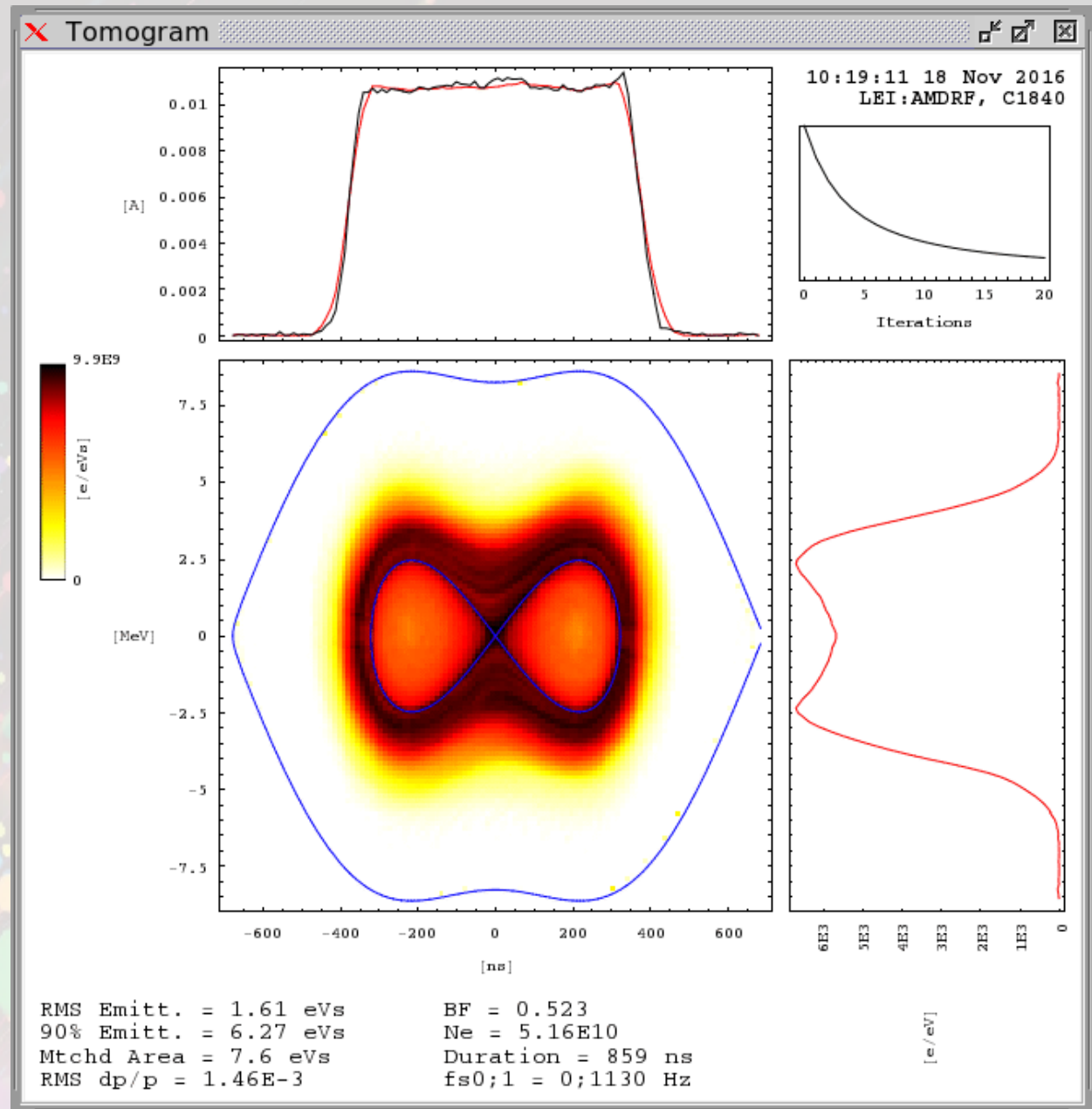


Bunching Factor: 0.523
RMS dp/p: 1.46E-3
Matched Area: 7.6 eVs

Bunching Factor: 0.385
RMS dp/p: 1.1E-3
Matched Area: 5.67 eVs

Application - LEIR

- Hollow bunches very good for space charge*
- Improved transmission in LEIR
- Captured distribution very sensitive to difference between F_{RF} and F_{beam}

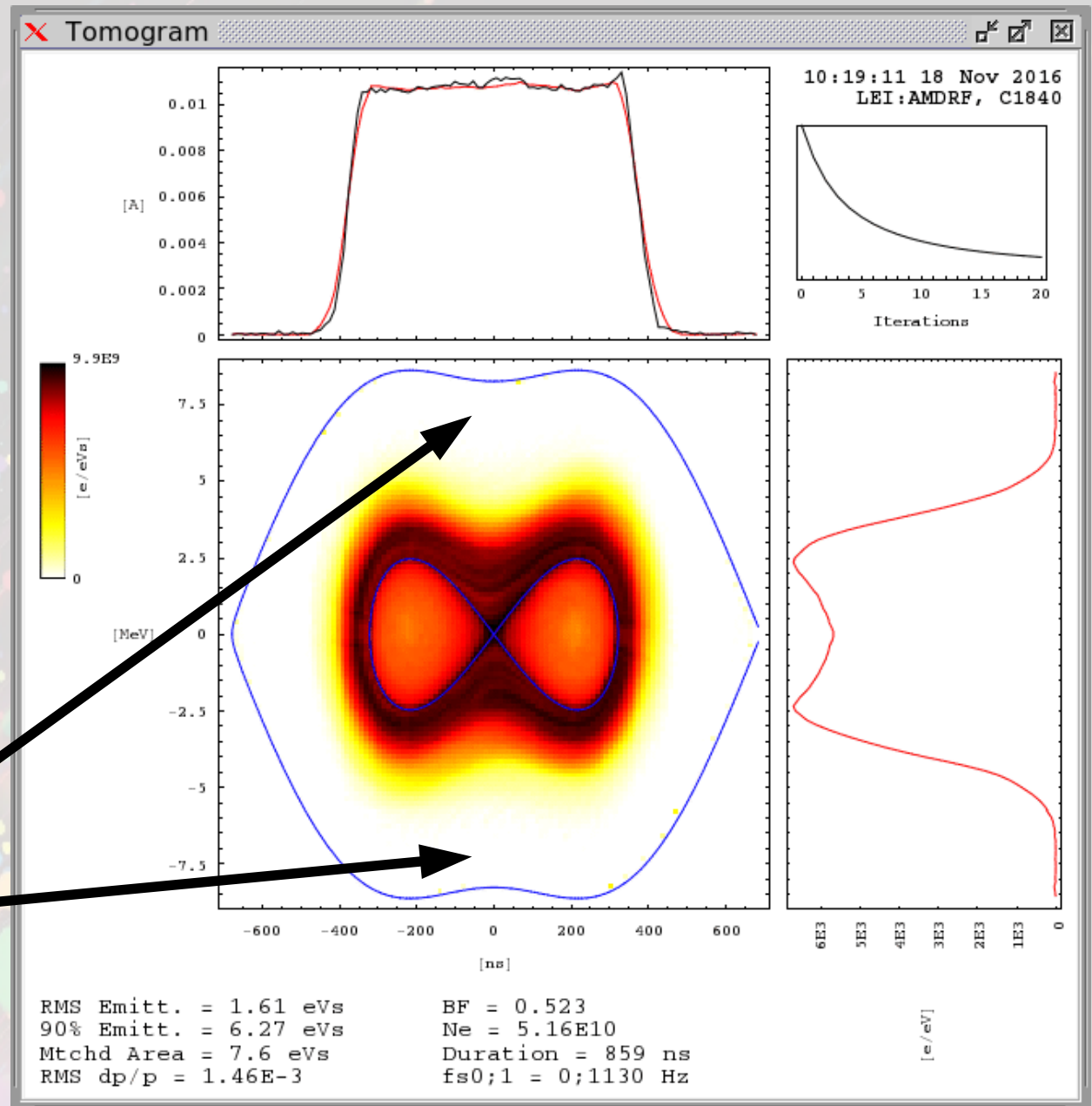


*For more details see: Adrian Oeftiger, "Hollow bunches for space charge mitigation"

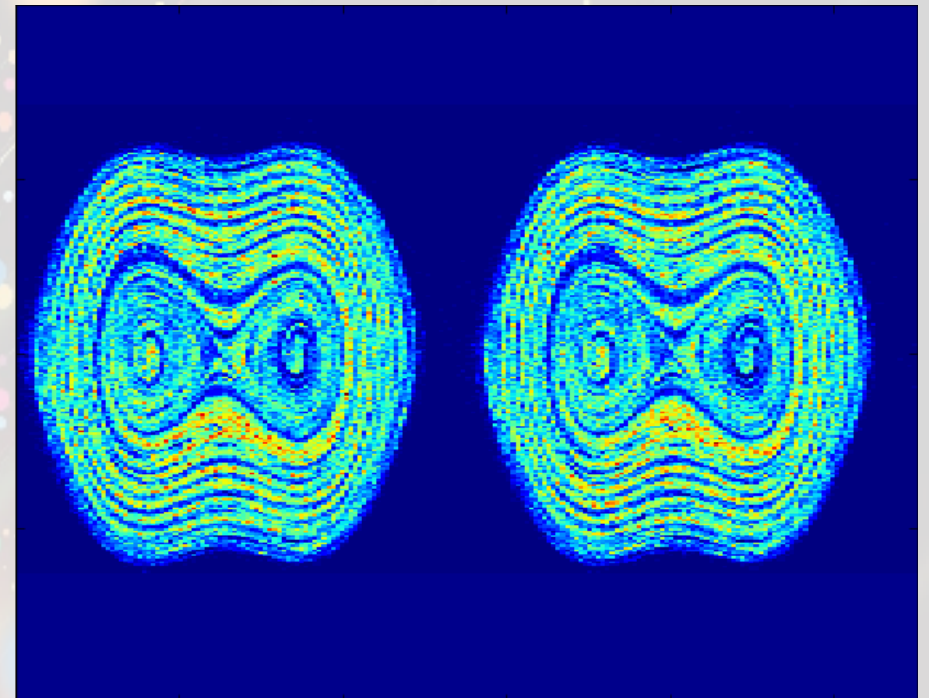
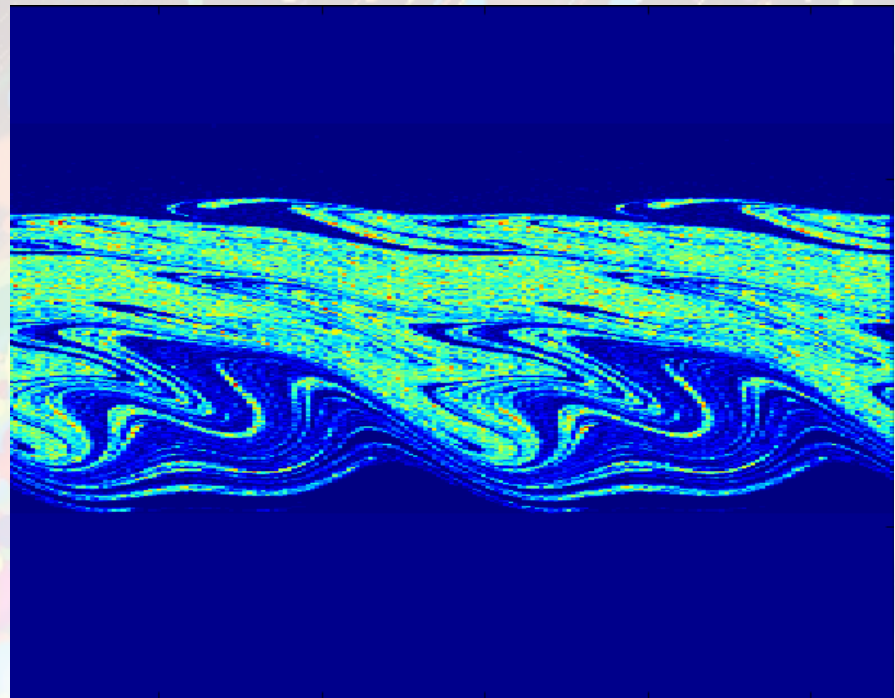
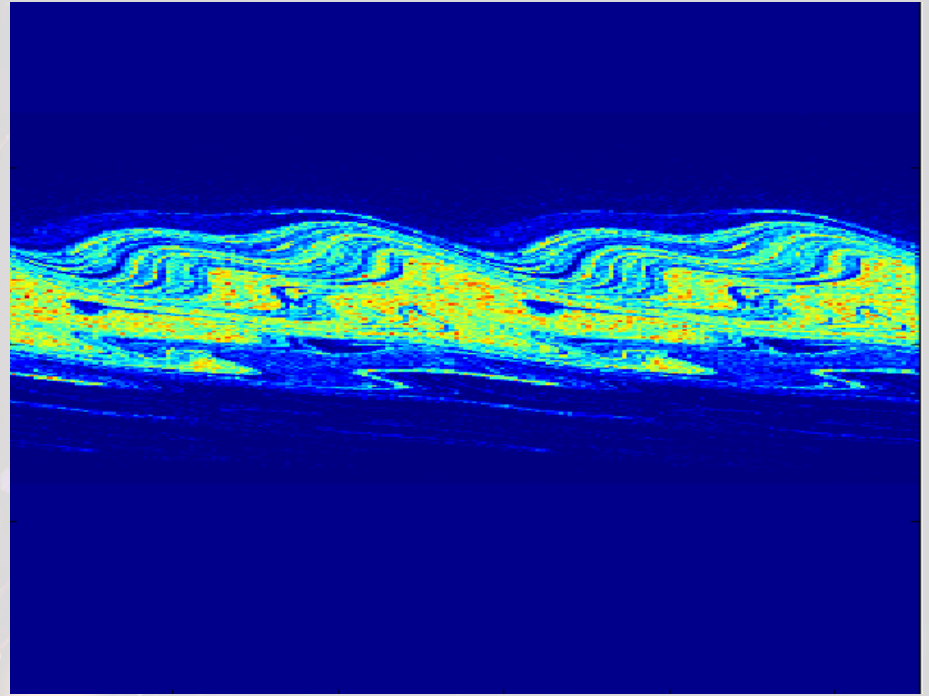
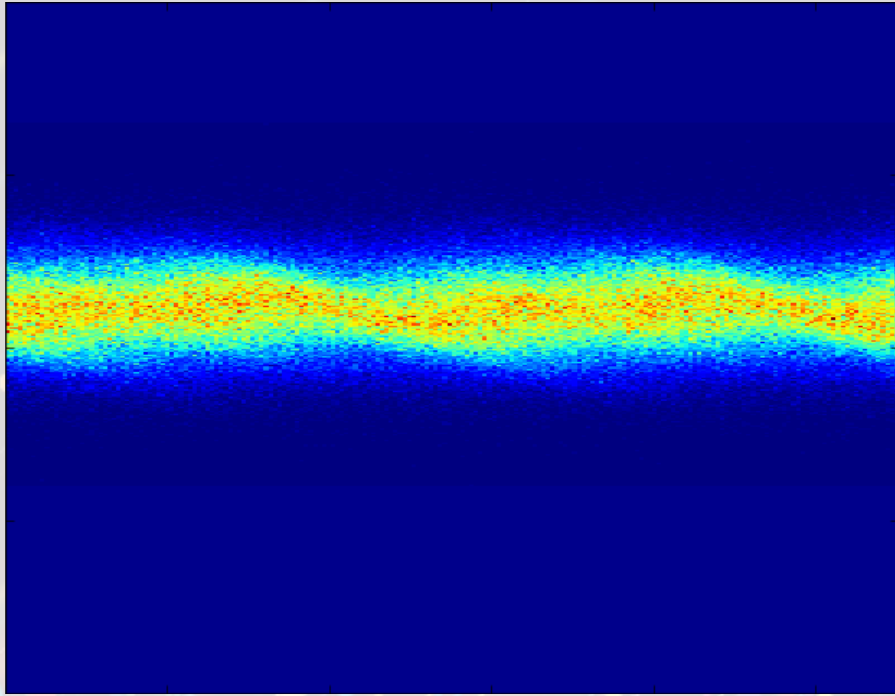
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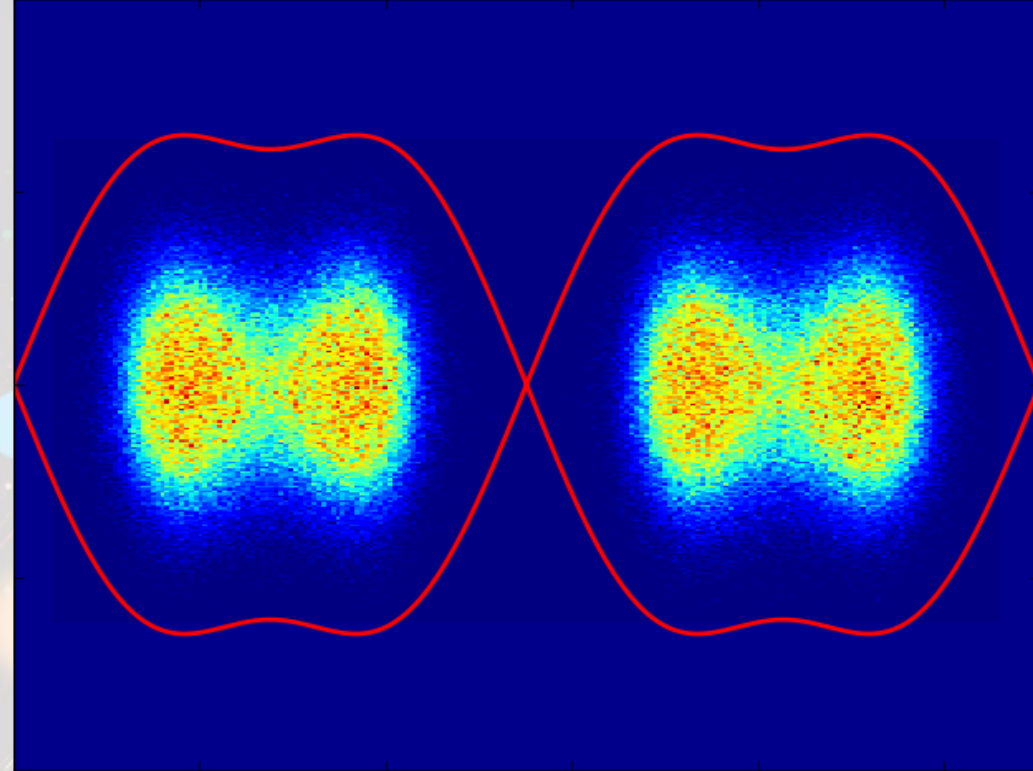
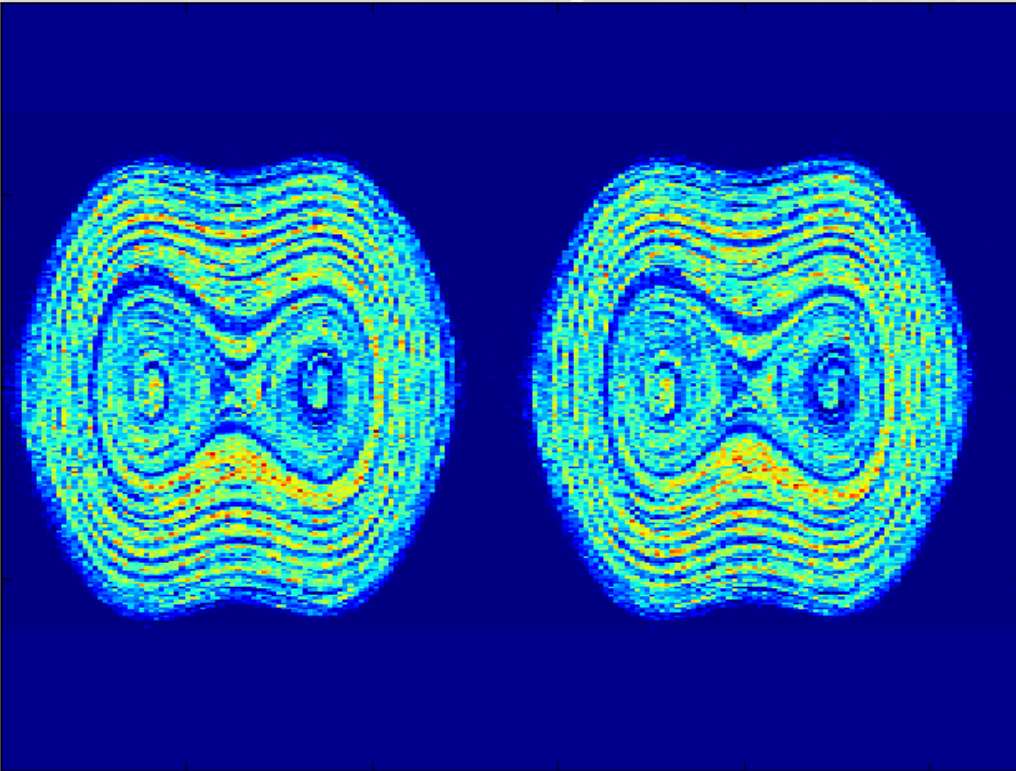
Lots of empty space



Application - LEIR

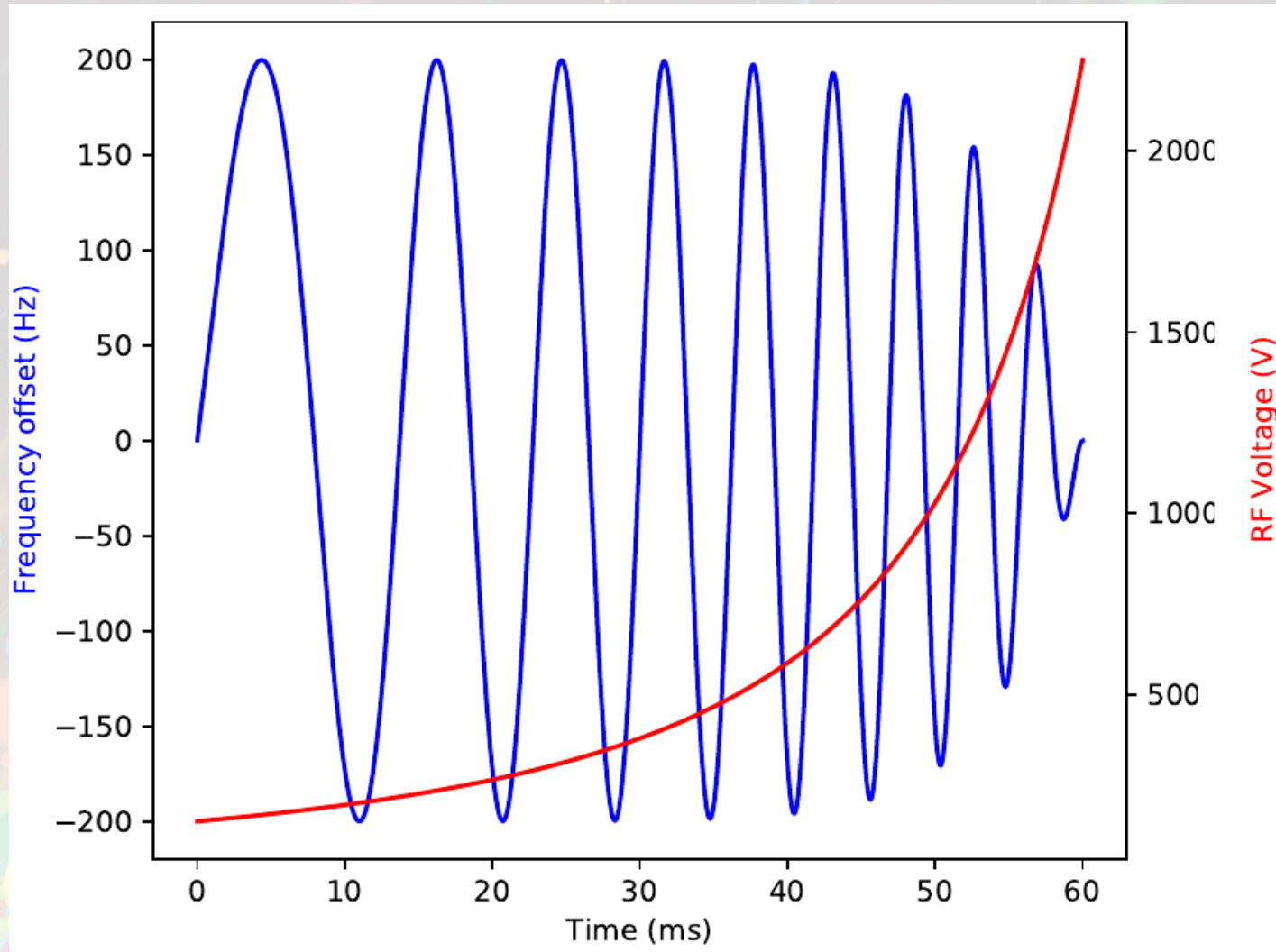


Application - LEIR



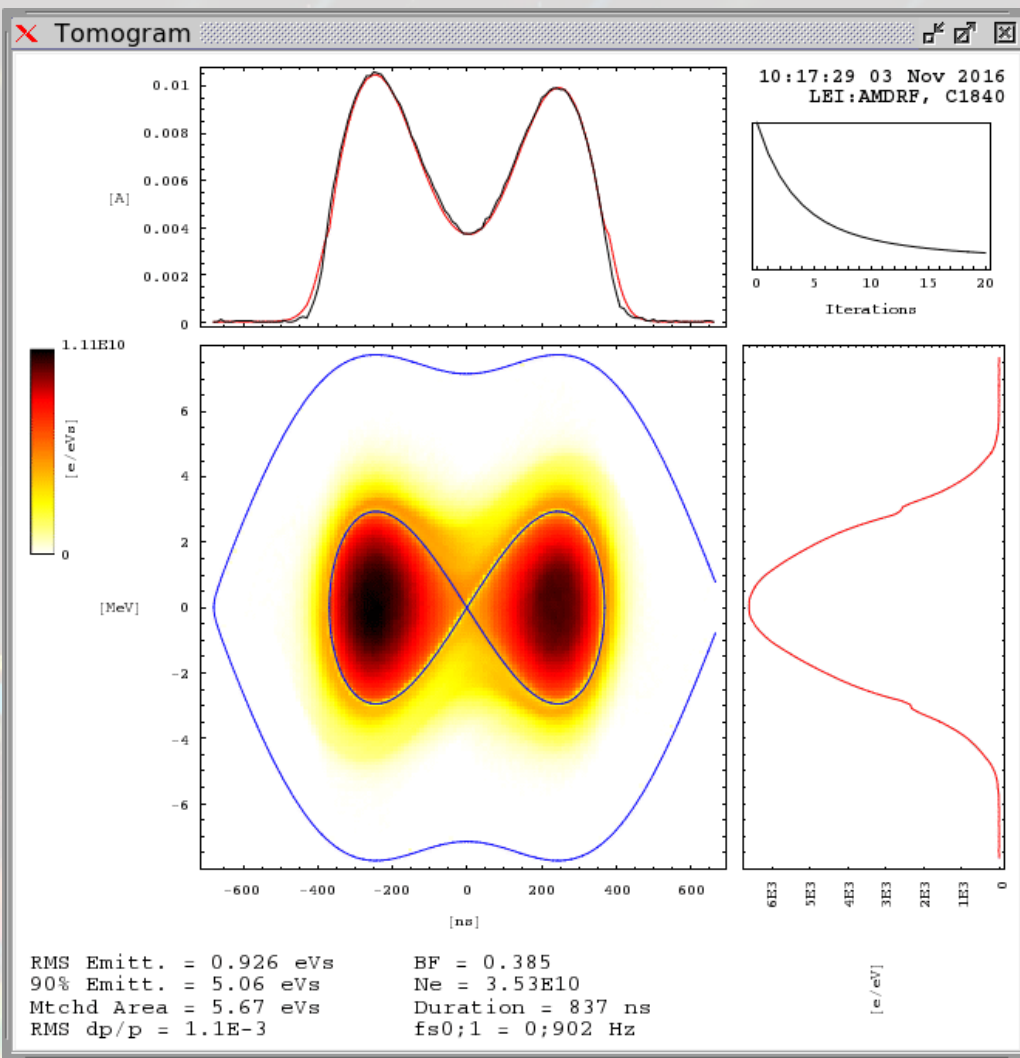
- Apply frequency modulation during the capture process
- Increase reproducibility
- increase emittance
- Further reduce losses

Application - LEIR

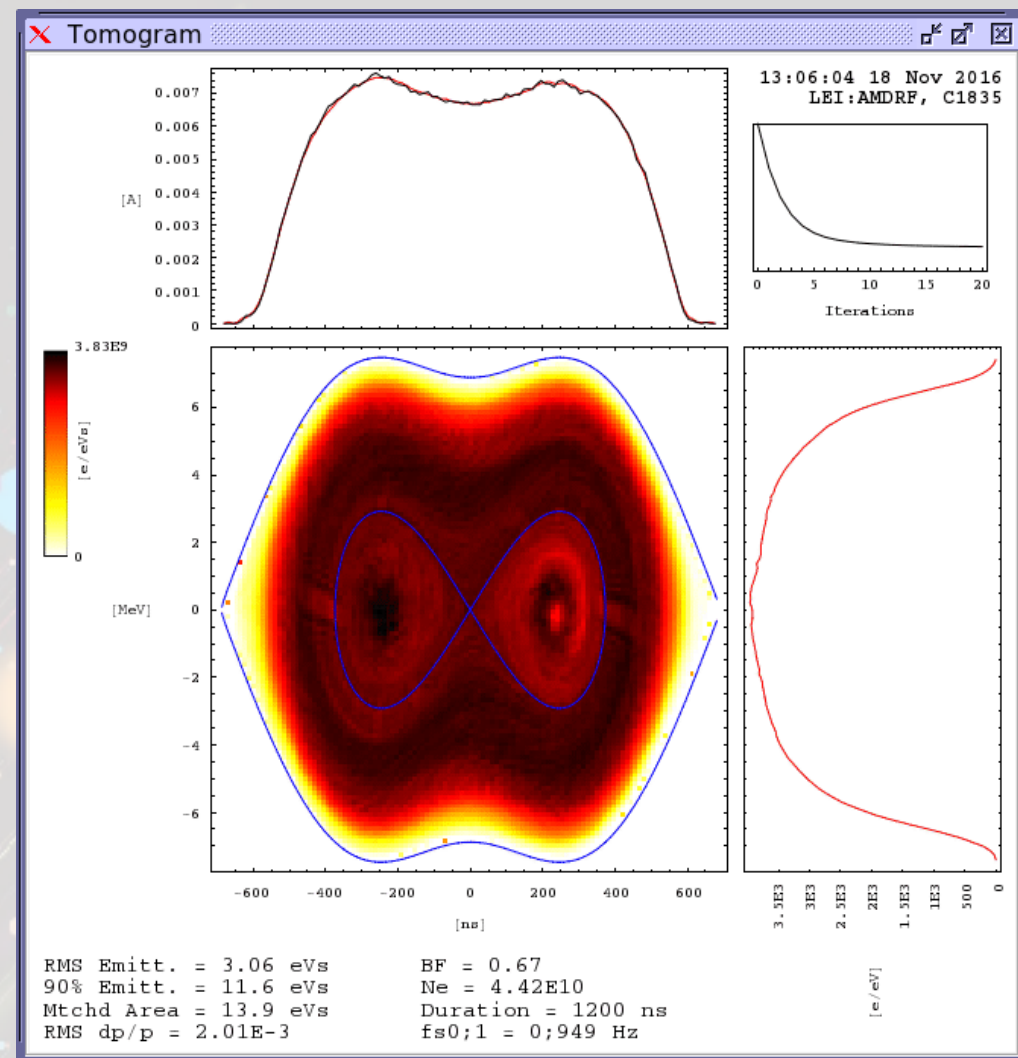


- Bucket is swept through the beam during the capture process
- Redistributes particles longitudinally to increase the captured emittance
- Frequency comparable to f_s – too fast and beam is not affected, too slow and beam is captured prematurely
- Amplitude proportional to voltage – maximum bucket offset comparable to final bucket height

Application - LEIR

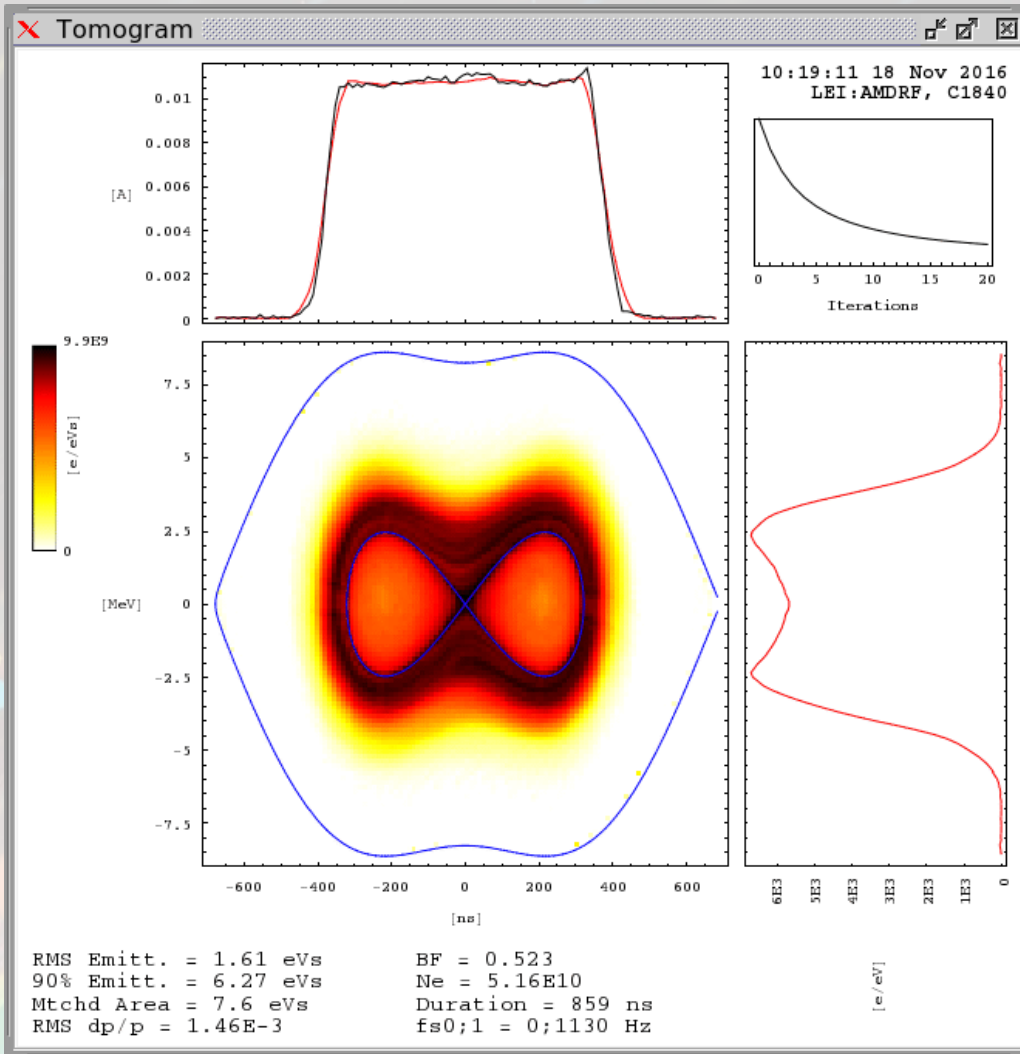


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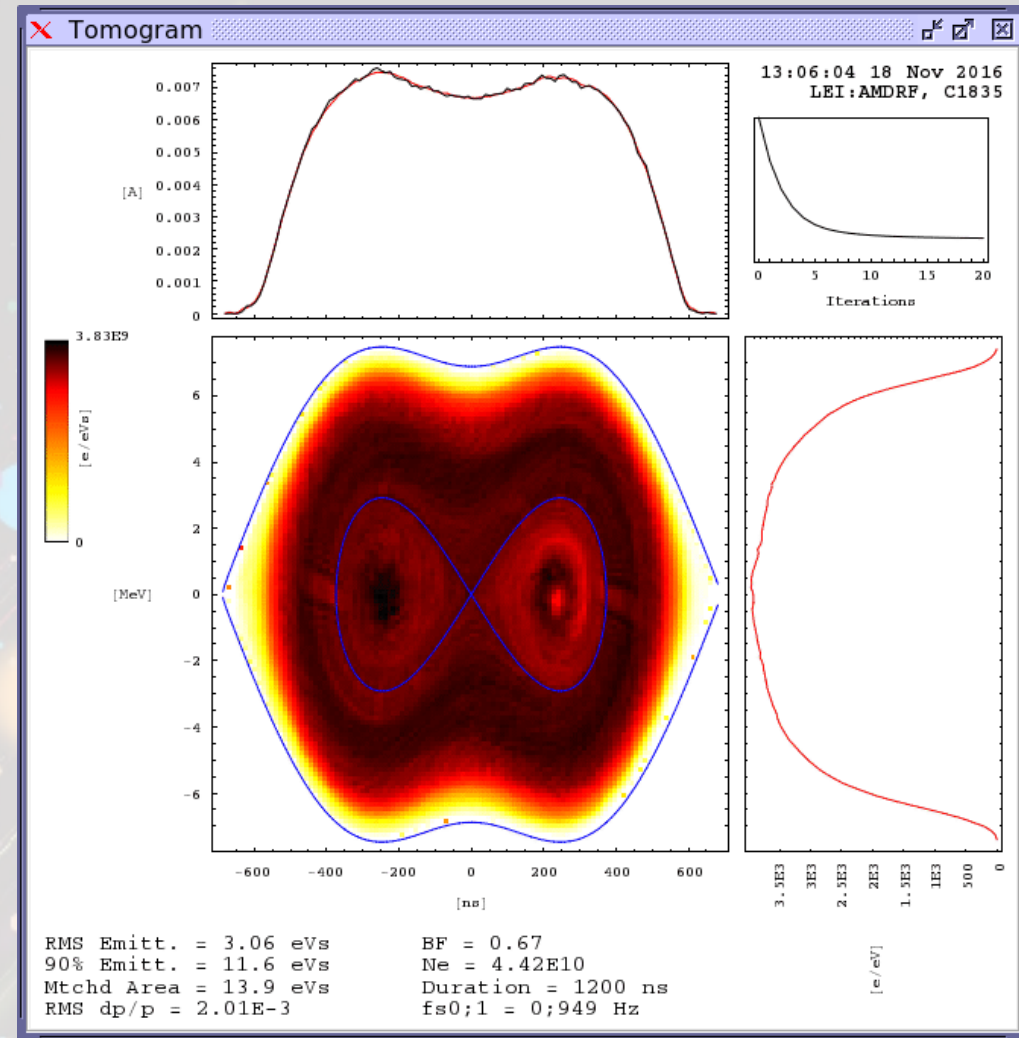


Bunching Factor: 0.67
RMS dp/p: 2.01E-3
Matched Area: 13.9 eVs

Application - LEIR

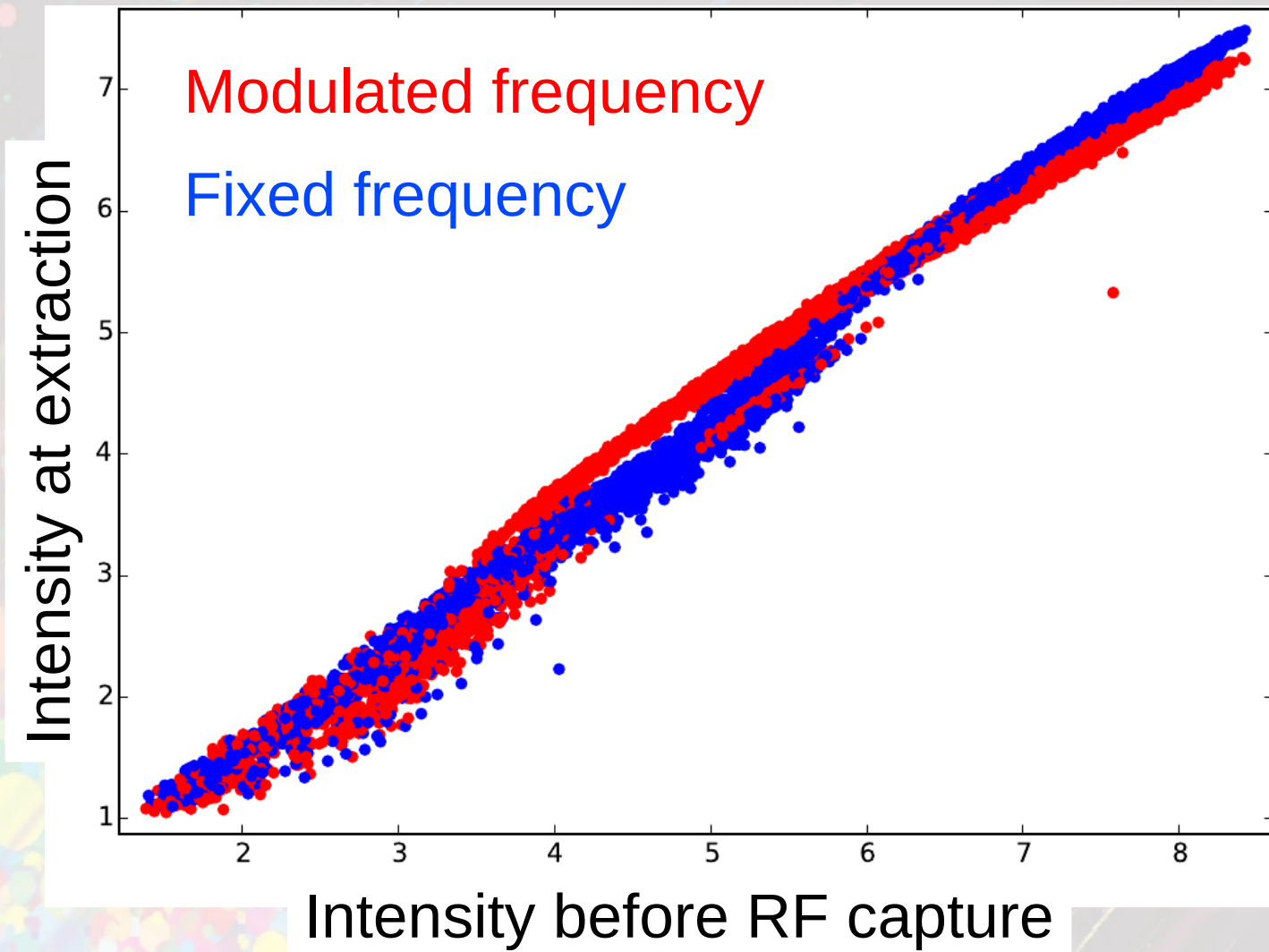


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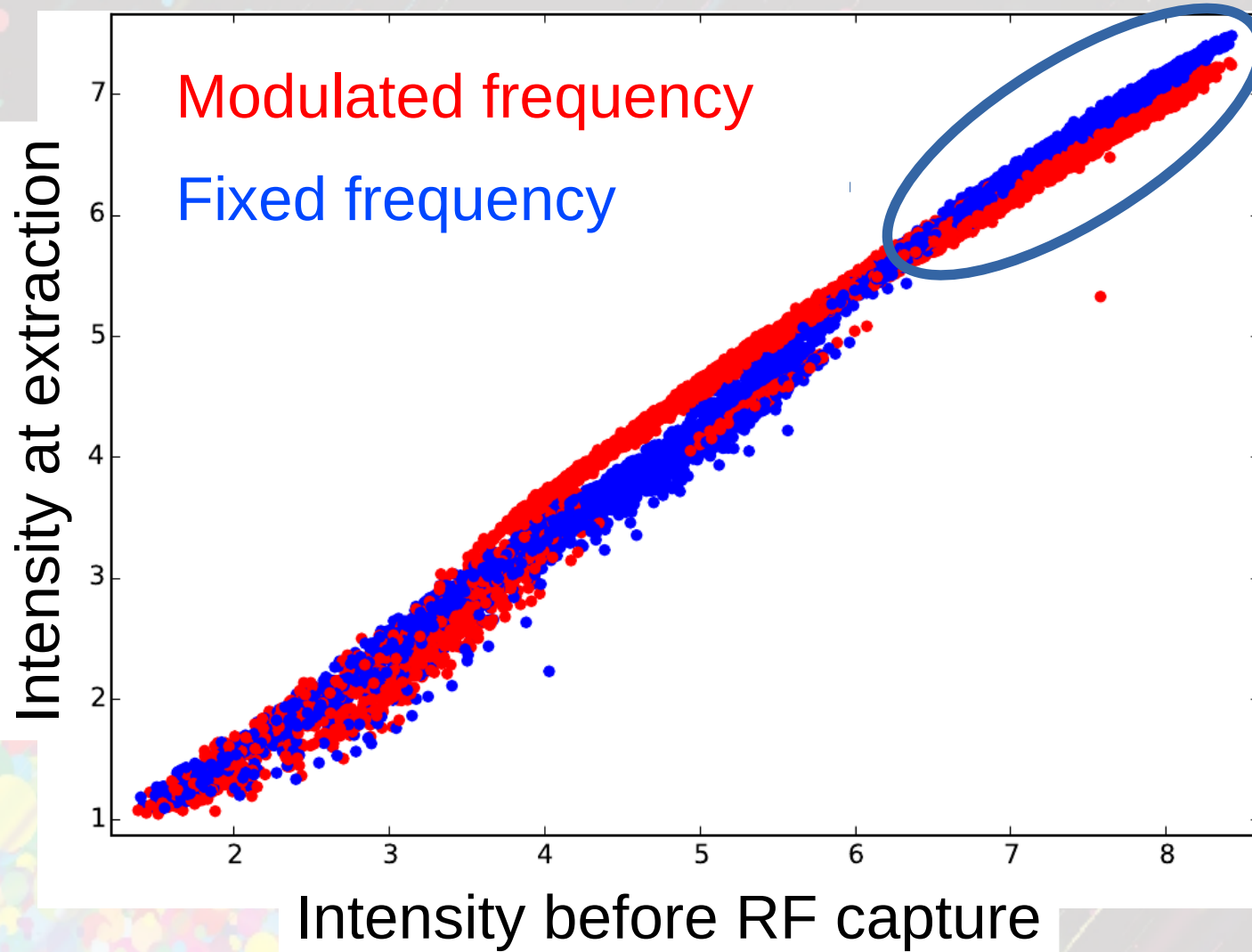


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Application - LEIR



Application - LEIR



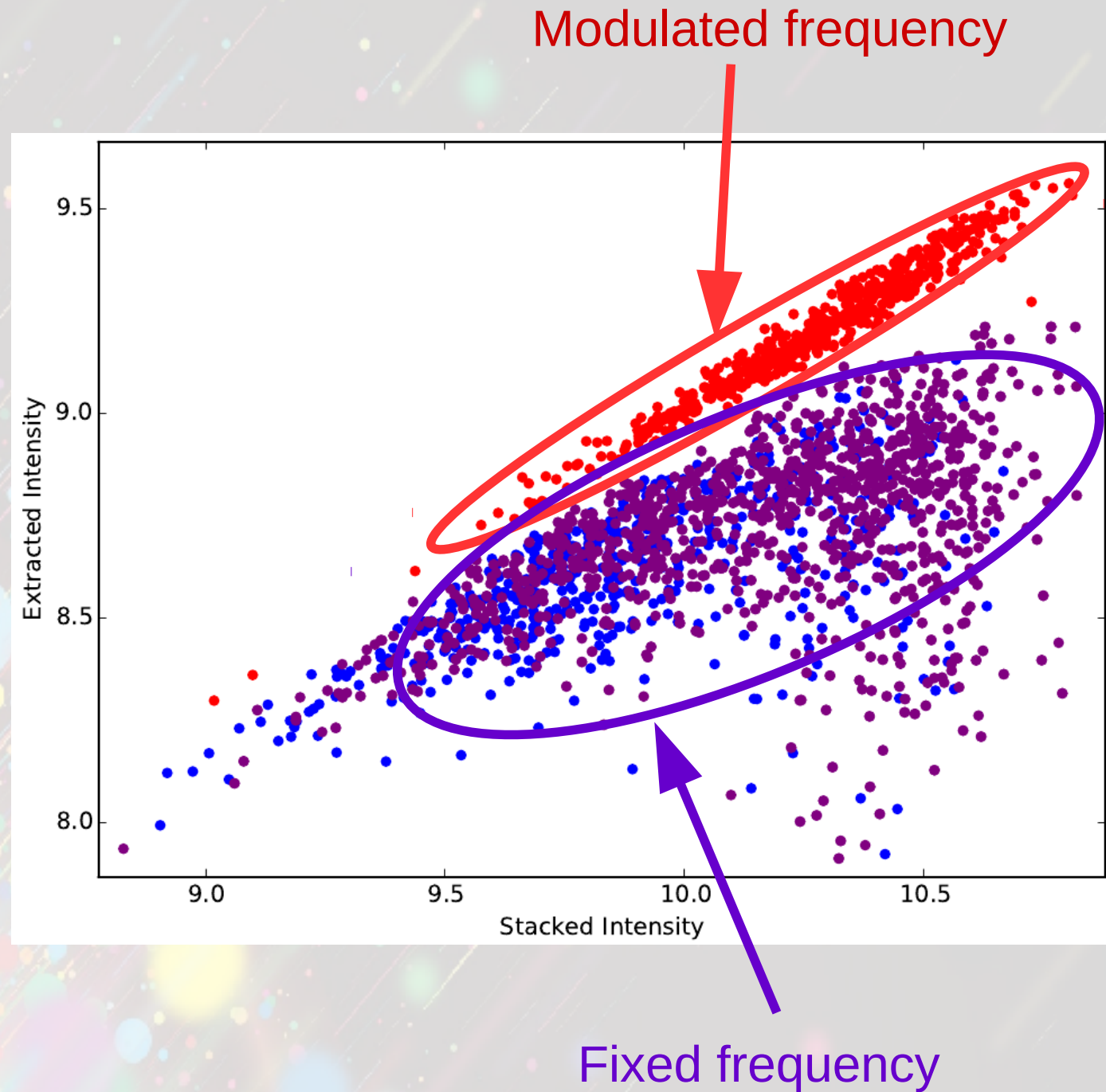
Large emittance worse at high intensity

Most likely explanation
increased density in tune
space on/near destructive
resonance lines

Application - LEIR

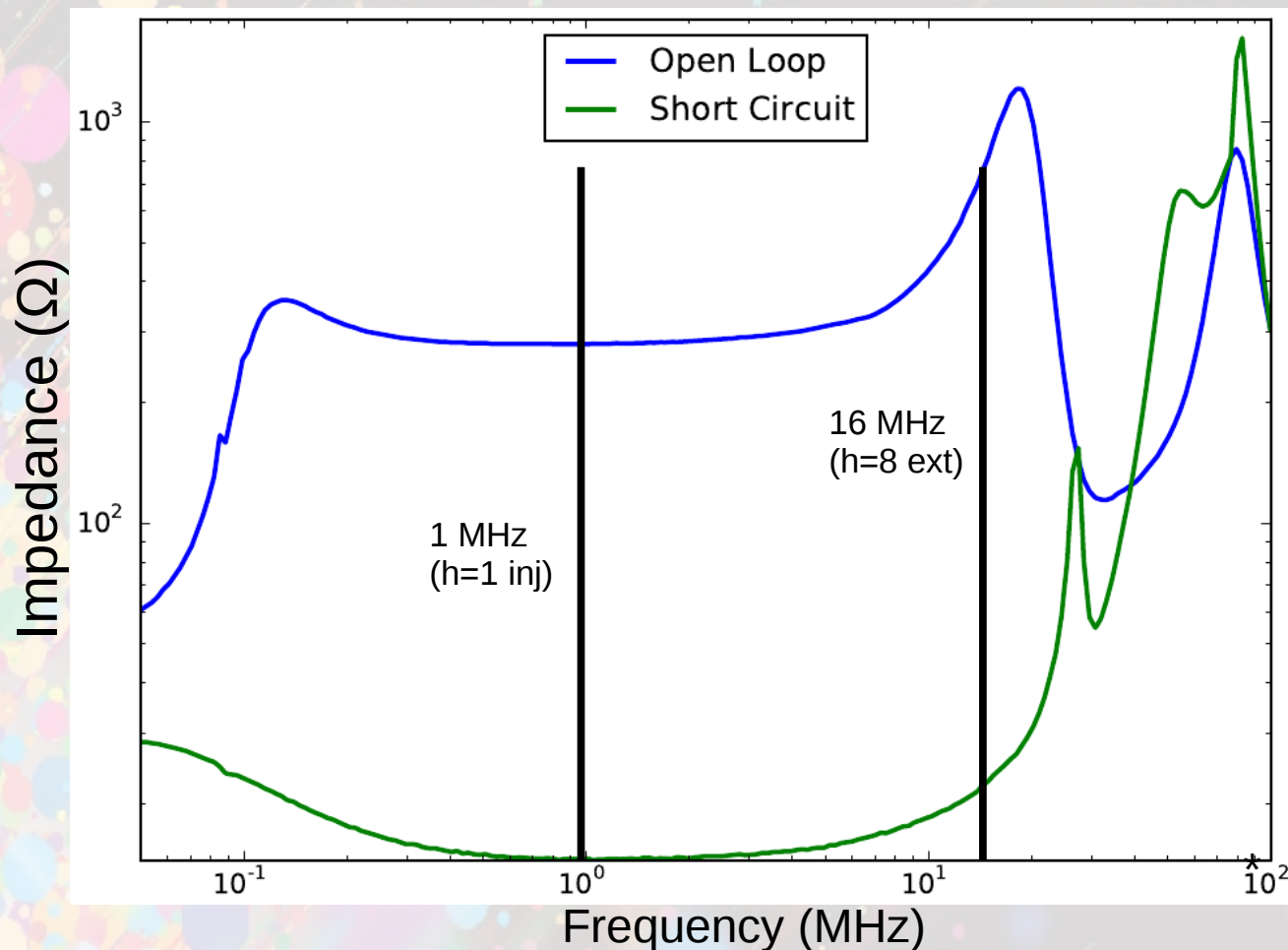
Increase $Q_v \sim 0.02$ at capture

Gain $\sim 10\%$ extracted intensity
for high intensity shots



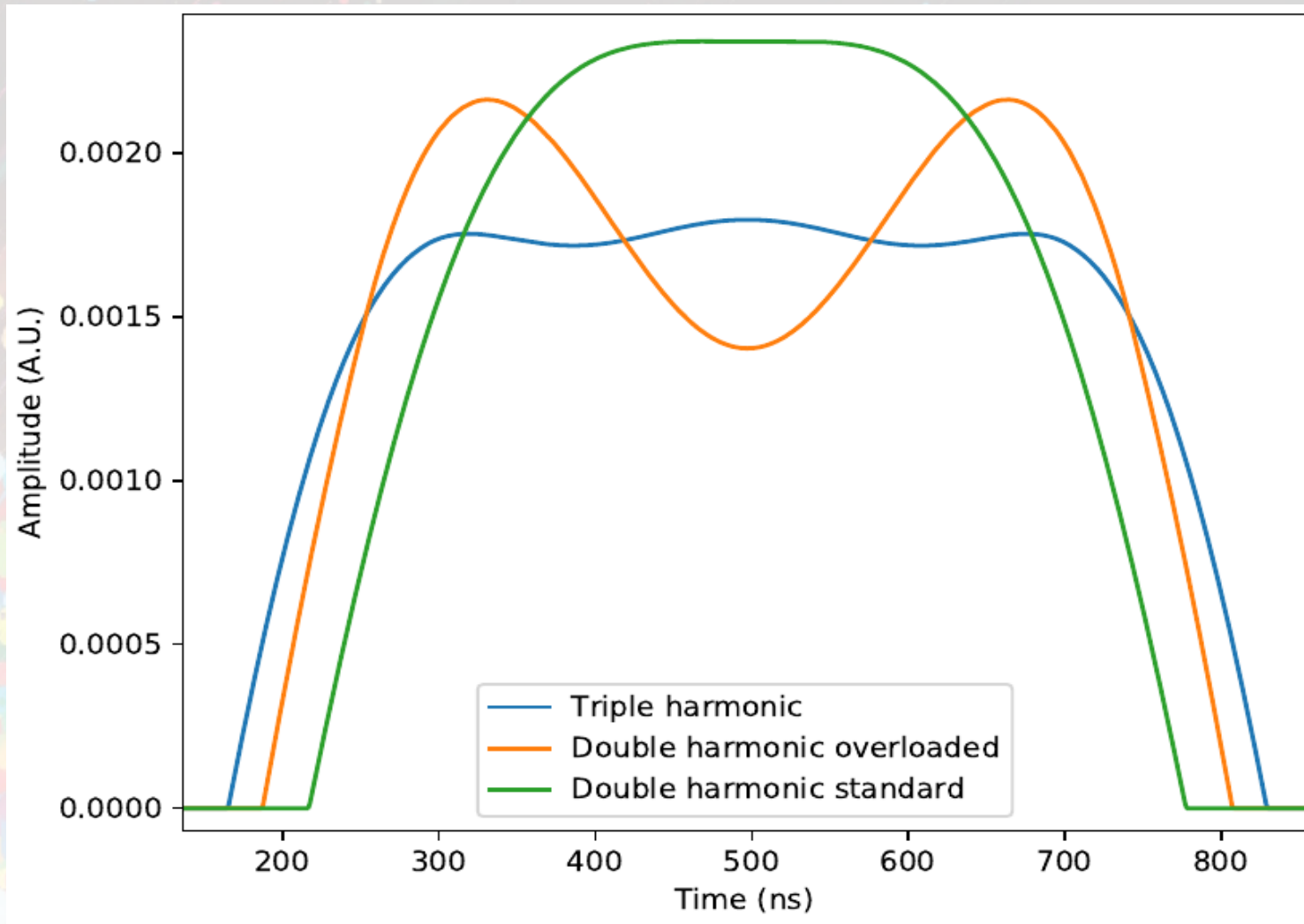
Application - PSB

- PSB future RF broadband Finemet cavities, total voltage is limit, not voltage per harmonic
- More flexibility, tailor injection bucket to required effect
- $V_1 = V_2$ only one possibility



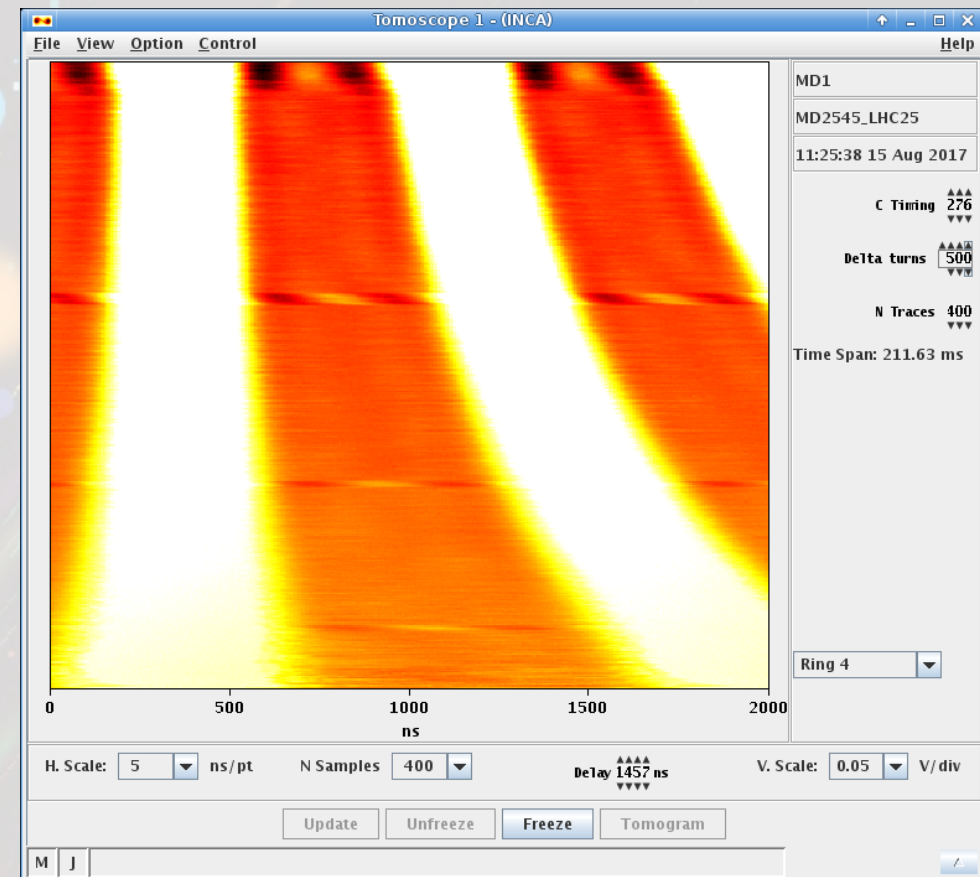
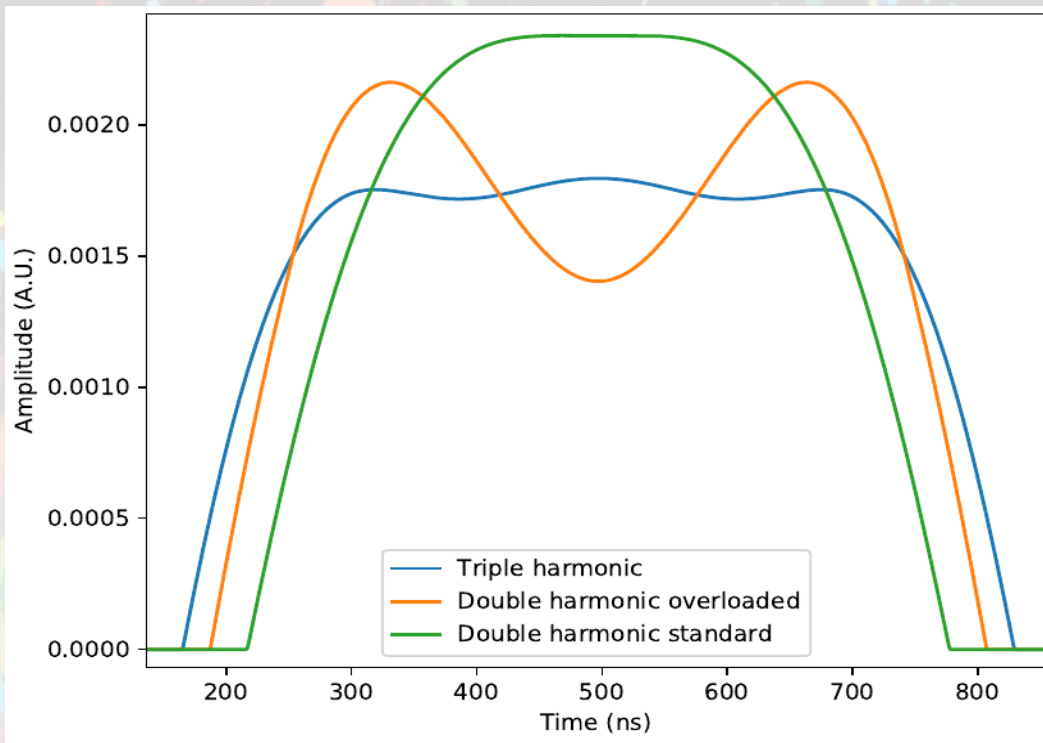
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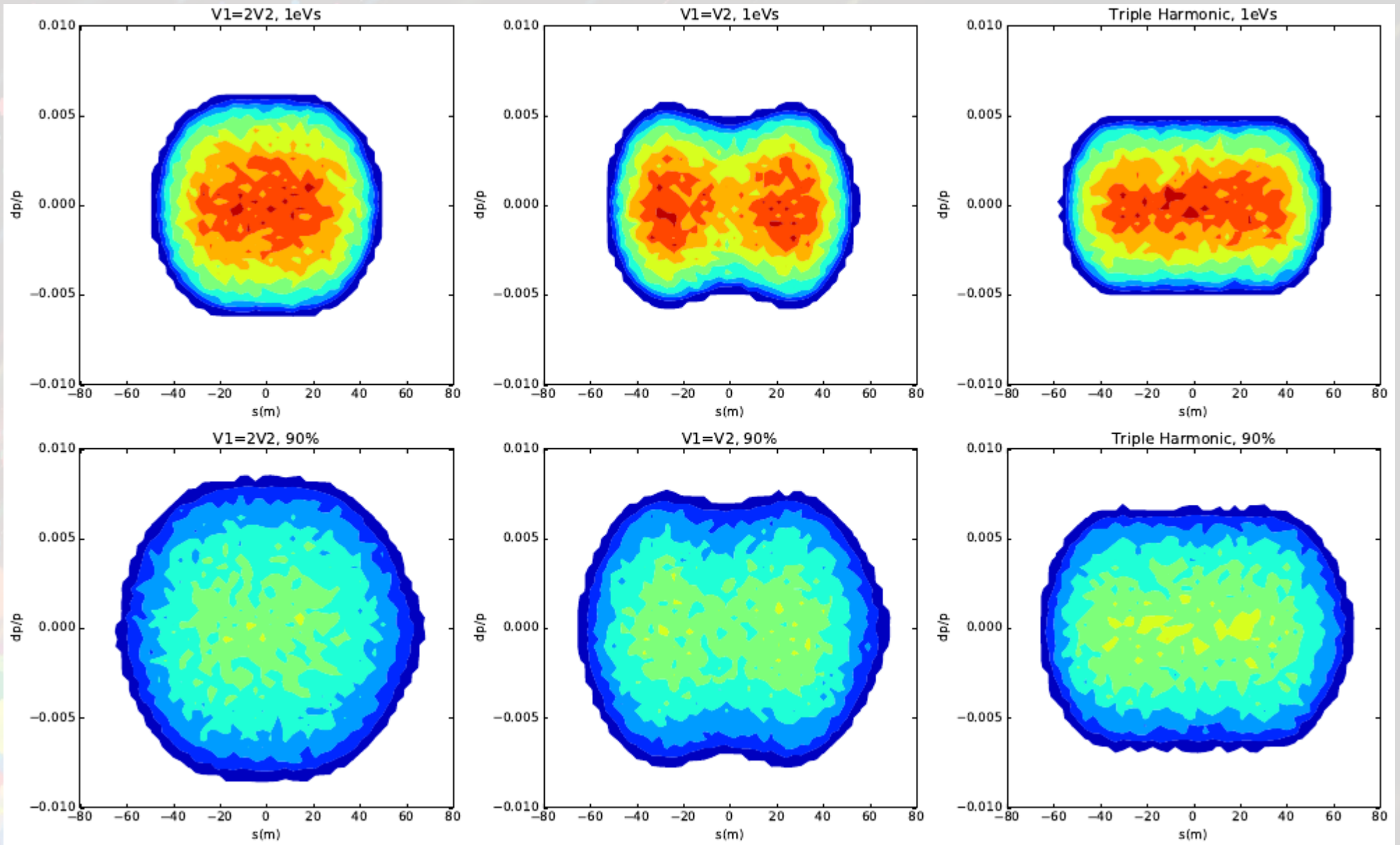


Application - PSB

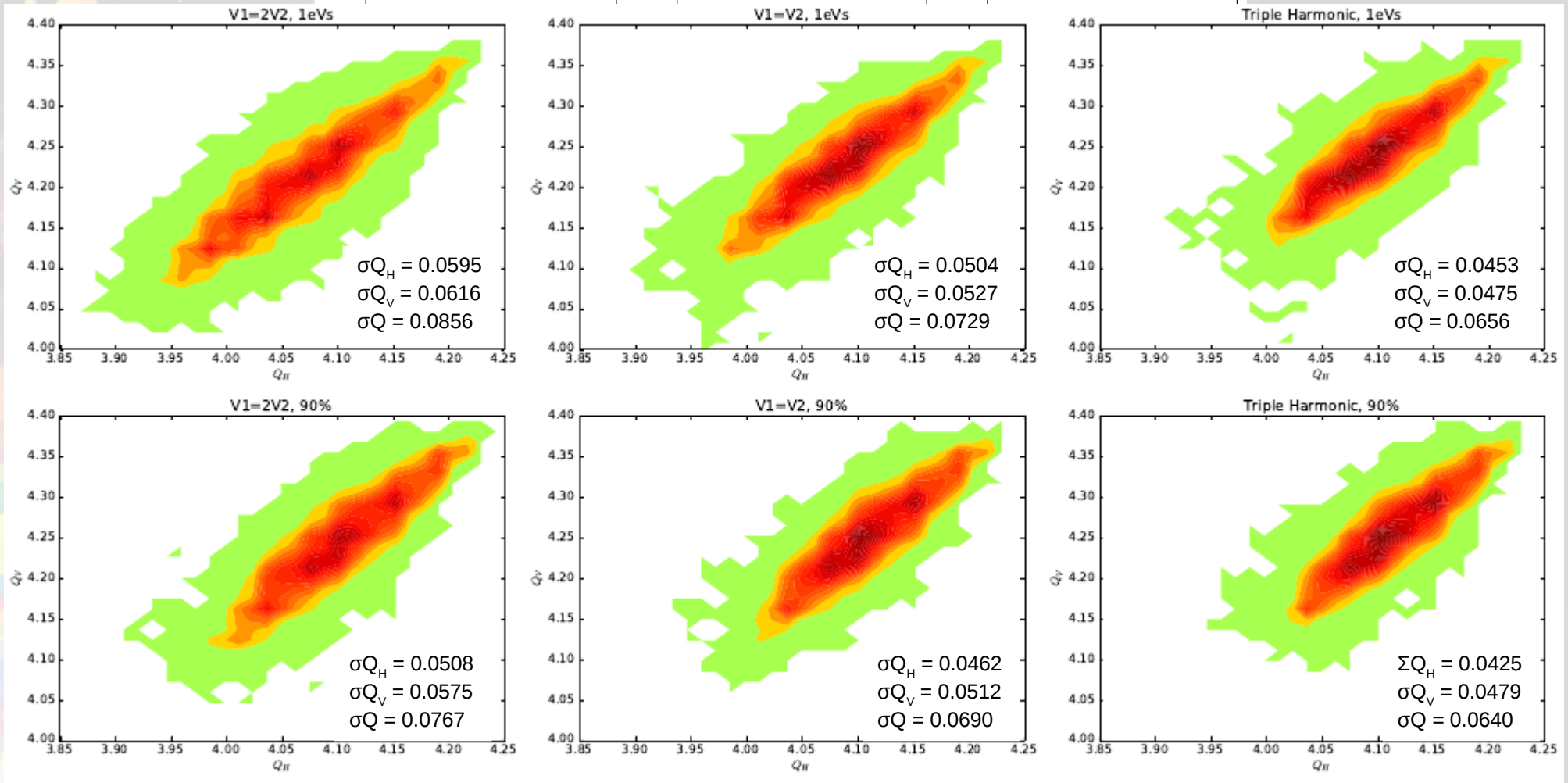
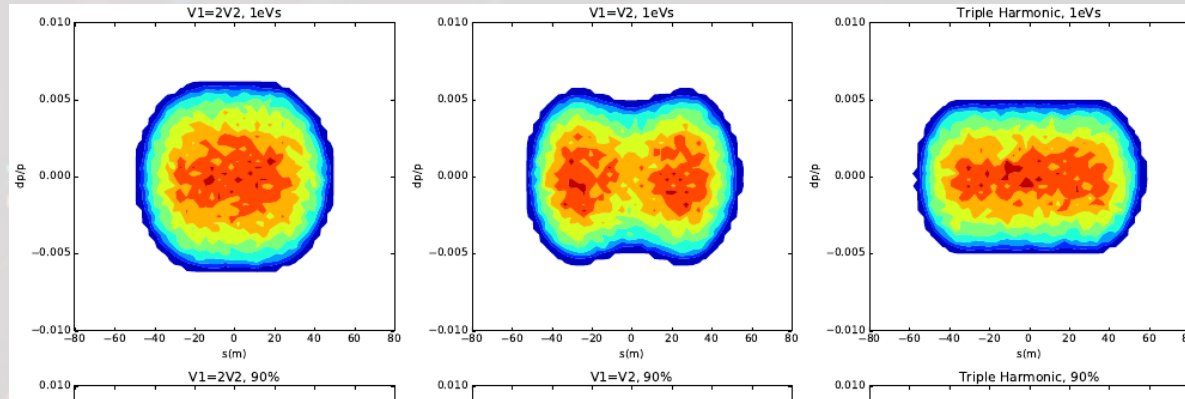
- PSB future RF broadband Finemet cavities, total voltage is limit, not voltage per harmonic
- More flexibility, tailor injection bucket to required effect
- $V_1 = V_2$ only one possibility



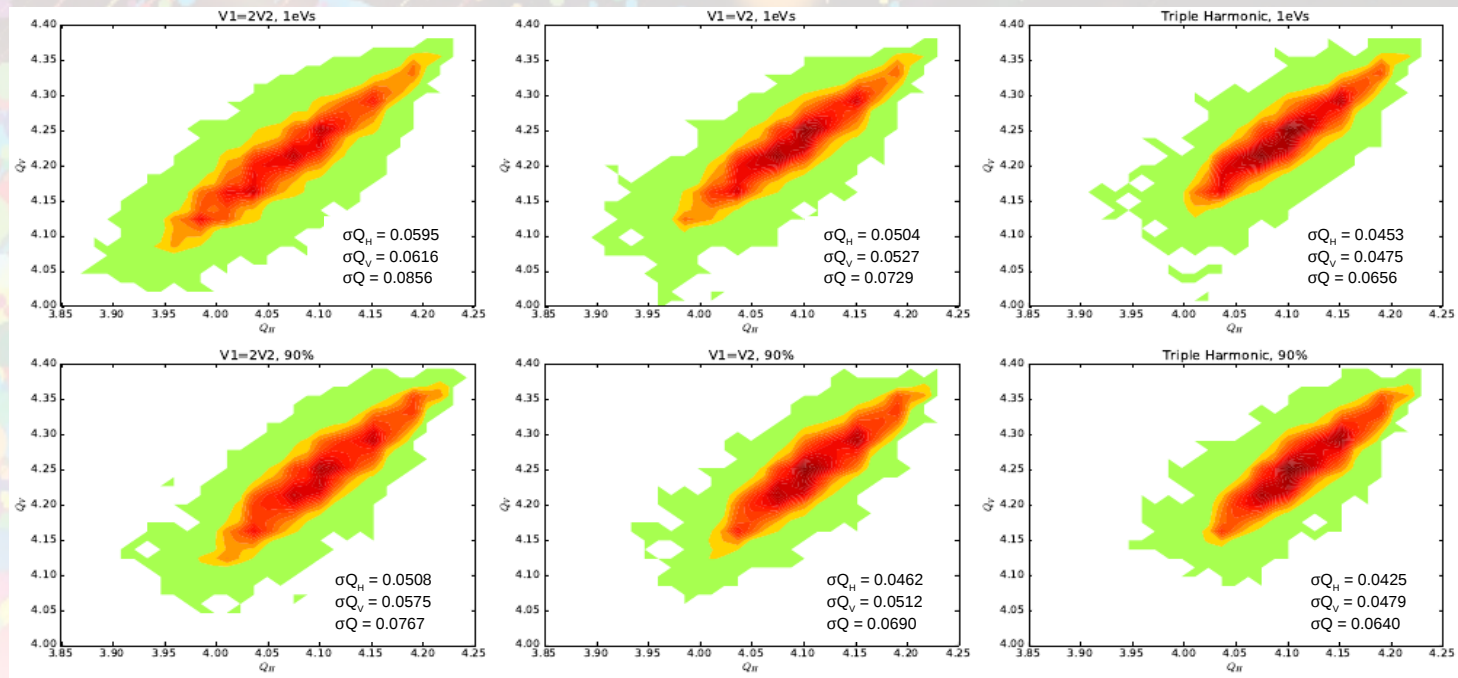
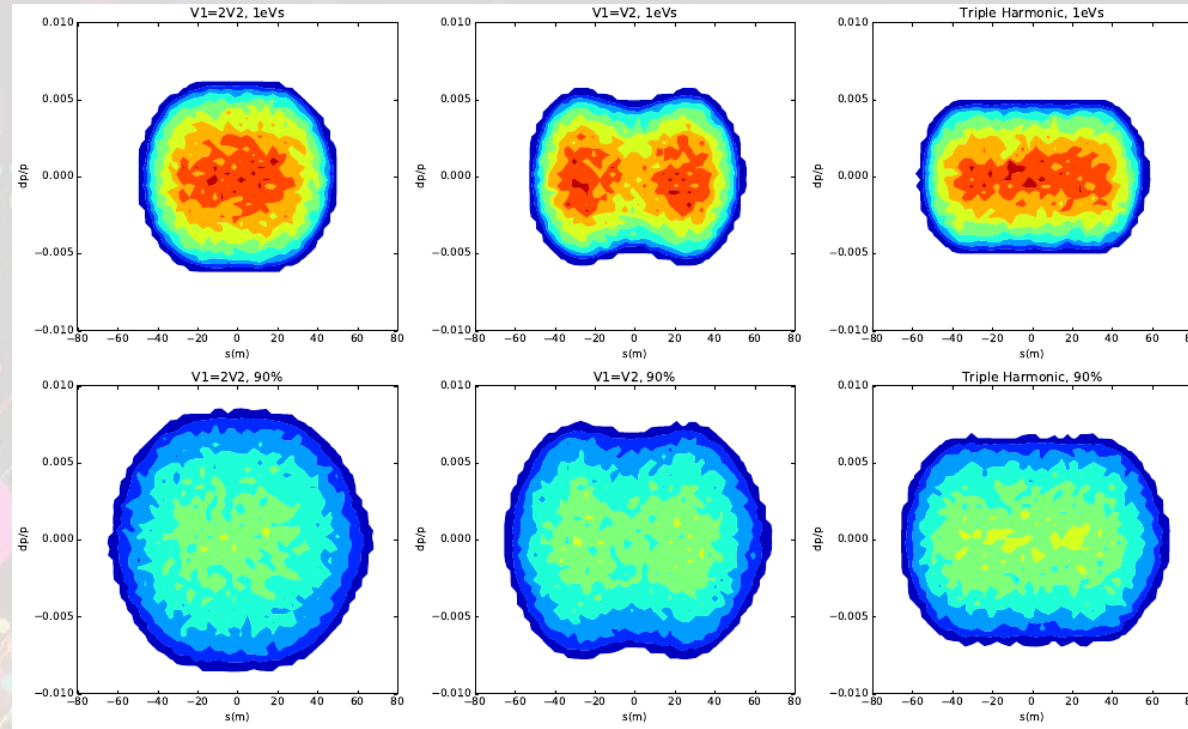
Application - PSB



Application - PSB

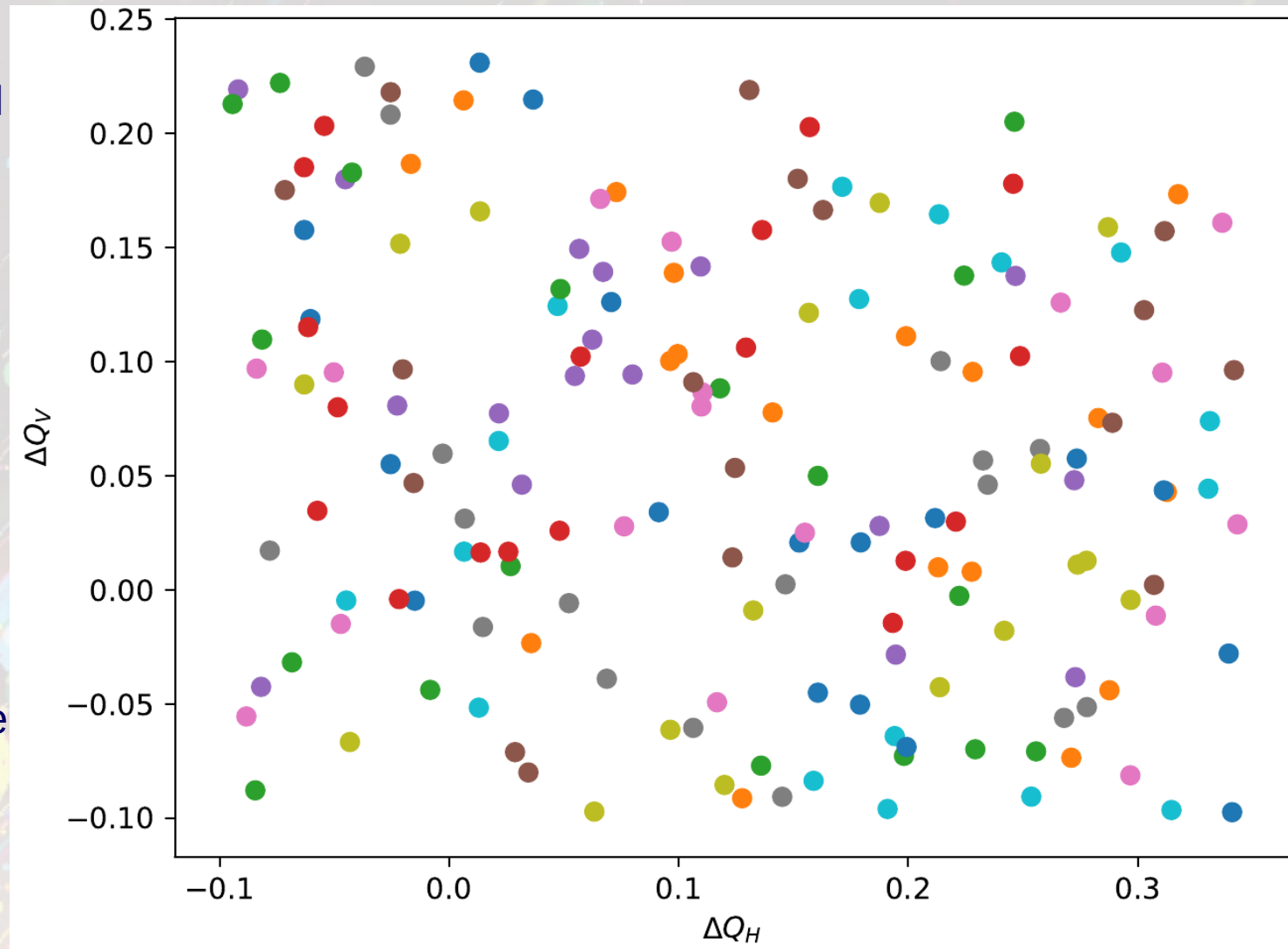


Application - PSB



Application - PSB

- As with LEIR capture ideal working point is likely to change due to footprint change
- Random sampling of around operational working point (ΔQ_H , ΔQ_V) at injection to find ideal working point and indicate relative size of footprint
- If footprint is smaller it should be possible to have a larger area of tune space with the same emittance growth

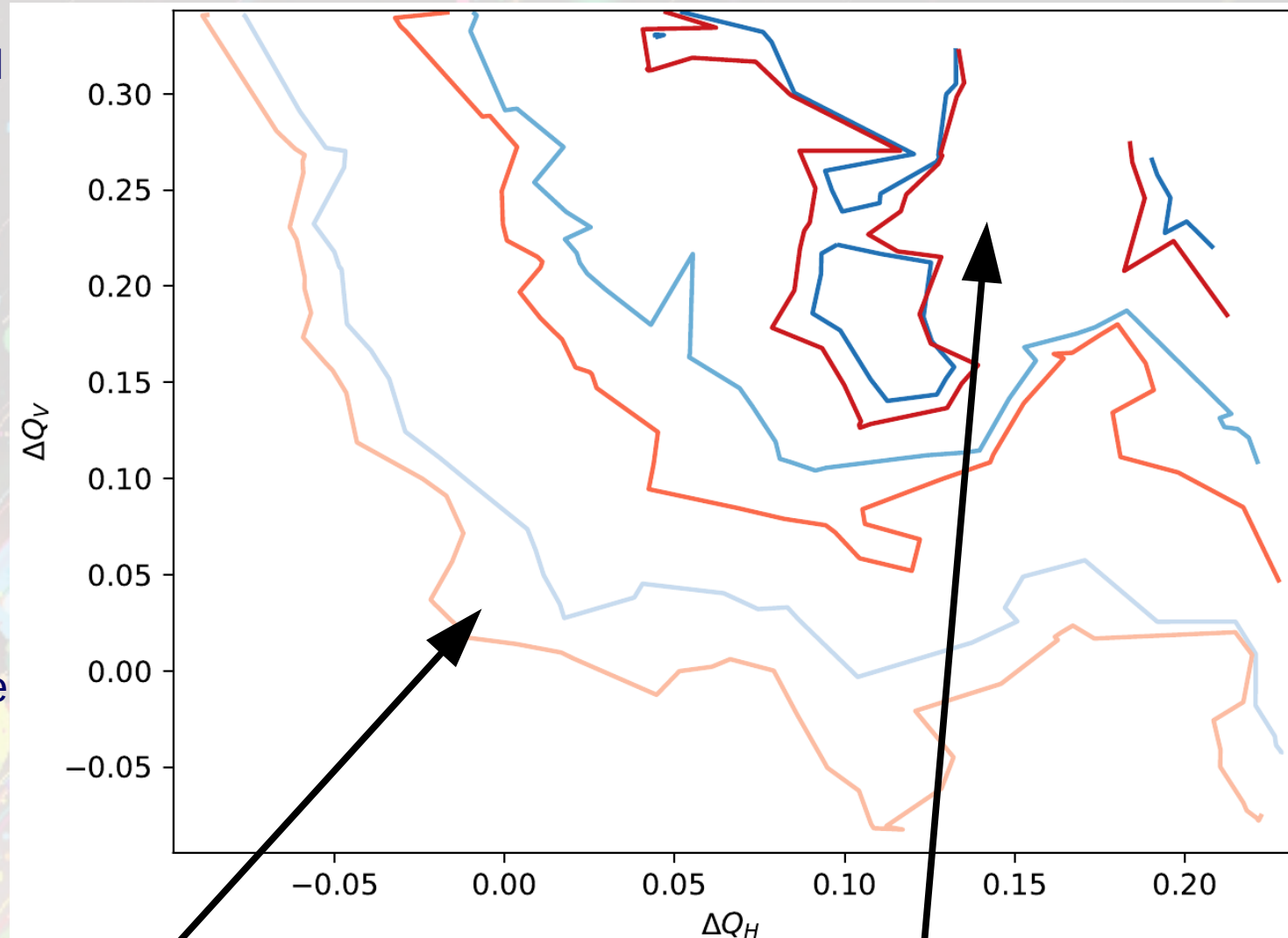


Application - PSB

Triple harmonic

Double harmonic

- As with LEIR capture ideal working point is likely to change due to footprint change
- Random sampling of around operational working point (ΔQ_H , ΔQ_V) at injection to find ideal working point and indicate relative size of footprint
- If footprint is smaller it should be possible to have a larger area of tune space with the same emittance growth



High emittance (large blow-up)

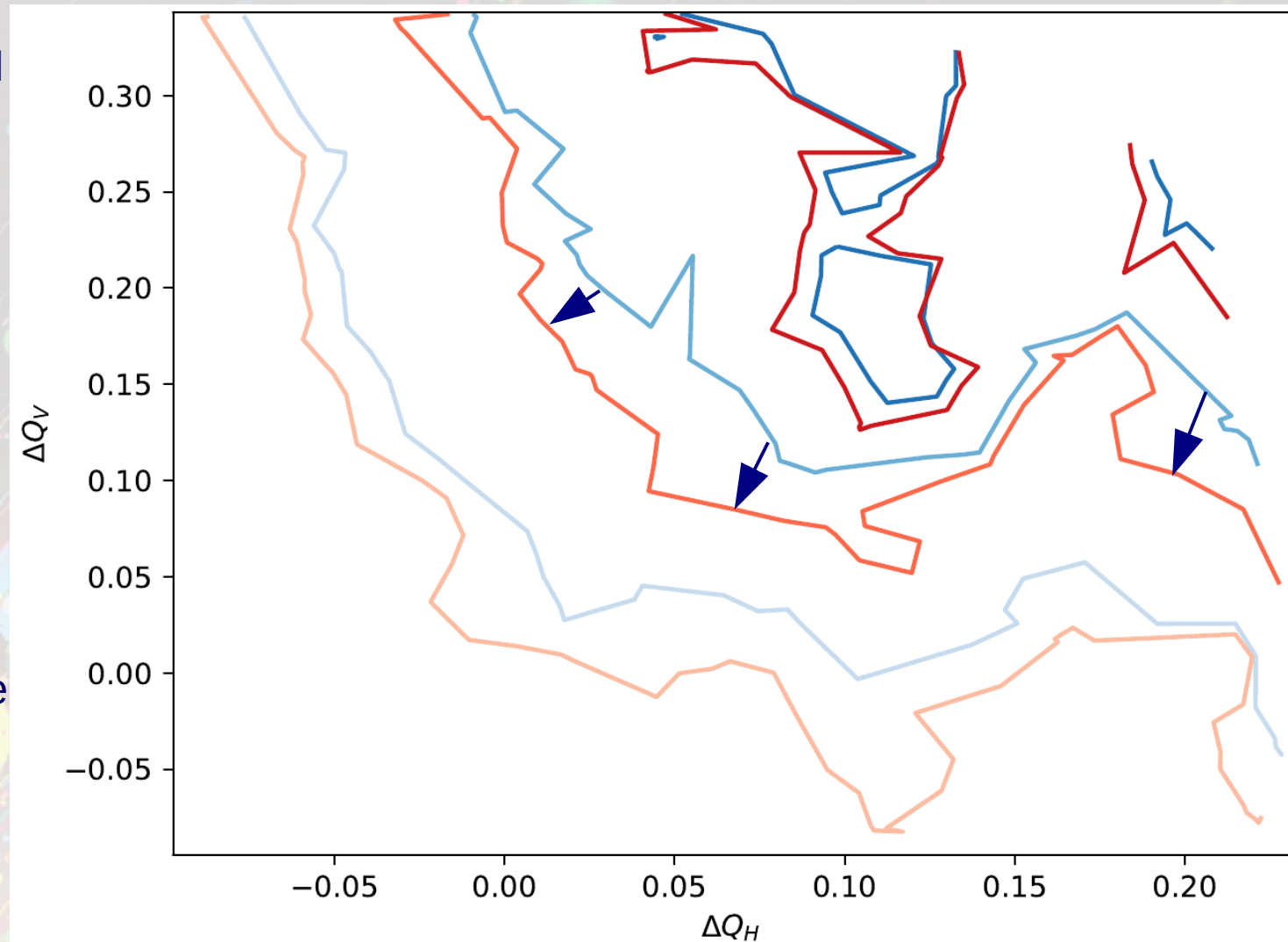
Low emittance (small blow-up)

Application - PSB

Triple harmonic

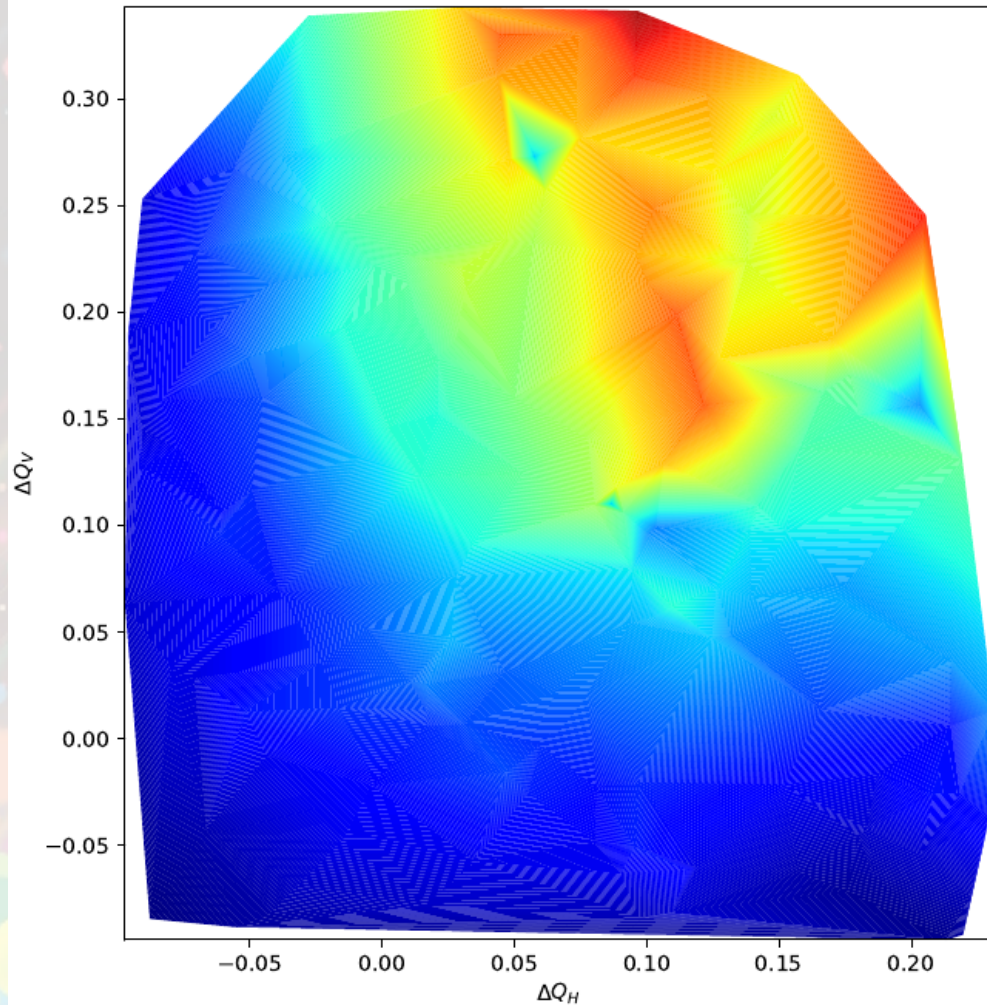
Double harmonic

- As with LEIR capture ideal working point is likely to change due to footprint change
- Random sampling of around operational working point (ΔQ_H , ΔQ_V) at injection to find ideal working point and indicate relative size of footprint
- If footprint is smaller it should be possible to have a larger area of tune space with the same emittance growth

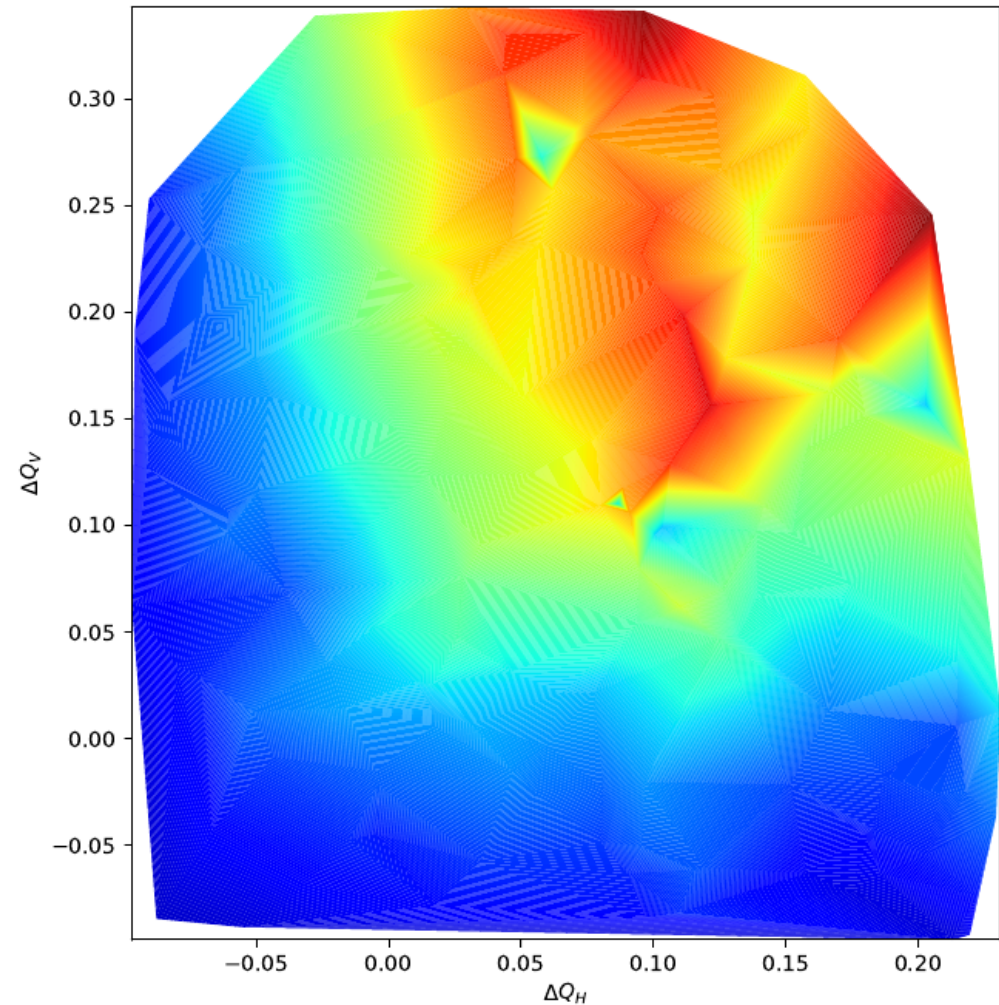


Application - PSB

Double harmonic

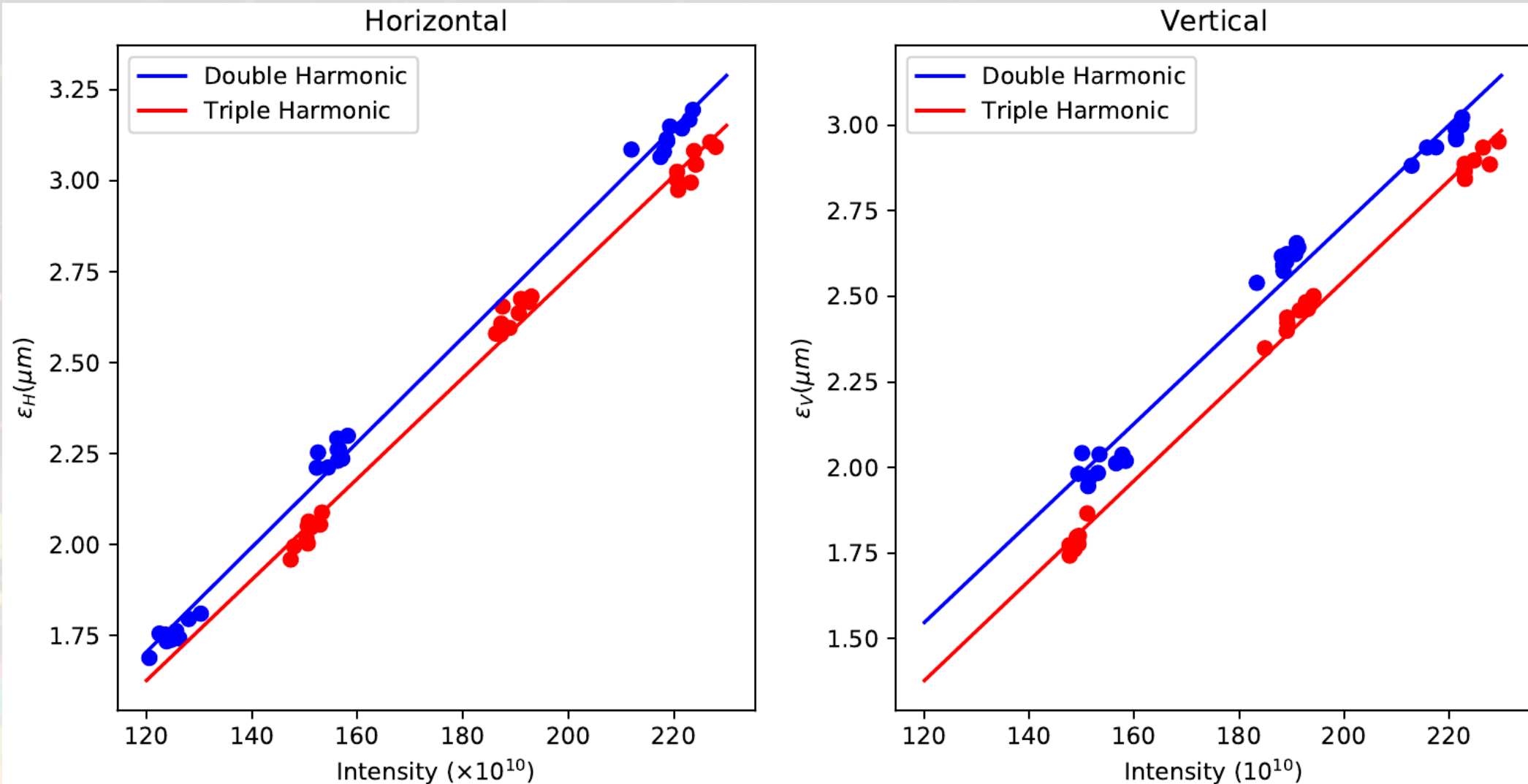


Triple harmonic



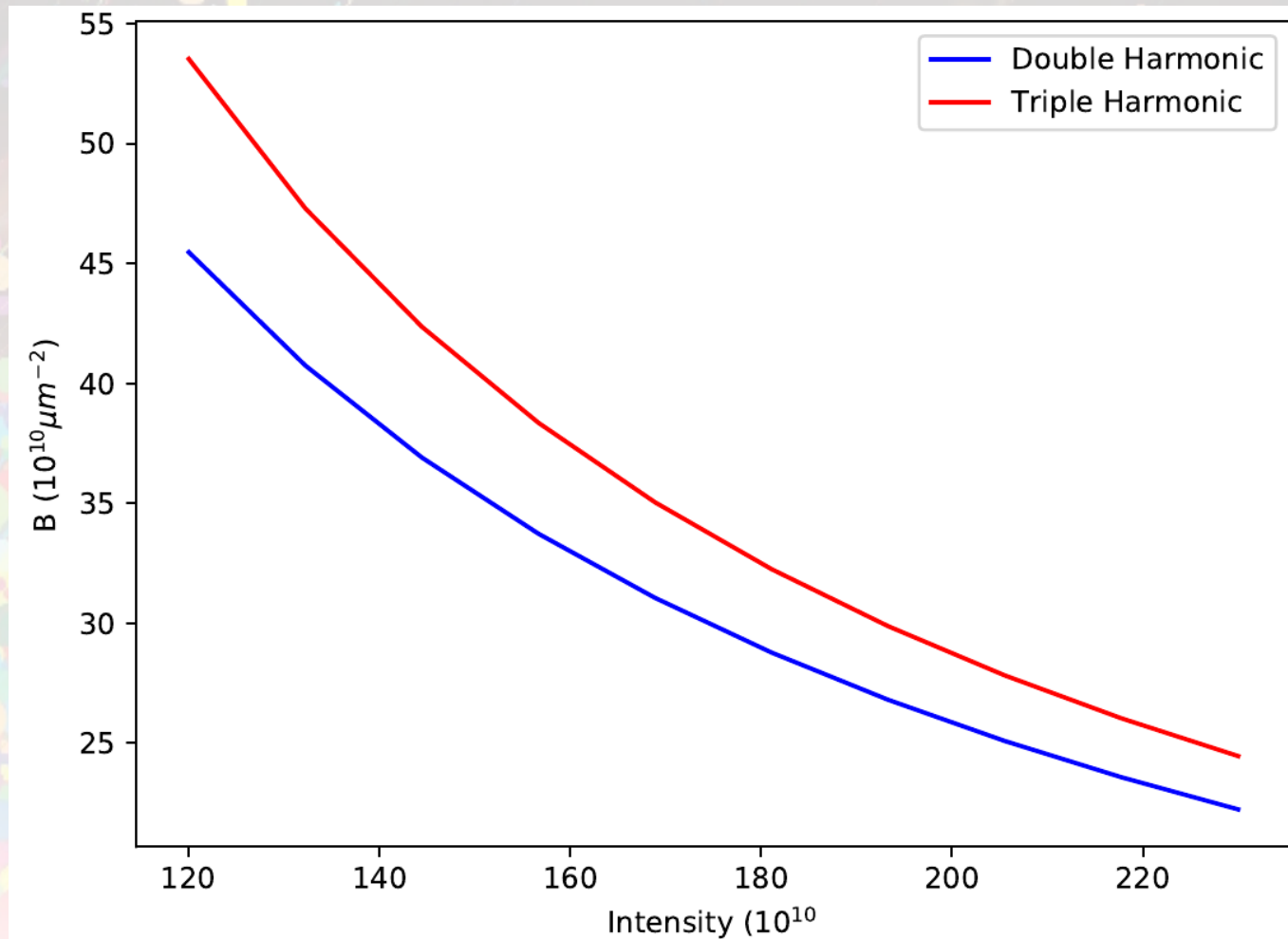
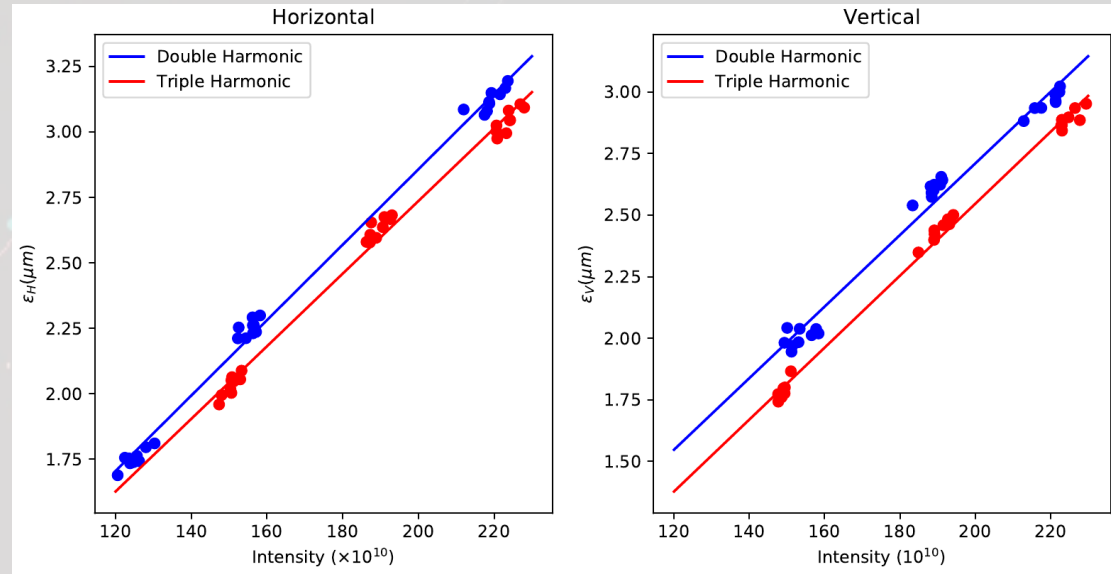
- Compare brightness across full (ΔQ_H , ΔQ_V) range
- Maximum brightness and “good” area appear larger for triple harmonic case

Application - PSB

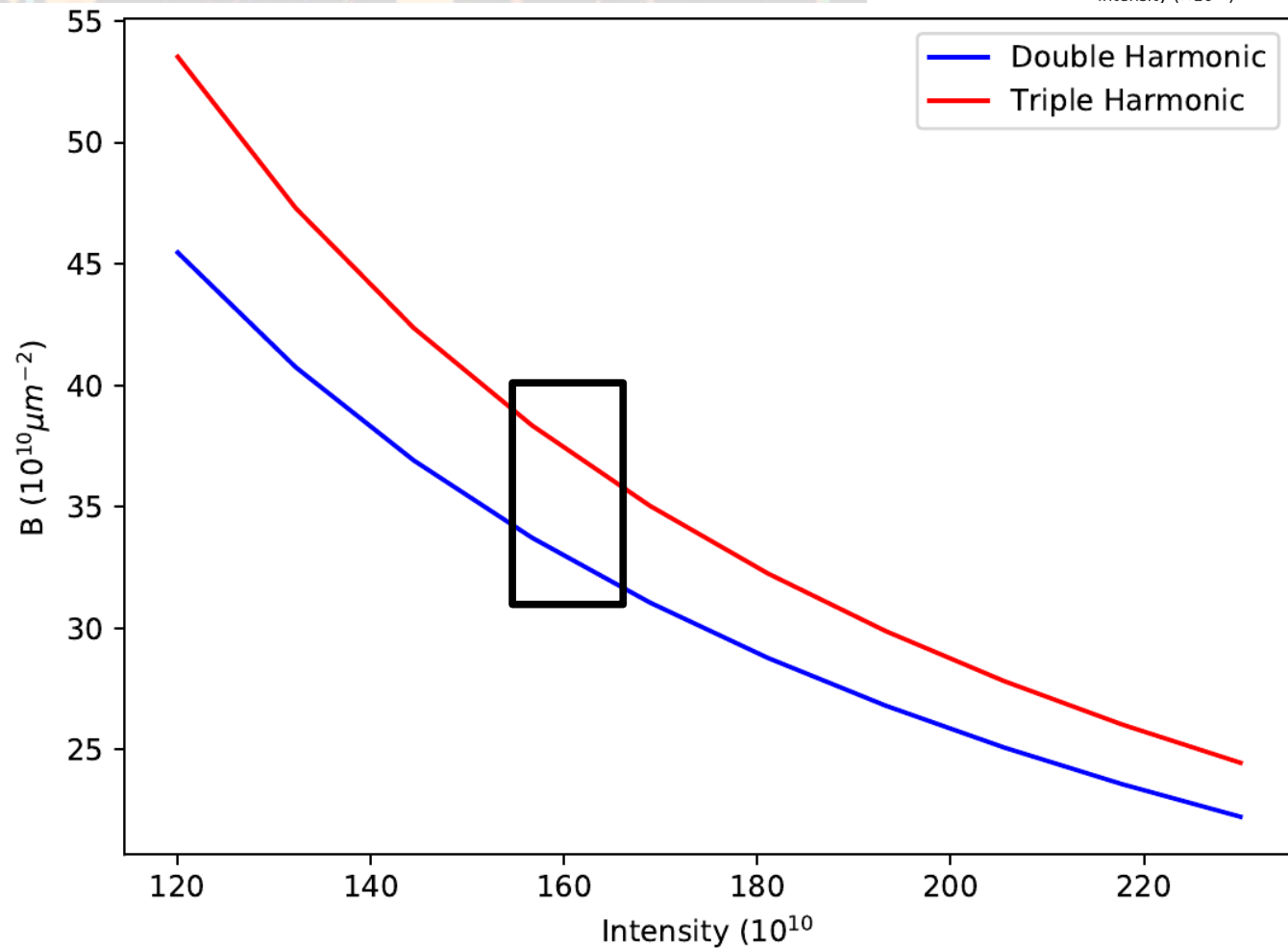
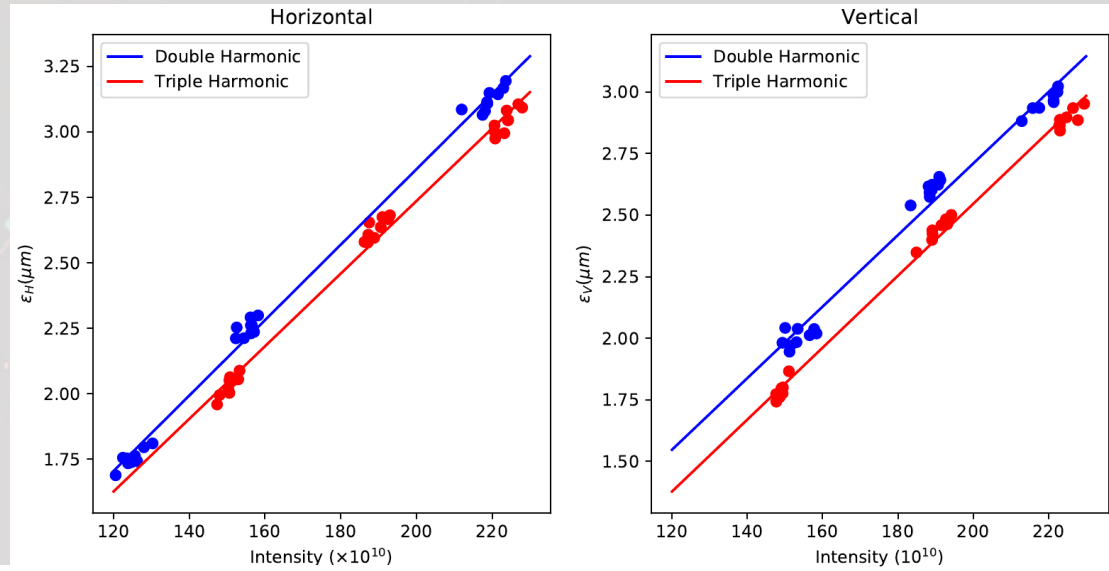


- Choose best working point for both double and triple harmonic cases and measure brightness curve
- ϵ_H reduced by $\sim 0.1\mu\text{m}$, ϵ_V reduced by $\sim 0.2\mu\text{m}$

Application - PSB



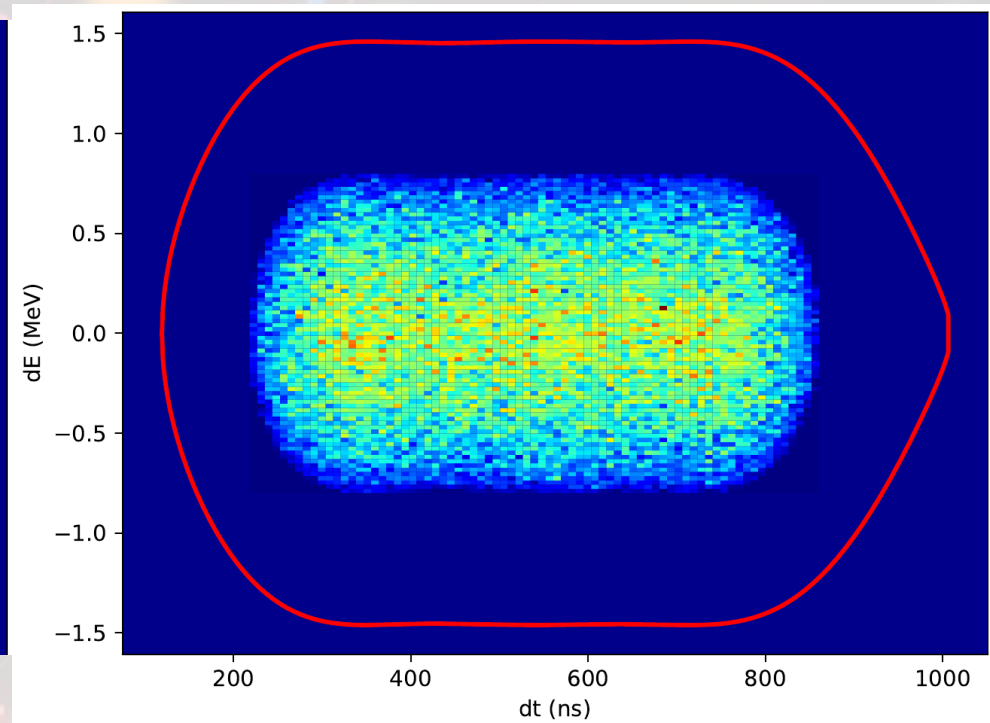
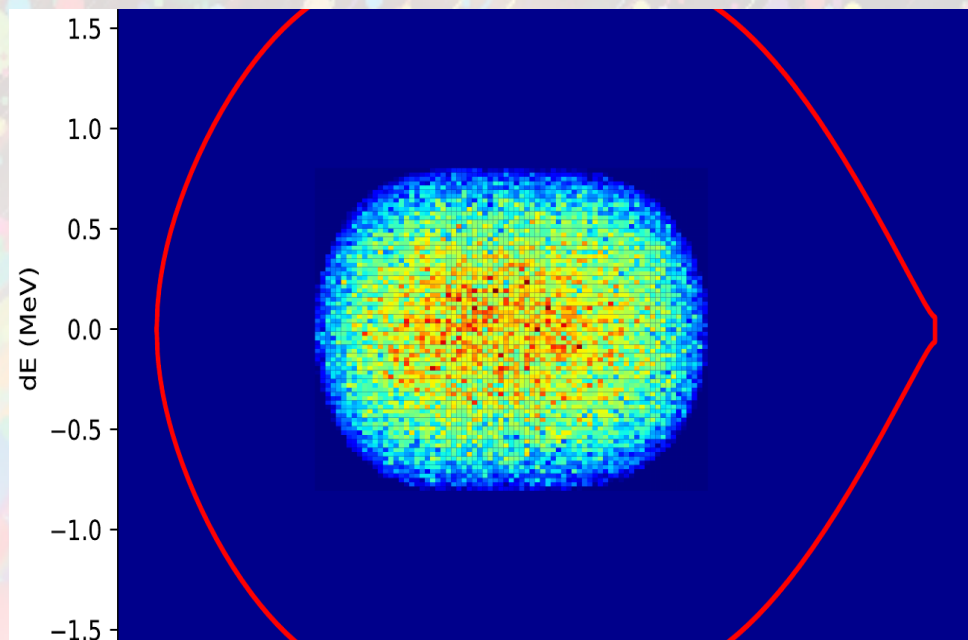
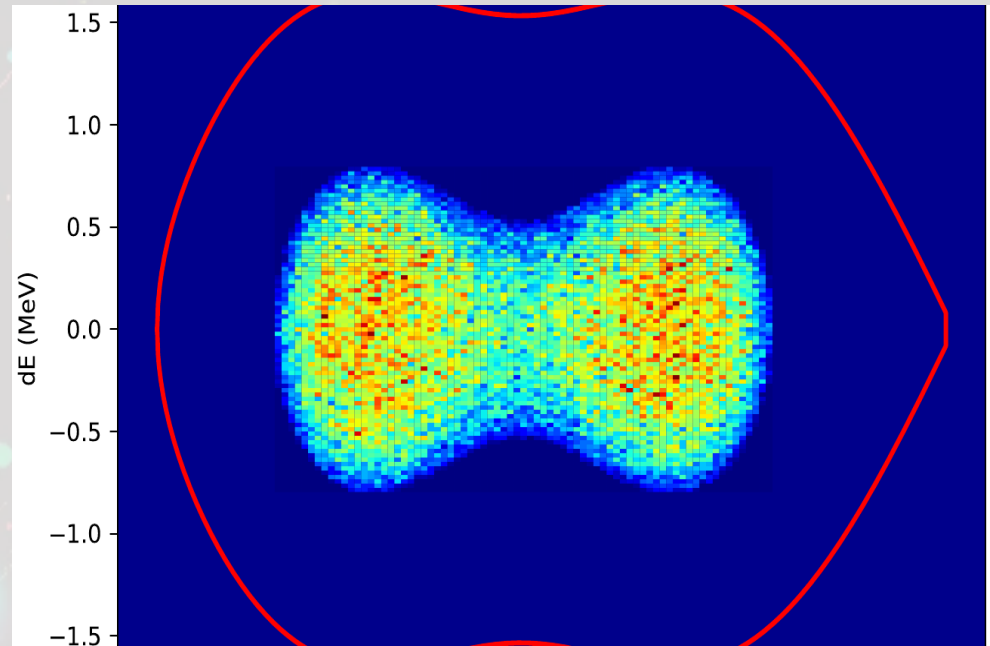
Application - PSB



One version of LHC filling intensity (160E10) brightness is increased by approximately 10% for the same total voltage

Application - PSB

- Additional gain may be possible after LS2 due to longitudinal painting
- Longitudinal painting with ± 0.8 MeV

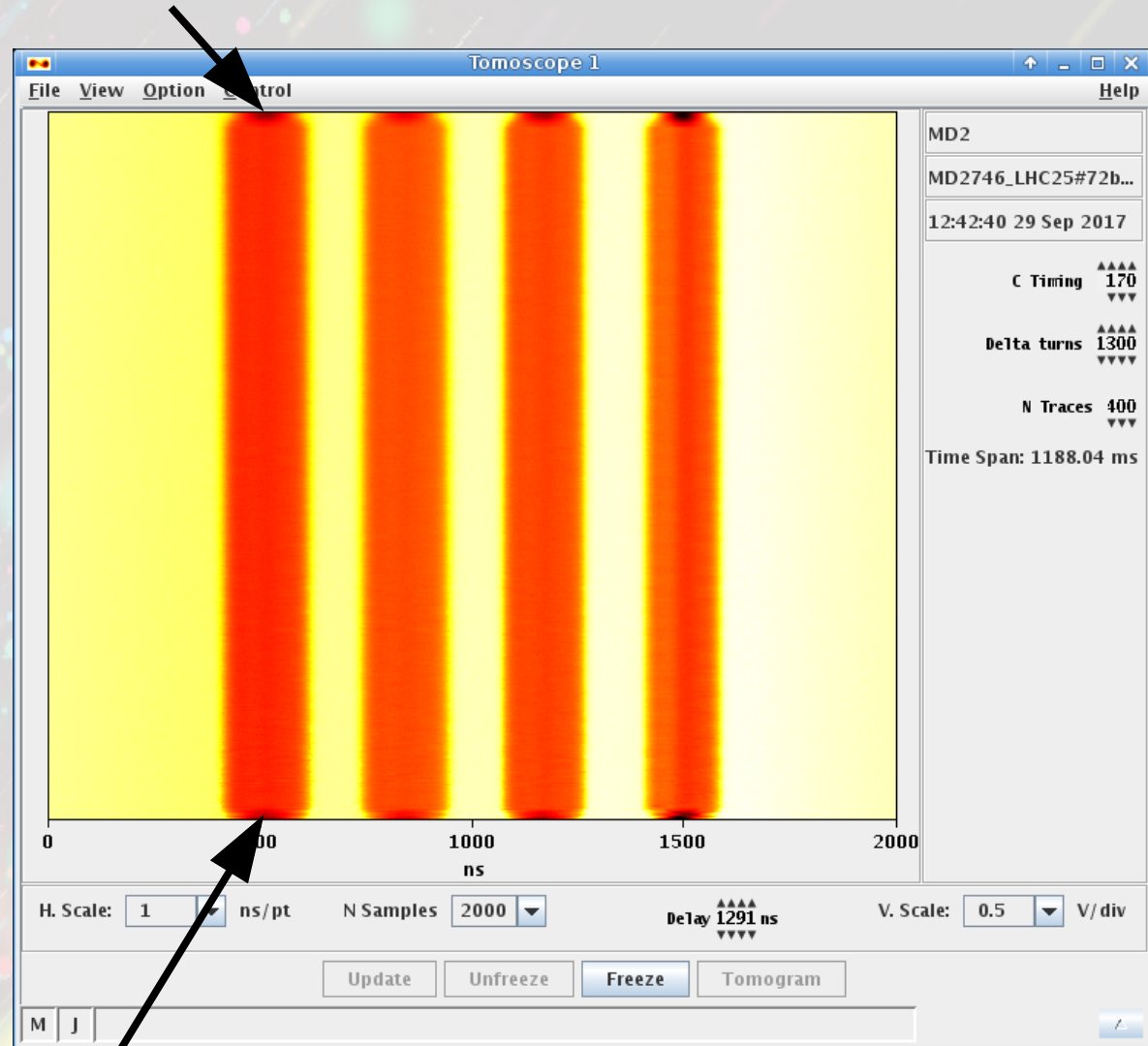


Future work

PS

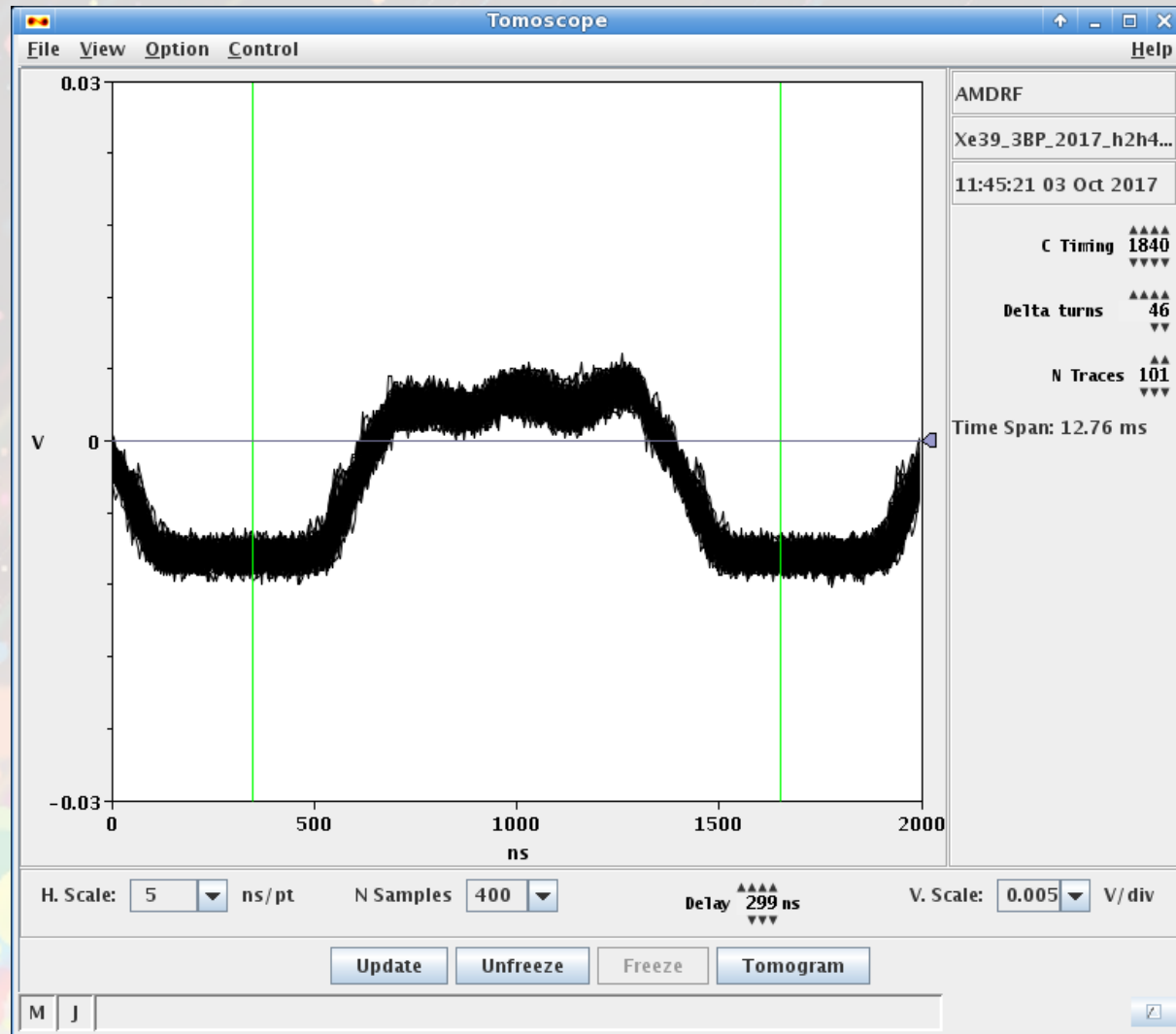
- LHC filling cycle has 2 injections
- 1.2s flat bottom for first injection waiting for second
- Ability to put beam into three harmonic bucket demonstrated for first time
- Cannot inject in multi-harmonic bucket, need to raise voltage over some ms, might be too late to prevent blow-up

Single harmonic for injection of second batch



Single harmonic for injection of first batch

Future work



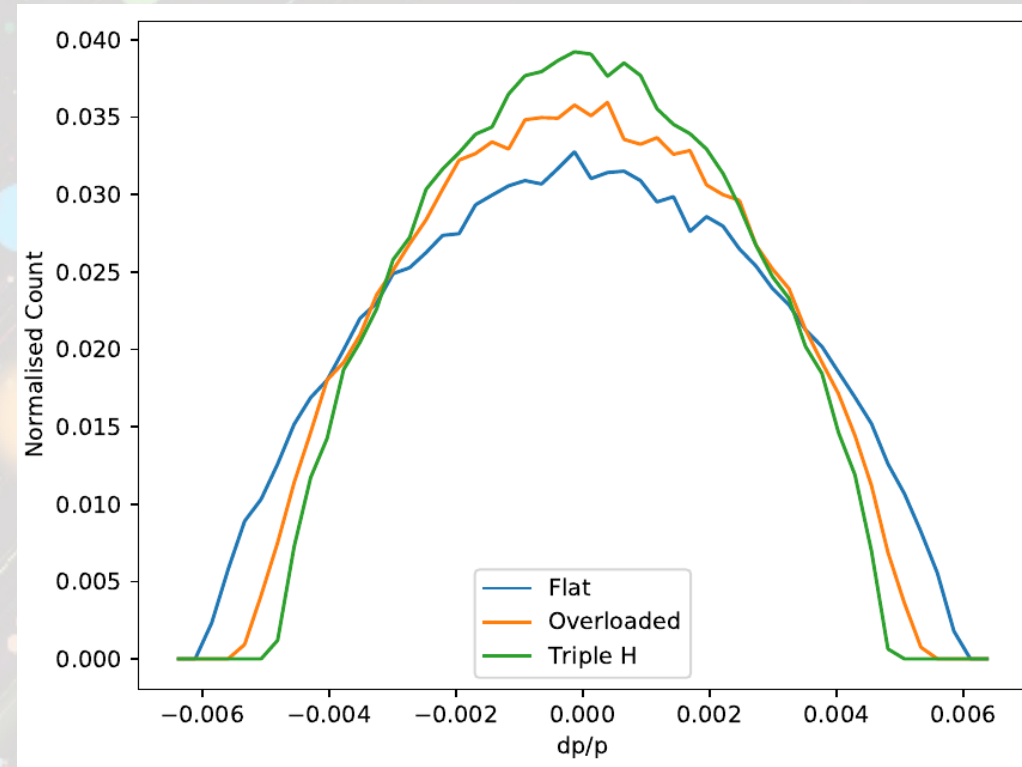
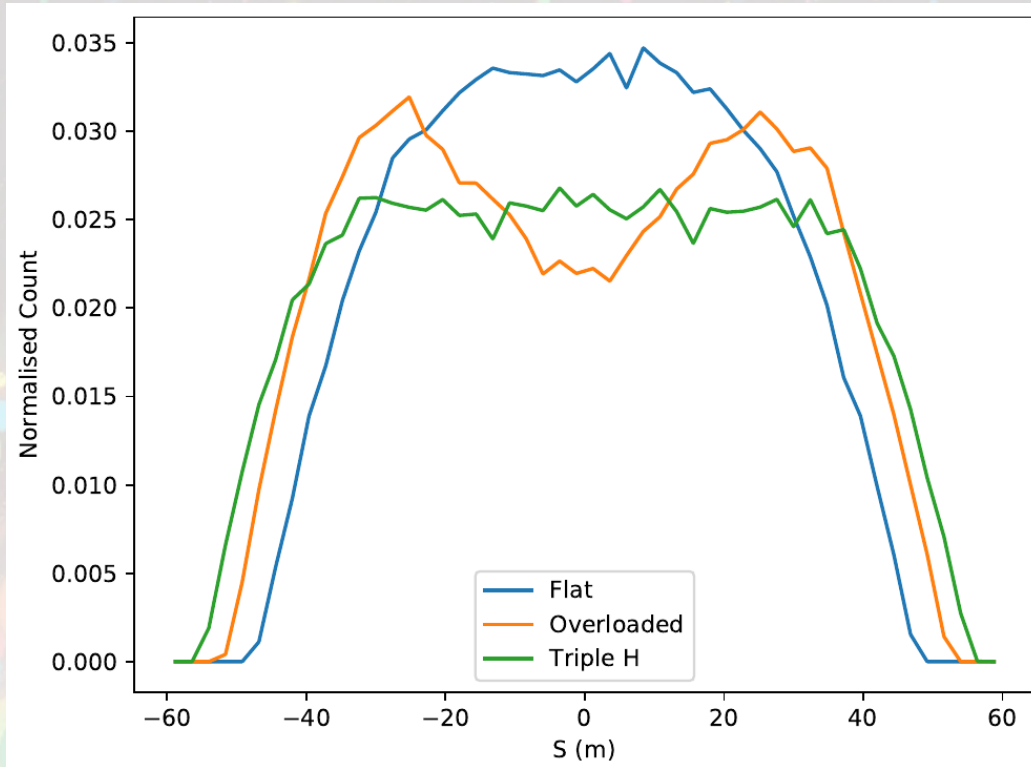
LEIR

- Addition of third harmonic ($h=6$) has been provided
- Adiabatic capture into $h=2+h=4+h=6$ bucket demonstrated effectively
- Intensity problems prevented further investigations of intensity mitigation, but studies planned for near future

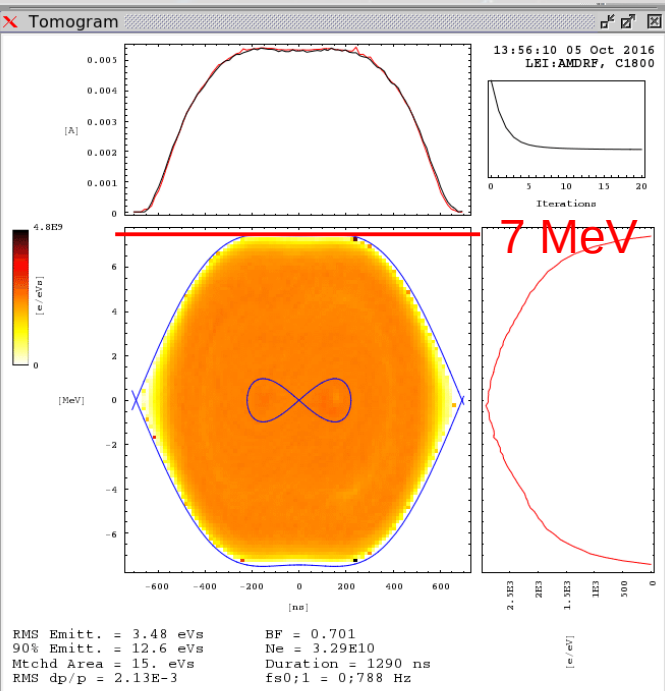
Conclusion

- Two regimes of interest, intensity limited and brightness limited
- Traditional longitudinal emittance blow-up ineffective – damage done too quickly
- RF frequency modulation during capture in LEIR provided maximum longitudinal emittance increasing extracted intensity
- Addition of third harmonic during capture in the PSB shows 10% increase in brightness for LHC filling cycle

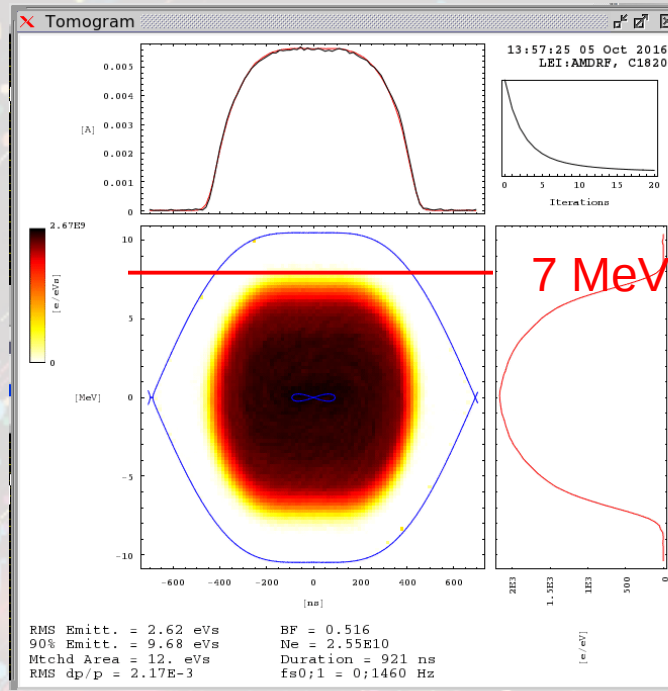
Appendix



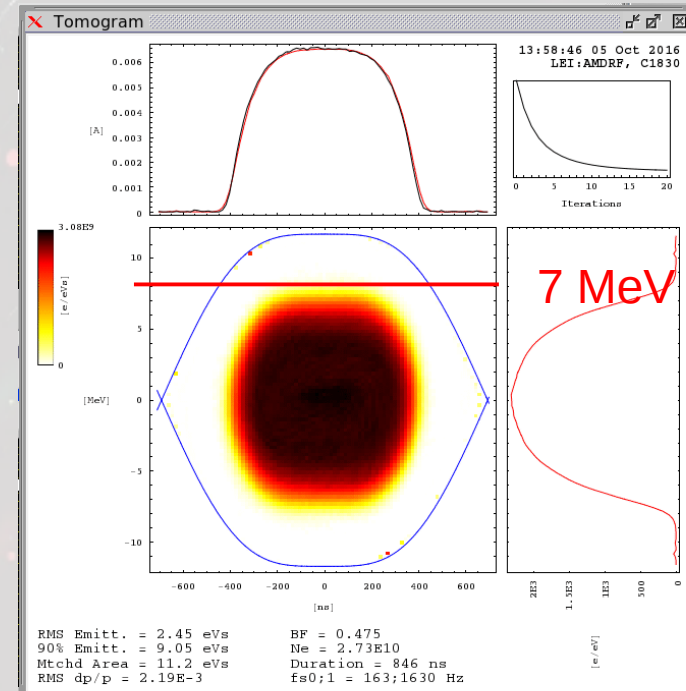
Appendix



C1800
15 eVs
dp/p: 2.13E-4

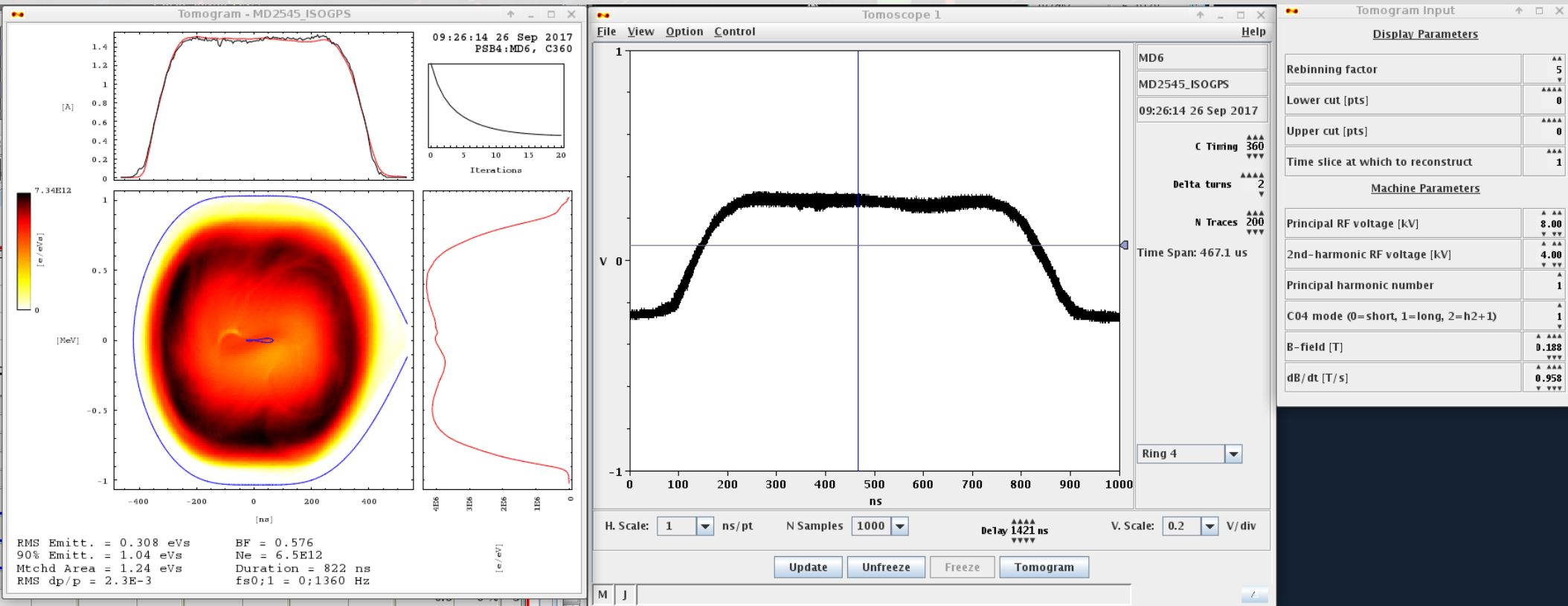


C1820
12 eVs
dp/p: 2.17E-4



C1830
11 eVs
dp/p: 2.19E-4

Appendix



Triple harmonic RF, tell Tomography $V_1 = 2V_2$, artificial hollow bunch